BSIM 3v3 MANUAL (Final Version)

by

Yuhua Cheng, Mansun Chan, Kelvin Hui, Min-chie Jeng, Zhihong Liu, Jianhui Huang, Kai Chen, James Chen, Robert Tu, Ping K. Ko, and Chenming Hu

Memorandum No. UCB/ERL M97/2

13 January 1997
Developers:

BSIM3v3 is developed by the following researchers of the University of California, Berkeley (listed in alphabetical order):

- Dr. Mansun Chan, UC Berkeley
- Mr. James C. Chen, UC Berkeley
- Mr. Kai Chen, UC Berkeley
- Dr. Yuhua Cheng, UC Berkeley
- Dr. Jian Hui Huang, Intel Corp.
- Dr. Kelvin Hui, Lattice Semiconductor
- Dr. Min Chie Jeng, Cadence Design Systems
- Dr. Zhi Hong Liu, BTA Technology Inc.
- Dr. Robert Tu, UC Berkeley

The BSIM3 project is spearheaded and directed by:

- Prof. Ping K. Ko (formerly with UC Berkeley, now with The University of Science and Technology, Hong Kong)
- Prof. Chenming Hu (UC Berkeley).

Help:

email: bsim3@bsim.eecs.berkeley.edu

How to get a copy of this manual and SPICE source code (model part only):

anonymous ftp site: rely.eecs.berkeley.edu or 128.32.156.10
CHAPTER 1: Introduction

General Information .................................................. 1-1
Organization of Manual ............................................. 1-3

CHAPTER 2: Physics-Based Derivation of the I-V Model

Non-Uniform Doping and Small Channel Effects on Threshold Voltage .... 2-1
Vertical Non-Uniform Doping Effect ................................ 2-3
Lateral Non-Uniform Doping Effect: ................................ 2-5
Short Channel Effect .................................................. 2-7
Narrow Channel Effect ................................................. 2-12
Mobility Model .......................................................... 2-14
Carrier Drift Velocity .................................................. 2-17
Bulk Charge Effect ..................................................... 2-17
Strong Inversion Drain Current (Linear Regime) ..................... 2-19
Intrinsic Case (Rds=0) ............................................... 2-19
Extrinsic Case (Rds>0) ................................................. 2-21
Strong Inversion Current and Output Resistance (Saturation Regime) .......... 2-22
Channel Length Modulation (CLM) .................................. 2-25
Drain-Induced Barrier Lowering (DIBL) ................................ 2-26
Current Expression without Substrate Current Induced Body Effect .......... 2-27
Current Expression with Substrate Current Induced Body Effect .......... 2-28
Subthreshold Drain Current .......................................... 2-30
Effective Channel Length and Width ................................ 2-31
Poly Gate Depletion Effect ......................................... 2-32

CHAPTER 3: Unified I-V Model

Unified Channel Charge Density Expression ....................... 3-1
Unified Mobility Expression ........................................ 3-6
Unified Linear Current Expression ................................ 3-7
Intrinsic case (Rds=0) ............................................... 3-7
Extrinsic Case (Rds>0) ................................................. 3-9
Unified Vdsat Expression ............................................. 3-9
Intrinsic case (Rds=0) ............................................... 3-9
Extrinsic Case (Rds>0) ................................................. 3-10
Unified Saturation Current Expression ................................ 3-11
Single Current Expression for All Operational Regimes of Vgs and Vds .... 3-12
Substrate Current ...................................................... 3-15
A Note on Vbs ........................................................... 3-15

BSIM3v3 Manual Copyright © 1995, 1996, UC Berkeley
CHAPTER 4: Capacitance Model

General Information .......................................................... 4-1
A Note on Device Geometry Dependencies ...................... 4-3
Intrinsic Capacitance .......................................................... 4-5
  Background Information .................................................. 4-5
  Basic Formulation .......................................................... 4-6
  Short Channel Model ..................................................... 4-9
  New Single Equation Formulation ................................. 4-11
Extrinsic Capacitance: Fringing Capacitance .................. 4-17
Extrinsic Capacitance: Overlap Capacitance ..................... 4-17
Graphical Results ............................................................ 4-20

CHAPTER 5: Non-Quasi Static Model

Background Information ...................................................... 5-1
The NQS Model in BSIM3v3 .............................................. 5-1
Model Formulation .............................................................. 5-2

CHAPTER 6: Parameter Extraction

Optimization strategy ......................................................... 6-1
Extraction Strategies ......................................................... 6-2
Extraction Procedure ........................................................ 6-2
  Parameter Extraction Requirements ............................. 6-2
  Optimization ............................................................... 6-4
  Extraction Routine ........................................................ 6-6
Notes on Parameter Extraction ........................................ 6-14
  Parameters with Special Notes ..................................... 6-14
  Explanation of Notes .................................................... 6-15

CHAPTER 7: Benchmark Test Results

Benchmark Test Types .......................................................... 7-1
Benchmark Test Results (Figures) ....................................... 7-2

CHAPTER 8: Noise Model

Flicker Noise ................................................................. 8-1
Parameters ................................................................. 8-1
Expressions ............................................................... 8-1
Channel Thermal Noise ..................................................... 8-3
CHAPTER 9: MOS Diode Model

MOS Diode DC Current Model ........................................ 9-1
Model Equations ......................................................... 9-1
Parameters ............................................................... 9-4
MOS Diode Capacitance Model ...................................... 9-4
Model Equations ......................................................... 9-4
Parameters ............................................................... 9-7

APPENDIX A: Parameter List

BSIM3v3 Model Control Parameters ................................ A-1
DC Parameters ......................................................... A-1
AC and Capacitance Parameters .................................. A-6
NQS Parameters ....................................................... A-7
dW and dL Parameters ............................................... A-8
Temperature Parameters ........................................ A-9
Flicker Noise Model Parameters ................................ A-10
Process Parameters ................................................ A-10
Bin Description Parameters ...................................... A-11
Model Parameter Notes ........................................... A-12

APPENDIX B: Equation List

I-V Model ................................................................. B-1
Threshold Voltage ................................................... B-1
Effective Vgs-Vth .................................................... B-2
Mobility ................................................................. B-3
Drain Saturation Voltage ......................................... B-3
Effective Vds .......................................................... B-5
Drain Current Expression ......................................... B-5
Substrate Current .................................................... B-6
Polysilicon Depletion Effect ................................... B-6
Effective Channel Length and Width ......................... B-7
Drain/Source Resistance ........................................ B-8
Temperature Effects ............................................... B-8
Capacitance Model Equations ................................... B-9
APPENDIX C: References

APPENDIX D: Binning BSIM3v3 Parameters

BSIM3v3 Model Control Parameters ........................................ D-1
DC Parameters ..................................... D-2
AC and Capacitance Parameters ...................................... D-6
NQS Parameters ........................................ D-7
dW and dL Parameters .................................. D-8
Temperature Parameters ........................................ D-9
Flicker Noise Model Parameters ................................ D-10
Process Parameters ........................................ D-10
Bin Description Parameters ................................. D-11
CHAPTER 1: Introduction

1.1 General Information

BSIM3v3 is the latest physics-based, deep-submicron MOSFET model for digital and analog circuit designs from the Device Group at the University of California at Berkeley. BSIM3v3 has been extensively modified from its previous release (BSIM3 Version 2.0). Amongst the new advancements are:

- A single I-V expression to describe current and output conductance characteristics from subthreshold to strong inversion as well as from the linear to the saturation operating regions. Such a formulation guarantees the continuities of $I_{ds}$, $G_{ds}$, $G_{m}$ and their derivatives throughout all $V_{gs}$, $V_{ds}$ and $V_{bs}$ bias conditions. In addition, all previous kinks and glitches at device operation boundaries are eliminated.

- New width dependencies for bulk charge and source/drain resistance ($R_{ds}$). This greatly enhances the accuracy in modeling narrow width devices.

- $\Delta W$ and $\Delta L$ dependencies for different $W_{drawn}$ and $L_{drawn}$ devices. This improves the model's ability to fit a variety of $W/L$ ratios with a single set of parameters.

- A new capacitance model has been formulated to address the concern and to improve the modeling of short and narrow geometry devices.

- Lastly, BSIM3v3 includes a new relaxation time model for characterizing the non-quasi-static effect of MOS circuits for improved transient modeling.
General Information

In the mist of all these new features, BSIM3v3 still retains the same physical underpinnings of BSIM3 Version 2.0. For example, his new model still has the extensive built-in dependencies of important dimensional and processing parameters (e.g. channel length, width, gate oxide thickness, junction depth, substrate doping concentration, etc.). This allows users to accurately model the MOSFET over a wide range of channel lengths as well as channel widths for present as well as future technologies. Furthermore, BSIM3v3 still relies on a coherent pseudo-2D formulation to model various short-channel and high field effects such as the following:

- threshold voltage roll-off,
- non-uniform doping effect,
- mobility reduction due to vertical field,
- carrier velocity saturation,
- channel-length modulation,
- drain induced barrier lowering,
- substrate current-induced body effect,
- subthreshold conduction, and
- parasitic resistance effect.

Meticulous care has been taken to mesh the above model enhancements with high levels of accuracy and minimum simulation costs. In addition, the enhanced expressions yield more continuous behavior and should also help to facilitate faster SPICE convergence properties.
1.2 Organization of Manual

The manual will introduce BSIM3v3's capabilities in the following manner:

- Chapter 2 will highlight the physical basis and arguments used in deriving BSIM3v3's I-V equations.
- Chapter 3 will combine these various BSIM3v3 equations for different operational regimes in a unified I-V model.
- Chapter 4 will present the new capacitance model.
- Chapter 5 will detail the inclusion of the new model for transient modeling called the NQS (Non-Quasi-Static) Model.
- Chapter 6 will discuss SPICE model file extraction.
- Chapter 7 will provide results of some benchmark tests applied on the model to illustrate its general robustness (no discontinuities).
- Chapter 8 will conclude with the noise model.
- Chapter 9 will describe the MOS diode model.
- Finally, the Appendix will list all model equations and references used throughout this manual. In addition, model parameters which can be binned during parameter extraction will also be listed.
BSIM3v3’s development is based upon finding solutions to Poisson's equation using Gradual Channel Approximation (GCA) and Quasi-Two Dimensional Approximation (QTDA) approaches. It includes compact, analytical expressions for the following physical phenomenon observed in present day MOS devices [1]:

- Short and narrow channel effects on threshold voltage.
- Non-uniform doping effect (in both lateral and vertical directions).
- Mobility reduction due to vertical field.
- Bulk charge effect.
- Carrier velocity saturation.
- Drain-induced barrier lowering (DIBL).
- Channel length modulation (CLM).
- Substrate current induced body effect (SCBE).
- Subthreshold conduction.
- Source/drain parasitic resistances.

2.1 Non-Uniform Doping and Small Channel Effects on Threshold Voltage

Accurate modeling of threshold voltage (Vth) is one of the most important requirements for the precise description of a device's electrical characteristics. In addition, it serves as a useful reference point for the evaluation of device operation
regimes. By using threshold voltage, the whole device operation regime can be divided into three operational regions.

First, if the gate voltage is greater than the threshold voltage, the inversion charge density is larger than the substrate doping concentration. The MOSFET is then operating in the strong inversion region and drift current is dominant. Second, if the gate voltage is much less than the threshold voltage, the inversion charge density is smaller than the substrate doping concentration. The MOSFET is now considered to be operating in the weak inversion (or subthreshold) region. Diffusion current is now dominant [2]. Lastly, if the gate voltage is very close to the threshold voltage, the inversion charge density is close to the doping concentration and the MOSFET is operating in the transition region. In such a case, both diffusion and drift currents are equally important.

The standard threshold voltage of a MOSFET with long channel length/width and uniform substrate doping concentration [2] is given by:

\[ V_{th} = V_{FB} + \phi_s + \gamma \sqrt{\phi_s - V_{bs}} = V_{Tideal} + \gamma (\sqrt{\phi_s - V_{bs}} - \sqrt{\phi_s}) \]  

where \( V_{FB} \) is the flat band voltage, \( V_{Tideal} \) is the ideal threshold voltage of the long channel device at zero volt substrate bias, and \( \gamma \) is the substrate bias effect coefficient and is given by:

\[ \gamma = \frac{\sqrt{2\varepsilon_{st}qN_a}}{C_{ox}} \]  

where \( N_a \) is the substrate doping concentration. The surface potential is given by:
Equation (2.1.1) assumes that the channel is uniform and makes use of the one dimensional Poisson equation in the vertical direction of the channel. This model is valid only when the substrate doping concentration is constant and the channel length is long. Under these conditions, the potential is uniform along the channel. But in reality, these two conditions are not always satisfied. Modifications have to be made when the substrate doping concentration is not uniform or and when the channel length is short, narrow, or both.

2.1.1 Vertical Non-Uniform Doping Effect

The substrate doping level is not constant in the vertical direction as shown in Figure 2-1.

Figure 2-1. Actual substrate doping distribution and its approximation.
The substrate doping concentration is usually higher near the silicon to silicon dioxide interface (due to the threshold voltage adjust implant) than deep into substrate. The distribution of impurity atoms inside the substrate is approximately a half gaussian distribution, as shown in Figure 2-1. This non-uniformity will make $\gamma$ in Eq. (2.1.2) a function of the substrate bias. If the depletion width is less than $X_t$ as shown in Figure 2-1, $N_a$ in Eq. (2.1.2) is equal to $N_{ch}$, otherwise it is equal to $N_{sub}$.

In order to take into account such non-uniform substrate doping, the following threshold voltage model is proposed:

$$V_{th} = V_{T_{ideal}} + K_1(\sqrt{\phi_s - V_{bs}} - \sqrt{\phi_s}) - K_2 V_{bs}$$  \hspace{1cm} (2.1.4)

For a zero substrate bias, Eqs. (2.1.1) and (2.1.4) give the same result. $K_1$ and $K_2$ can be determined by the criteria that $V_{th}$ and its derivative versus $V_{bs}$ should be the same at $V_{bm}$, where $V_{bm}$ is the maximum substrate bias voltage. Therefore, using equations (2.1.1) and (2.1.4), $K_1$ and $K_2$ [3] will be given by the following:

$$K_1 = \gamma_2 - 2K_2 \sqrt{\phi_s - V_{bm}}$$  \hspace{1cm} (2.1.5)

$$K_2 = (\gamma_1 - \gamma_2) \frac{\sqrt{\phi_s - V_{bs}} - \sqrt{\phi_s}}{2\sqrt{\phi_s} (\sqrt{\phi_s - V_{bm}} - \sqrt{\phi_s}) + V_{bm}}$$  \hspace{1cm} (2.1.6)

where $\gamma_1$ (or $\gamma_2$) is the body effect coefficient when the substrate doping concentration is $N_{ch}$ (or $N_{sub}$) as shown in Figure 2-1.
Non-Uniform Doping and Small Channel Effects on Threshold Voltage

\[ \gamma_1 = \sqrt{\frac{2e_{si}N_{ch}}{C_{ox}}} \]  

(2.1.7)

\[ \gamma_2 = \sqrt{\frac{2e_{si}N_{sub}}{C_{ox}}} \]  

(2.1.8)

\[ V_{bx} \] is the body bias when the depletion width is equal to \( X_i \). Therefore, \( V_{bx} \) satisfies:

\[ \frac{qN_{ch}X_i^2}{2e_{si}} = \phi_s - V_{bx} \]  

(2.1.9)

If the devices are available, \( K_1 \) and \( K_2 \) can be determined experimentally. If the devices are not available but the user knows the doping concentration distribution, the user can input the appropriate parameters to specify doping concentration distribution (e.g. \( N_{ch}, N_{sub}, X_i \)). Then, \( K_1 \) and \( K_2 \) can be calculated using equations (2.1.5) and (2.1.6).

### 2.1.2 Lateral Non-Uniform Doping Effect:

For some technologies, the doping concentration near the drain and the source is higher than that in the middle of the channel. This is referred to as lateral non-uniform doping and is shown in Figure 2-2. As the channel length becomes shorter, lateral non-uniform doping will cause the threshold voltage to increase in magnitude because the average doping concentration in the channel is larger. The average channel doping can be calculated as follows:
Due to this lateral non-uniform doping effect, Eq. (2.1.4) becomes:

\[
V_{th} = V_{th0} + K_1 \left( \sqrt{\Phi_x - V_{bs}} - \sqrt{\Phi_x} \right) - K_2 V_{bs} + K_1 \left( \frac{N_{Lx}}{L_{eff}} - 1 \right) \sqrt{\Phi_x}
\]

Eq. (2.1.11) can be derived by setting \( V_{bs} = 0 \), and using \( K_1 \propto (N_{eff})^{0.5} \). The fourth term in Eq. (2.1.11) is used empirically to model the body bias dependence of the lateral non-uniform doping effect. This effect gets stronger at a lower body bias. Examination of Eq. (2.1.11) shows that the threshold voltage will increase as channel length decreases [3].
2.1.3 Short Channel Effect

The threshold voltage of a long channel device is independent of the channel length and the drain voltage. Its dependence on the body bias is given by Eq. (2.1.4). However, as the channel length becomes shorter and shorter, the threshold voltage shows a greater dependence on the channel length and the drain voltage. The dependence of the threshold voltage on the body bias becomes weaker as channel length becomes shorter, because the body bias has less control of the depletion region. Short-channel effects must be included in the threshold voltage in order to model deep-submicron devices correctly.

The short channel effect can be modeled in the threshold voltage by the following:

\[
V_{th} = V_{th0} + K_1 \left( \Phi_L - V_{bs} \right) - K_2 V_{bs} + K_3 \left( \sqrt{1 + \frac{N_{Lx}}{L_{eff}}} - 1 \right) \Phi_L - \Delta V_{th}
\]

where $\Delta V_{th}$ is the threshold voltage reduction due to the short channel effect. Many models have been developed to calculate $\Delta V_{th}$. They used either numerical solutions [4], a two-dimensional charge sharing approach [5,6], or a simplified Poisson's equation in the depletion region [7-9]. A simple, accurate, and physical model was developed by Z.H. Liu, et al, [10]. Their model was derived by solving the quasi two-dimension Poisson equation along the channel. This quasi-2D model concluded that:

\[
\Delta V_{th} = \theta_{th} (L) \left[ 2(V_{bi} - \phi_s) + V_{ds} \right]
\]
where \( V_{bi} \) is the built-in voltage of a PN junction between the substrate and the source. \( V_{bi} \) is given by:

\[
V_{bi} = \frac{k_B T}{q} \ln \left( \frac{N_{ch} N_d}{n_i^2} \right)
\]

where \( N_d \) in Eq. (2.1.14) is the source doping concentration, and \( N_{ch} \) is the substrate doping concentration. The expression \( \theta_{th}(L) \) is a short channel effect coefficient that has a strong dependence on the channel length and is given by:

\[
\theta_{th}(L) = \left[ \exp(-L/2l_t) + 2\exp(-L/l_t) \right]
\]

\( l_t \) is referred to as the "characteristic length" and is given by:

\[
l_t = \sqrt{\frac{\varepsilon_{si} T_{ox} X_{dep}}{\varepsilon_{ox} \eta}}
\]

\( X_{dep} \) is the depletion width in the substrate and is given by:

\[
X_{dep} = \sqrt{\frac{2\varepsilon_{si} (\phi_s - V_{bs})}{qN_{ch}}}
\]

\( X_{dep} \) is larger near the drain than in the middle of the channel due to the drain voltage. \( X_{dep} / \eta \) represents the average depletion width along the channel.

Based on above discussion, the influences of drain/source charge sharing and DIBL effects to \( V_{th} \) are described by (2.1.15). However, in order to
Non-Uniform Doping and Small Channel Effects on Threshold Voltage

make the model fit a wide technology range, several parameters such as $D_{vt1}, D_{vt2}, D_{sub}, Eta0$ and $Etab$ are introduced, and the following modes are used in SPICE to account for charge sharing and the DIBL effects separately.

\[ \theta_{vt} (L) = D_{vt0} \left[ \exp \left( -D_{vt1} L / l_i \right) + 2 \exp \left( -D_{vt1} L / l_i \right) \right] \]

\[ \Delta V_{th(L)} = \theta_{vt(L)} (V_{bi} - \phi_s) \]

\[ l_i = \sqrt{\frac{e_r T_{ox} X_{dep}}{e_{ox}} (1 + D_{vt2} V_{bs})} \]

\[ \theta_{dibl(L)} = \left[ \exp \left( -D_{sub} L / 2l_{i0} \right) + 2 \exp \left( -D_{sub} L / l_{i0} \right) \right] \]

\[ \Delta V_{th(V_{ds})} = \theta_{dibl(L)} (E_{ta0} + E_{tab} V_{bs}) V_{ds} \]

where $l_{i0}$ is calculated by Eq. (2.1.20) at zero body-bias. $D_{vt1}$ is basically equal to $1/\eta^{1/2}$ in Eq. (2.1.16). $D_{vt2}$ is introduced to take care of the dependence of the doping concentration on substrate bias since the doping concentration is not uniform in the vertical direction of the channel. $X_{dep}$ is calculated using the doping concentration in the channel ($N_{ch}$). $D_{vt0}, D_{vt1}, D_{vt2}, Eta0, Etab$ and $D_{sub}$, which are determined experimentally, can improve accuracy greatly. Even though Eqs. (2.1.18), (2.1.21) and (2.1.15) have different coefficients, they all still have the same functional forms. This the device physics represented by Eqs. (2.1.18), (2.1.21) and (2.1.15) are still the same.
As channel length $L$ decreases, $\Delta V_{th}$ will increase, and in turn $V_{th}$ will decrease. If a MOSFET has a LDD structure, $N_d$ in Eq. (2.1.14) is the doping concentration in the lightly doped region. $V_{bi}$ in a LDD-MOSFET will be smaller as compared to conventional MOSFETs, therefore the threshold voltage reduction due to the short channel effect will be smaller in LDD-MOSFETs.

As the body bias becomes more negative, the depletion width will increase as shown in Eq. (2.1.17). Hence $\Delta V_{th}$ will increase due to the increase in $l_r$. The term:

$$V_{Tidel} + K_1\sqrt{\phi_S - V_{bs}} - K_2 V_{bs}$$

will also increase as $V_{bs}$ becomes more negative (for NMOS). Therefore, the changes in:

$$V_{Tidel} + K_1\sqrt{\phi_S - V_{bs}} - K_2 V_{bs}$$

and in $\Delta V_{th}$ will compensate for each other and make $V_{th}$ less sensitive to $V_{bs}$. This compensation is more significant as the channel length is shortened. Hence, the $V_{th}$ of short channel MOSFET is less sensitive to body bias as compared to a long channel MOSFET. For the same reason, the DIBL effect and the channel length dependence of $V_{th}$ are stronger as $V_{bs}$ is made more negative. This was verified by experimental data shown in Figure 2-3 and Figure 2-4. Although Liu, et al, found a accelerated $V_{th}$ roll-off and non-linear drain voltage dependence [10] as the channel became very short, a linear dependence of $V_{th}$ on $V_{ds}$ is nevertheless a good approximation for circuit simulation as shown in Figure 2-4. This figure shows that Eq. (2.1.13) can fit the experimental data very well.
Furthermore, Figure 2-5 shows how this model for $V_{th}$ can fit various channel lengths under various bias conditions.

**Figure 2-3.** Threshold voltage versus the drain voltage at different body biases.

**Figure 2-4.** Channel length dependence of threshold voltage.
2.1.4 Narrow Channel Effect

The actual depletion region in the channel is always larger than what is usually assumed under the one-dimensional analysis due to the existence of fringing fields [2]. This effect becomes very substantial as the channel width decreases and the depletion region underneath the fringing field becomes comparable to the "classical" depletion layer formed from the vertical field. The net result is an increase threshold voltage magnitude. It is shown in [2] that this increase can be modeled as:

\[
\frac{\pi q N_a (X_{d,\text{max}})^2}{2 C_{ox} W} = 3 \pi \frac{T_{ox}}{W} \phi_s
\]
Non-Uniform Doping and Small Channel Effects on Threshold Voltage

The right hand side of Eq. (2.1.23) represents the additional voltage increase. BSIM3v3 models this change in threshold voltage by Eq. (2.1.24a). This formulation includes but is not limited to the inverse of channel width due to the fact that the overall narrow width effect is dependent on process (i.e. isolation technology) as well. Hence, the introduction of parameters $K_3$, $K_{3b}$, and $W_0$.

\[
(K_3 + K_{3b} V_{bi}) \frac{T_{ox}}{(W_{eff} + W_0) \Phi_s}
\]

(2.1.24a)

$W_{eff}$' is the effective channel width (with no bias dependencies), which will be defined Section 2.9. In addition, we must also consider the narrow width effect for small channel lengths. To do this we introduce the following:

\[
D_{VTOw} \left( \exp(-D_{VTlw} \frac{W_{eff} L_{eff}}{2l_{lw}}) + 2 \exp(-D_{VTlw} \frac{W_{eff} L_{eff}}{l_{lw}}) \right) (V_{bi} - \Phi_s)
\]

(2.1.24b)

When all of the above considerations for non-uniform doping, short and narrow channel effects on threshold voltage are considered, the final, complete $V_{th}$ expression implemented in SPICE is as follows:

\[
V_{th} = V_{th_0} + K_1 (\sqrt{\Phi_s - V_{bseff}} - \sqrt{\Phi_s}) - K_2 V_{bseff}
\]

\[
+ K_1 \left( \sqrt{1 + \frac{N_{LX}}{L_{eff}} - 1} \sqrt{\Phi_s} + (K_3 + K_{3b} V_{bseff}) \frac{T_{ox}}{W_{eff} + W_0} \Phi_s
\]

\[
- D_{VTOw} \left( \exp(-D_{VTlw} \frac{W_{eff} L_{eff}}{2l_{lw}}) + 2 \exp(-D_{VTlw} \frac{W_{eff} L_{eff}}{l_{lw}}) \right) (V_{bi} - \Phi_s)
\]

\[
- D_{VTO} \left( \exp(-D_{VTl} \frac{L_{eff}}{2l_t}) + 2 \exp(-D_{VTl} \frac{L_{eff}}{l_t}) \right) (V_{bi} - \Phi_s)
\]

(2.1.25)
(2.1.25) (cont.)

\[-\left(\exp\left(-\frac{D_{mb} L_{eff}}{2 I_{to}}\right) + 2 \exp\left(-\frac{D_{mb} L_{eff}}{I_{to}}\right)\right)\left(E_{sab} + E_{sub} V_{bs\text{eff}}\right) V_{ds}\]

In Eq. (2.1.25), all \(V_{bs}\) terms have been substituted with a \(V_{bs\text{eff}}\) expression as shown in Eq. (2.1.26). This is done in order to set an upper bound for the body bias value during simulations. Unreasonable values can occur if this expression is not introduced. See Section 3.8 for details.

\(V_{bs\text{eff}} = V_{bc} + 0.5\left[V_{bs} - V_{bc} - \delta_1 + \sqrt{(V_{bs} - V_{bc} - \delta_1)^2 - 4\delta_1 V_{bc}}\right]\)

where \(\delta_1 = 0.001\). The parameter \(V_{bc}\) is the maximum allowable \(V_{bs}\) value and is calculated from the condition of \(\frac{dV_{\text{th}}}{dV_{bs}} = 0\) for the \(V_{\text{th}}\) expression of 2.1.4, 2.1.5, and 2.1.6 is equal to:

\[V_{bc} = 0.9(\phi_s - \frac{K_1^2}{4K_2^2})\]

2.2 Mobility Model

A good model for surface carrier mobility is very critical to the accuracy of a MOSFET model. The scattering mechanisms responsible for surface mobility basically include phonons, coulombic scattering sites, and surface roughness [11, 12]. For good quality interfaces, phonon scattering is generally the dominant scattering mechanism at room temperature. In general, mobility depends on many process parameters and bias conditions. For example, mobility depends on gate oxide thickness, doping concentration, threshold voltage, gate voltage and...
substrate voltage, etc. Sabnis and Clemens [13] proposed an empirical unified formulation based on the concept of an effective field $E_{\text{eff}}$ which lumps many process parameters and bias conditions together. $E_{\text{eff}}$ is defined by

\begin{equation}
E_{\text{eff}} = \frac{Q_B + (Q_n/2)}{\varepsilon_{si}}
\end{equation}

The physical meaning of $E_{\text{eff}}$ can be interpreted as the average electrical field experienced by the carriers in the inversion layer [14]. The unified formulation of mobility is then empirically given by:

\begin{equation}
\mu_{\text{eff}} = \frac{\mu_0}{1 + (E_{\text{eff}}/E_0)^v}
\end{equation}

Values for $\mu_0$, $E_0$, and $v$ were reported by Liang et al. [15] and Toh et al. [16] to be the following for electrons and holes:

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Electron (surface)</th>
<th>Hole (surface)</th>
</tr>
</thead>
<tbody>
<tr>
<td>$\mu_0$ (cm$^2$/V)</td>
<td>670</td>
<td>160</td>
</tr>
<tr>
<td>$E_0$ (MV/cm)</td>
<td>0.67</td>
<td>0.7</td>
</tr>
<tr>
<td>$v$</td>
<td>1.6</td>
<td>1.0</td>
</tr>
</tbody>
</table>

Table 2-1. Mobility and related parameters for electrons and holes.

For a NMOS transistor with n-type poly-silicon gate, Eq. (2.2.1) can be rewritten in a more useful form that explicitly relates $E_{\text{eff}}$ to the device parameters [14]:
Mobility Model

\[ E_{\text{eff}} \equiv \frac{V_{gs} + V_{th}}{6T_{ox}} \]  

Eq. (2.2.2) fits experimental data very well [15], but it involves a power function which is a very time consuming function for circuit simulators such as SPICE. A Taylor expansion Eq. (2.2.2) is used, and the coefficients are left to be determined using experimental data or to be obtained by fitting the unified formulation. Thus, we have:

\[ \text{(Mobmod}= 1) \quad \mu_{\text{eff}} = \frac{\mu_0}{1 + (U_a + U_c V_{bs}) \left( \frac{V_{gs} + 2V_{th}}{T_{ox}} \right) + U_b \left( \frac{V_{gs} + 2V_{th}}{T_{ox}} \right)^2} \]  

where \( V_{gst}=V_{gs}-V_{th} \). To account for depletion mode devices, another mobility model option is given by the following:

\[ \text{(Mobmod}= 2) \quad \mu_{\text{eff}} = \frac{\mu_0}{1 + (U_a + U_c V_{bs}) \left( \frac{V_{gst}}{T_{ox}} \right) + U_b \left( \frac{V_{gst}}{T_{ox}} \right)^2} \]  

The unified mobility expressions in subthreshold and strong inversion regions will be discussed in Section 3.2.

To consider the body bias dependence of Eq. 2.2.4 further, we have introduced the following expression:
2.3 Carrier Drift Velocity

Carrier drift velocity is one of the most important parameters that affects device performance characteristics. BSIM3v3 uses a simple and semi-empirical saturation velocity model [17] given by:

\[ v = \frac{\mu_{\text{eff}} E}{1 + (E/E_{\text{sat}})} \]

\[ = v_{\text{sat}}, \quad E > E_{\text{sat}} \]  \hspace{1cm} \text{(2.3.1)}

The parameter \( E_{\text{sat}} \) corresponds to the critical electrical field at which the carrier velocity becomes saturated. In order to have a continuous velocity model at \( E = E_{\text{sat}} \), \( E_{\text{sat}} \) must satisfy:

\[ E_{\text{sat}} = \frac{2v_{\text{sat}}}{\mu_{\text{eff}}} \]  \hspace{1cm} \text{(2.3.2)}

2.4 Bulk Charge Effect

When the drain voltage is large and/or when the channel length is long, the depletion "thickness" of the channel is not uniform along the channel length. This
Strong Inversion Drain Current (Linear Regime)

will cause threshold voltage to vary along the channel. This effect is called bulk charge effect [14].

In BSIM3v3, the parameter $A_{bulk}$ is used to take into account this bulk charge effect. This parameter is a modification from that of BSIM1 and BSIM2 where the bulk charge parameter was "$a$" [3]. Several extracted parameters such as $A_0$, $B_0$, $B_1$ are introduced to account for the channel length and width dependences of the bulk charge effect. In addition, the parameter Keta is introduced to model the change in bulk charge effect under high back or substrate bias conditions. It should be pointed out that narrow width effects have been considered in the formulation of Eq. (2.4.1). The $A_{bulk}$ expression used in BSIM3v3 is given by:

\[
A_{bulk} = (1 + \frac{K_1}{2\sqrt{\Phi_s - V_{smd}}} \cdot \frac{A_0 L_{eff}}{L_{eff} + 2\sqrt{X_I X_{dep}}} \left[1 - A_{g} V_{smd} \left(\frac{\frac{L_{eff}}{W_{eff}} + 2\sqrt{X_I X_{dep}}}{}\right)^2 + \frac{B_0}{W_{eff}^2 + B_1}\right]) \frac{1}{1 + Keta V_{smd}}
\]

where $A_0$, $A_{g}$, $K_1$, $B_0$, $B_1$ and Keta are determined by experimental data. Eq. (2.4.1) shows that $A_{bulk}$ is very close to 1.0 if the channel length is small, and $A_{bulk}$ increases as channel length increases.

2.5 Strong Inversion Drain Current (Linear Regime)

2.5.1 Intrinsic Case (Rds=0)

In the strong inversion region, the general current equation at any point $y$ along the channel is given by:
Strong Inversion Drain Current (Linear Regime)

\[ I_{ds} = WC_{ox}(V_{gs} - A_{bulk}V(y))V(y) \]  

(2.5.1)

The parameter \( V_{gst} = (V_{gs} - V_{th}) \), \( W \) is the device channel width, \( C_{ox} \) is the gate capacitance per unit area, \( V(y) \) is the potential difference between minority-carrier quasi-Fermi potential and the equilibrium Fermi potential in the bulk at point \( y \), \( v(y) \) is the velocity of carriers at point \( y \), and \( A_{bulk} \) is the coefficient accounting for the bulk charge effect.

With Eq. (2.3.1) (i.e. before carrier velocity saturates), the drain current can be expressed as:

\[ I_{ds} = WC_{ox}(V_{gs} - V_{th} - A_{bulk}V(y)) \frac{\mu_{eff} E(y)}{1 + E(y)/E_{sat}} \]  

(2.5.2)

Eq. (2.5.2) can be rewritten as follows:

\[ E(y) = \frac{I_{ds}}{\mu_{eff} WC_{ox}(V_{gst} - A_{bulk}V(y)) - I_{ds}/E_{sat}} = \frac{dV(y)}{dy} \]  

(2.5.3)

By integrating Eq. (2.5.3) from \( y = 0 \) to \( y = L \) and \( V(y) = V_s \) to \( V(y) = V_d \), we arrive at the following:

\[ I_{ds} = \mu_{eff} C_{ox} \frac{W}{L} \frac{1}{1 + V_{ds}/E_{sat} L} (V_{gs} - V_{th} - A_{bulk}V_{ds}/2)V_{ds} \]  

(2.5.4)

The drain current model in Eq. (2.5.4) is valid before the carrier velocity saturates.
Strong Inversion Drain Current (Linear Regime)

For instances when the drain voltage is high (and thus the lateral electrical field is high at the drain side), the carrier velocity near the drain saturates. The channel now can be reasonably divided into two portions: one adjacent to the source where the carrier velocity is field-dependent and the second where the velocity saturates. At the boundary between these two portions, the channel voltage is the saturation voltage \( V_{dsat} \) and the lateral electrical is equal to \( E_{sat} \). After the onset of saturation, we can substitute \( v = v_{sat} \) and \( V_{ds} = V_{dsat} \) into Eq. (2.5.1) to get the saturation current:

\[
I_{ds} = W C_{ox} (V_{gs} - A_{bulk} V_{dsat}) v_{sat}
\]

By equating eqs. (2.5.4) and (2.5.5) at \( E = E_{sat} \) and \( V_{ds} = V_{dsat} \), we can solve for saturation voltage \( V_{dsat} \):

\[
V_{dsat} = \frac{E_{sat} L (V_{gs} - V_{th})}{A_{bulk} E_{sat} L + (V_{gs} - V_{th})}
\]

2.5.2 Extrinsic Case (Rds>0)

Parasitic source/drain resistance is an important device parameter which can affect MOSFET performance significantly. As a MOSFET's channel length scale down, the parasitic resistance will not be proportionally scaled. As a result, Rds will have a more significant on device characteristics. Model parasitic resistance in a direct method yields a complicated drain current expression. In order to make simulations more efficient, BSIM3v3 models parasitic resistances using simple expressions. The resulting drain current equation in the linear region can be calculate [3] as follows:
Strong Inversion Drain Current (Linear Regime)

\[
I_{ds} = \frac{V_{ds}}{R_{tot}} = \frac{V_{ds}}{R_{ch} + R_{ds}}
\]

\[
= \mu_{\text{eff}} C_{ox} \frac{W}{L} \left( 1 + \frac{V_{ds}}{(E_{sat} L)} \right) \left( \frac{V_{gst} - A_{bulk} V_{ds}/2}{1 + R_{ds} \mu_{\text{eff}} C_{ox} \frac{W}{L} \left( \frac{V_{gst} - A_{bulk} V_{ds}/2}{1 + V_{ds}/(E_{sat} L)} \right)} \right)
\]

Due to parasitic resistance, the saturation voltage \(V_{dsat}\) will be larger than that predicted by Eq. (2.5.6). Let Eq. (2.5.5) be equal to Eq. (2.5.9). The \(V_{dsat}\) with parasitic resistance \(R_{ds}\) expression is then:

\[
V_{dsat} = \frac{-b - \sqrt{b^2 - 4ac}}{2a}
\]

The following are the expression for the variables \(a, b,\) and \(c:\)

\[
a = A_{bulk}^2 R_{ds} C_{ox} W V_{sat} + \left( \frac{1}{\lambda} - 1 \right) A_{bulk}
\]

\[
b = -(V_{gsr} \left( \frac{2}{\lambda} - 1 \right) + A_{bulk} E_{sat} L + 3 A_{bulk} R_{ds} C_{ox} W V_{sat} V_{gst})
\]

\[
c = E_{sat} L V_{gst} + 2 R_{ds} C_{ox} W V_{sat} V_{gst}^2
\]

\[
\lambda = A_1 V_{gsr} + A_2
\]

The last expression for \(\lambda\) is introduced to account for non-saturation effect of the device. In BSIM3v3, parasitic resistance is modeled as:

\[
R_{ds} = \frac{R_{ds}[1 + P_{w} V_{bunf} + P_{rsh}(\sqrt{\phi_e} - V_{bunf} - \sqrt{\phi_e})]}{(10^6 W_{eff})^{Wr}}
\]
Strong Inversion Current and Output Resistance (Saturation Regime)

The variable $R_{dw}$ is the resistance per unit width, $W_r$ is a fitting parameter, $P_{\text{body}}$ is the body effect coefficient, and $P_{\text{gbs}}$ is the gate-bias effect.

2.6 **Strong Inversion Current and Output Resistance (Saturation Regime)**

A typical I-V curve and its output resistance are shown in Figure 2-6. Considering only the drain current, the I-V curve can be divided into two parts: the linear region in which the drain current increases quickly with the drain voltage and the saturation region in which the drain current has a very weak dependence on the drain voltage. The first order derivative reveals more detailed information about the physical mechanisms which are involved during device operation. The output resistance (which is the reciprocal of the first order derivative of the I-V curve) curve can be clearly divided into four regions in which have distinct $R_{\text{out}}$ vs. $V_{ds}$ dependences.

The first region is the triode (or linear) region in which carrier velocity is not saturated. The output resistance is very small because the drain current has a strong dependence on the drain voltage. The other three regions belong to the saturation region. As will be discussed later, there are three physical mechanisms which affect the output resistance in the saturation region: channel length modulation ($CLM$) [4, 14], drain-induced barrier lowering ($DIBL$) [4, 6, 14], and the substrate current induced body effect ($SCBE$) [14, 18, 19]. All three mechanisms affect the output resistance in the saturation range, but each of them dominates in only a single region. It will be shown next that channel length modulation ($CLM$)
dominates in the second region, DIBL in the third region, and SCBE in the fourth region.

![Graph](image)

**Figure 2-6. General behavior of MOSFET output resistance.**

Generally, drain current is a function of the gate voltage and the drain voltage. But the drain current depends on the drain voltage very weakly in the saturation region. A Taylor series can be used to expand the drain current in the saturation region [3].

\[
I_{ds}(V_{gs}, V_{ds}) = I_{ds}(V_{gs}, V_{dsat}) + \frac{\partial I_{ds}(V_{gs}, V_{ds})}{\partial V_{ds}} (V_{ds} - V_{dsat})
\]

\(= I_{dsat}(1 + \frac{V_{ds} - V_{dsat}}{V_A})\)

where,
Strong Inversion Current and Output Resistance (Saturation Regime)

\[
I_{dsat} = I_d(V_{gs}, V_{dsat}) = W_{sat} C_{ox} (V_{gs} - A_{bulk} V_{dsat})
\]

(2.6.2)

and

\[
V_A = I_{dsat} (\frac{\partial I_d}{\partial V_{ds}})^{-1}
\]

(2.6.3)

The parameter \( V_A \) is called the Early Voltage (analogous to the BJT) and is introduced for the analysis of the output resistance in the saturation region. Only the first order term is kept in the Taylor series. For simplicity, we also assume that the contributions to the Early Voltage from all three mechanisms are independent and can be calculated separately.

### 2.6.1 Channel Length Modulation (CLM)

If channel length modulation is the only physical mechanism to be taken into account, then according to Eq. (2.6.3), the Early Voltage can be calculated by:

\[
V_{ACL\text{M}} = I_{dsat} \left( \frac{\partial I_d}{\partial L} \frac{\partial L}{\partial V_{ds}} \right)^{-1} = A_{bulk} E_{sat} \frac{L + V_{gst}}{A_{bulk} E_{sat}} (\frac{\partial \Delta L}{\partial V_{ds}})^{-1}
\]

(2.6.4)

where \( \Delta L \) is the length of the velocity saturation region, the effective channel length is \( L - \Delta L \). Based on the quasi-two dimensional approximation, \( V_{ACL\text{M}} \) can be derived as the following:

\[
V_{ACL\text{M}} = \frac{A_{bulk} E_{sat} L + V_{gst}}{A_{bulk} E_{sat} L} (V_{ds} - V_{dsat})
\]

(2.6.5)
where $V_{A_CLM}$ is the Early Voltage due to channel length modulation alone.

The parameter $P_{clm}$ is introduced into the $V_{A_CLM}$ expression not only to compensate for the error caused by the Taylor expansion in the Early Voltage model, but also to compensate for the error in $X_j$ since:

$$l = \sqrt{X_j}$$

and the junction depth, $X_j$, can not generally be determined very accurately. Thus, the $V_{A_CLM}$ became:

$$V_{A_CLM} = \frac{1}{P_{clm}} \frac{A_{bulk} E_{sat} L + V_{gst}}{A_{bulk} E_{sat} l} (V_{ds} - V_{dsat}) \quad \text{(2.6.6)}$$

### 2.6.2 Drain-Induced Barrier Lowering (DIBL)

As discussed above, threshold voltage is can be approximated as a linear function of the drain voltage. According to Eq. (2.6.3), the Early Voltage due to the DIBL effect can be calculated as:

$$V_{ADIBLC} = I_{dsat} (\frac{\partial I_{ds}}{\partial V_{th}} \frac{\partial V_{th}}{\partial V_{ds}})^{-1}$$

$$V_{ADIBLC} = \frac{(V_{gs_{eff}} + 2\mu)}{\theta_{nsd}(1 + P_{DIBLC} V_{gs_{eff}})} \left(1 - \frac{A_{bulk} V_{dsat}}{A_{bulk} V_{dsat} + V_{gs_{eff}} + 2\mu}\right)$$

During the derivation of Eq. (2.6.7), the parasitic resistance is assumed to be equal to 0. As expected, $V_{ADIBLC}$ is a strong function of $L$ as shown in Eq. (2.6.7). As channel length decreases, $V_{ADIBLC}$ decreases very quickly.
Strong Inversion Current and Output Resistance (Saturation Regime)

The combination of the CLM and DIBL effects determines the output resistance in the third region, as was shown in Figure 2-6.

Despite the formulation of these two effects, accurate modeling of the output resistance in the saturation region requires that the coefficient \( \theta_{th}(L) \) be replaced by \( \theta_{rout}(L) \). Both \( \theta_{th}(L) \) and \( \theta_{rout}(L) \) have the same channel length dependencies, but different coefficients. The expression for \( \theta_{rout}(L) \) is:

\[
\theta_{rout}(L) = P_{diblc1}[\exp(-D_{rout}L/2l_i) + 2\exp(-D_{rout}L/l_i)] + P_{diblc2}
\]

(2.6.8)

The variables \( P_{diblc1}, P_{diblc2}, P_{diblc} \) and \( D_{rout} \) are the newly introduced parameters to correct for DIBL effect in the strong inversion region. The reason why \( D_{vt0} \) is not equal to \( P_{diblc1} \) and \( D_{vt1} \) is not equal to \( D_{rout} \) is because the gate voltage modulates the DIBL effect. When the threshold voltage is determined, the gate voltage is equal to the threshold voltage. But in the saturation region where the output resistance is modeled, the gate voltage is much larger than the threshold voltage. Drain induced barrier lowering may not be the same at different gate bias. \( P_{diblc2} \) is usually very small (may be as small as 8.0E-3). If \( P_{diblc2} \) is placed into the threshold voltage model, it will not cause any significant change. However it is an important parameter in \( V_{ADIBL} \) for long channel devices, because \( P_{diblc2} \) will be dominant in Eq. (2.6.8) if the channel is long.

2.6.3 Current Expression without Substrate Current Induced
Body Effect

In order to have a continuous drain current and output resistance expression at the transition point between linear and saturation region, the $V_{Asat}$ parameter is introduced into the Early Voltage expression. $V_{Asat}$ is the Early Voltage at $V_{ds} = V_{dsat}$ and is as follows:

$$V_{Asat} = \frac{E_{sat}L + V_{dsat} + 2R_{ds}V_{sat}C_{ox}W(V_{gst} - A_{bulk}V_{ds}/2)}{1 + A_{bulk}R_{ds}V_{sat}C_{ox}W}$$  \hspace{1cm} (2.6.9)

Thus, the total Early Voltage, $V_A$, can be written as:

$$V_A = V_{Asat} + \left(\frac{1}{V_{ACLM}} + \frac{1}{V_{ADIBL}}\right)^{-1}$$  \hspace{1cm} (2.6.10)

The complete (with no impact ionization at high drain voltages) current expression in the saturation region is given by:

$$I_{ds} = W_{V_{sat}}C_{ox}(V_{gst} - A_{bulk}V_{dsat})(1 + \frac{V_{ds} - V_{dsat}}{V_A})$$  \hspace{1cm} (2.6.11)

Furthermore, another parameter, $P_{vag}$, is introduced in $V_A$ to account for the gate bias dependence of $V_A$ more accurately. This much said, the final expression for Early Voltage becomes:

$$V_A = V_{Asat} + \left(1 + \frac{P_{vag}V_{gs}}{E_{sat}L_{eff}}\right)(\frac{1}{V_{ACLM}} + \frac{1}{V_{ADIBL}})^{-1}$$  \hspace{1cm} (2.6.12)
2.6.4 Current Expression with Substrate Current Induced Body Effect

When the electrical field near the drain is very large (> 0.1MV/cm), some electrons coming from the source will be energetic (hot) enough to cause impact ionization. This creates electron-hole pairs when they collide with silicon atoms. The substrate current $I_{sub}$ thus created during impact ionization will increase exponentially with the drain voltage. A well known $I_{sub}$ model [20] is given as:

$$I_{sub} = \frac{A_i}{B_i} I_{dsat} (V_{ds} - V_{dsat}) \exp\left(-\frac{B_i l}{V_{ds} - V_{dsat}}\right)$$  (2.6.13)

The parameters $A_i$ and $B_i$ are determined from extraction. $I_{sub}$ will affect the drain current in two ways. The total drain current will change because it is the sum of the channel current from the source as well as the substrate current. The total drain current can now be expressed [21] as follows:

$$I_{ds} = I_{ds0} + I_{sub}$$

$$= I_{ds0} \left[ 1 + \frac{(V_{ds} - V_{dsat})}{B_l \exp\left(\frac{B_i l}{V_{ds} - V_{dsat}}\right)} \right]$$  (2.6.14)

The total drain current, including $CLM$, $DIBL$ and $SCBE$, can be written as:

$$I_{ds} = W_{V_{sat}} C_{ox} (V_{gs} - A_{bulk} V_{dref})(1 + \frac{V_{ds} - V_{dref}}{V_A})(1 + \frac{V_{ds} - V_{dref}}{V_{SCBE}})$$  (2.6.15)
Subthreshold Drain Current

where \( V_{ASCBE} \) can also be called as the Early Voltage due to the substrate current induced body effect. Its expression is the following:

\[
V_{ASCBE} = \frac{B_l}{A_l} \exp\left(\frac{-B_l}{V_{ds} - V_{dsat}}\right)
\]

From Eq. (2.6.16), we can see that \( V_{ASCBE} \) is a strong function of \( V_{ds} \). In addition, we also observe that \( V_{ASCBE} \) is small only when \( V_{ds} \) is large. This is why \( SCBE \) is important for devices with high drain voltage bias. The channel length and gate oxide dependence of \( V_{ASCBE} \) comes from \( V_{dsat} \) and \( L \). In BSIM3v3, we replace \( B_l \) with \( PSCBE2 \) and \( A_l/B_l \) with \( PSCBE1/L \) to yield the following expression for \( V_{ASCBE} \):

\[
\frac{1}{V_{ASCBE}} = \frac{PSCBE2}{L} \exp\left(-\frac{PSCBE1}{V_{ds} - V_{dsat}}\right)
\]

The variables \( P_{scbe1} \) and \( P_{scbe2} \) are determined experimentally.

2.7 Subthreshold Drain Current

The drain current equation in the subthreshold region was given in [2, 3] can is expressed by the following:

\[
I_{ds} = I_{s0} (1 - \exp\left(\frac{-V_{ds}}{V_t}\right)) \exp\left(\frac{V_{gs} - V_{th} - V_{off}}{nV_t}\right)
\]
Subthreshold Drain Current

\[ I_{so} = \mu_0 \frac{W}{L} \sqrt{\frac{q \varepsilon_{si} N_{ch} v_t^2}{2\Phi_s}} \]  

(2.7.2)

Here the parameter \( \nu_t \) is the thermal voltage and is given by \( KBT/q \). \( \nu_{off} \) is the offset voltage, as discussed in Jeng's dissertation [18]. \( \nu_{off} \) is an important parameter which determines the drain current at \( V_{gs} = 0 \). In Eq. (2.7.1), the parameter \( n \) is the subthreshold swing parameter. Experimental data shows that the subthreshold swing is a function of channel length and the interface state density. These two mechanisms are modeled in BSIM3v3 by the following:

\[ n = 1 + N_{factor} \frac{C_d + C_{dsd} V_{ds} + C_{dsb} V_{bseff}}{C_{ox}} \left( \exp\left(-\frac{D\nu_{T1}}{2l_1}\right) + 2 \exp\left(-\frac{D\nu_{T1}}{l_1}\right) \right) + \frac{C_{it}}{C_{ox}} \]  

(2.7.3)

where, the term:

\[ (C_{dsd} + C_{dsd} V_{ds} + C_{dsb} V_{bseff}) \left( \exp\left(-D\nu_{T1} \frac{L_{eff}}{2l_1}\right) + 2 \exp\left(-D\nu_{T1} \frac{L_{eff}}{l_1}\right) \right) \]

represents the coupling capacitance between the drain or source to the channel. The parameters \( C_{dsd}, C_{dsd}, C_{dsb} \) are extracted. The parameter \( C_{it} \) in Eq. (2.7.3) is the capacitance due to interface states. From Eq. (2.7.3), it can be seen that subthreshold swing shares the same exponential dependence on channel length as the DIBL effect. The parameter \( N_{factor} \) is introduced to compensate for errors in the depletion width capacitance calculation. \( N_{factor} \) is determined experimentally and is usually very close to 1.
2.8 Effective Channel Length and Width:

The effective channel length and width used in all model expressions is given below:

\[ L_{\text{eff}} = L_{\text{drawn}} - 2dL \]  
(2.8.1)

\[ W_{\text{eff}} = W_{\text{drawn}} - 2dW \]  
(2.8.2a)

\[ W_{\text{eff}}' = W_{\text{drawn}} - 2dW' \]  
(2.8.2b)

The only difference between Eq. (2.8.1a) and (2.8.1b) is that the former includes bias dependencies. The parameters \( dW \) and \( dL \) are modeled by the following:

\[ dW = dW' + dW_g V_{\text{steff}} + dW_b \left( \sqrt{V_b} - \sqrt{V_{\text{beff}}} \right) \]  
(2.8.3)

\[ dW' = \frac{W_{\text{int}}}{L_{W_{\text{ln}}}} + \frac{W_g}{W_{W_{\text{mn}}} W_{L_{W_{\text{ln}}}}} + \frac{W_w}{L_{W_{\text{ln}}} W_{W_{\text{mn}}}} \]  
(2.8.4)

\[ dL = \frac{L_{\text{int}}}{L_{L_{\text{ln}}}} + \frac{L_g}{L_{W_{\text{ln}}} W_{L_{W_{\text{ln}}}}} + \frac{L_w}{L_{L_{\text{ln}}} W_{L_{\text{ln}}}} \]

These complicated formulations require some explanation. From Eq. (2.8.3), the variable \( W_{\text{int}} \) models represents the tradition manner from which "delta W" is extracted (from the intercepts of straights lines on a \( 1/R_{\text{ds}} \) vs. \( W_{\text{drawn}} \) plot). The parameters \( dW_g \) and \( dW_b \) have been added to account for the contribution of both front gate and back side (substrate) biasing effects. For \( dL \), the parameter \( L_{\text{int}} \)
Poly Gate Depletion Effect

represents the traditional manner from which "delta L" is extracted (mainly from the intercepts of lines from a $R_{ds}$ vs. $L_{drawn}$ plot).

The remaining terms in both $dW$ and $dL$ are included for the convenience of the user. They are meant to allow the user to model each parameter as a function of $W_{(drawn)}$, $L_{(drawn)}$, and their associated product terms. In addition, the freedom to model these dependencies as other than just simple inverse functions of $W$ and $L$ is also provide for the user in BSIM3v3. For $dW$, they are $Wln$ and $Wwn$. For $dL$ they are $Lln$ and $Lwn$.

By default all of the above geometrical dependencies for both $dW$ and $dL$ are turned off. Again, these equations are provided in BSIM3v3 only for the convenience of the user. As such, it is up to the user must adopt the correct extraction strategy to ensure proper use.

2.9 Poly Gate Depletion Effect

When a gate voltage is applied to a heavily doped poly-silicon gate, e.g. NMOS with n+ poly-silicon gate, a thin depletion layer will be formed at the interface between the poly-silicon and gate oxide. Although this depletion layer is very thin due to the high doping concentration of the poly-Si gate, its effect cannot be ignored in the 0.1μm regime since the gate oxide thickness will also be very small, possibly 50Å or thinner.

Figure 2-7 shows a NMOSFET with a depletion region in the n+ poly-silicon gate. The doping concentration in the n+ poly-silicon gate is $N_{gate}$ and the doping concentration in the substrate is $N_{sub}$. The gate oxide thickness is $T_{ox}$. The depletion width in the poly gate is $X_p$. The depletion width in the substrate is $X_d$. If we
Poly Gate Depletion Effect

assume the doping concentration in the gate is infinite, then no depletion region will exist in the gate, and there would be one sheet of positive charge whose thickness is zero at the interface between the poly-silicon gate and gate oxide.

In reality, the doping concentration is, of course, finite. The positive charge near the interface of the poly-silicon gate and the gate oxide is distributed over a finite depletion region with thickness $X_p$. In the presence of the depletion region, the voltage drop across the gate oxide and the substrate will be reduced, because part of the gate voltage will be dropped across the depletion region in the gate. That means the effective gate voltage will be reduced.

Figure 2-7. Charge distribution in a MOSFET with the poly gate depletion effect. The device is in the strong inversion region.
Poly Gate Depletion Effect

The effective gate voltage can be calculated in the following manner. Assume the doping concentration in the poly gate is uniform. The voltage drop in the poly gate ($V_{poly}$) can be calculated as:

\[ V_{poly} = \frac{q}{2} N_{gate} \frac{X_{poly}^2}{\epsilon_{si}} \]

(2.9.1)

where $E_{poly}$ is the maximum electrical field in the poly gate. The boundary condition at the interface of poly gate and the gate oxide is

\[ \epsilon_{ox} E_{ox} = \epsilon_{si} E_{poly} = \sqrt{2q\epsilon_{si}N_{gate}V_{poly}} \]

(2.9.2)

where $E_{ox}$ is the electrical field in the gate oxide. The gate voltage satisfies

\[ V_{gs} - V_{FB} - \phi_s = V_{poly} + V_{ox} \]

(2.9.3)

where $V_{ox}$ is the voltage drop across the gate oxide and satisfies $V_{ox} = E_{ox} T_{ox}$.

According to the equations (2.9.1) to (2.9.3), we obtain the following:

\[ a(V_{gs} - V_{FB} - \phi_s - V_{poly})^2 - V_{poly} = 0 \]

(2.9.4)

where

\[ a = \frac{\epsilon_{ox}^2}{2q\epsilon_{si}N_{gate}T_{ox}^2} \]

(2.9.5)
Poly Gate Depletion Effect

By solving the equation (2.9.4), we get the effective gate voltage \( V_{gs\_eff} \) which is equal to:

\[
V_{gs\_eff} = V_{FB} + \phi_s + \frac{q\varepsilon_{si}N_{gate}T_{ox}}{\varepsilon_{ox}^2} \left( \sqrt{1 + \frac{2\varepsilon_{ox}^2(V_{gs} - V_{FB} - \phi_s)}{q\varepsilon_{si}N_{gate}T_{ox}^2}} - 1 \right)
\]  

(2.9.6)

Figure 2-8 shows \( V_{gs\_eff} / V_{gs} \) versus the gate voltage. The threshold voltage is assumed to be 0.4V. If \( T_{ox} = 40 \text{Å} \), the effective gate voltage can be reduced by 6% due to the poly gate depletion effect as the applied gate voltage is equal to 3.5V.

![Figure 2-8. The effective gate voltage versus applied gate voltage at different gate oxide thickness.](image)

The drain current reduction in the linear region as a function of the gate voltage can now be determined. Assume the drain voltage is very small, e.g. 50mV. Then
Poly Gate Depletion Effect

the linear drain current is proportional to $C_{ox}(V_{gs} - V_{th})$. The ratio of the linear drain current with and without poly gate depletion is equal to:

$$\frac{I_{ds}(V_{gs\_eff})}{I_{ds}(V_{gs})} = \frac{(V_{gs\_eff} - V_{th})}{(V_{gs} - V_{th})}$$  \hfill (2.9.7)

Figure 2-9 shows $I_{ds}(V_{gs\_eff}) / I_{ds}(V_{gs})$ versus the gate voltage using eq. (2.9.7). The drain current can be reduced by several percent due to gate depletion.

Figure 2-9. Ratio of linear region current with poly gate depletion effect and that without.
CHAPTER 3: Unified I-V Model

The development of separate model expressions for such device operation regimes as subthreshold and strong inversion were discussed in Chapter 2. Although these expressions can each accurately describe device behavior within their own respective region of operation, problems are likely to occur between two well-described regions or within transition regions. In order to circumvent this issue, a unified model should be synthesized to not only preserve region-specific expressions but also to ensure the continuities of current ($I_d$) and conductance ($G_{xx}$) and their derivatives in all transition regions as well. Such high standards are met in BSIM3v3. As a result, convergence and calculation efficiencies are much improved.

This chapter will describe the unified natured of BSIM3v3’s model equations. While most of the parameter symbols in this chapter are explained in the following text, a complete description of all I-V model equation parameters can be found in the Appendix A.

3.1 Unified Channel Charge Density Expression

Separate expressions for channel charge density are shown below for subthreshold (Eq. (3.1.1a) and (3.1.1b)) and strong inversion (Eq. (3.1.2)). Both expressions are valid for small $V_d$s.
Unified Channel Charge Density Expression

\[ Q_{\text{ch,sub0}} = Q_0 \exp \left( \frac{V_{\text{gs}} - V_{\text{th}}}{nV_t} \right) \]  

(3.1.1a)

where, \( Q_0 \) is:

\[ Q_0 = \sqrt{\frac{q\varepsilon_0 N_{\text{ch}}}{2\Phi_t}} \exp \left( -\frac{V_{\text{eff}}}{nV_t} \right) \]  

(3.1.1b)

\[ Q_{\text{ch}0} = C_{\text{ox}}(V_{\text{gs}} - V_{\text{th}}) \]  

(3.1.2)

In both Eqs. (3.1.1a) and (3.1.2), the parameters \( Q_{\text{ch,sub0}} \) and \( Q_{\text{ch}0} \) are the channel charge densities at the source for very small \( V_{\text{ds}} \). To form a unified expression, an effective \((V_{\text{gs}} - V_{\text{th}})\) function named \( V_{\text{gsteff}} \) is introduced to describe the channel charge characteristics from subthreshold to strong inversion:

\[ V_{\text{gsteff}} = \frac{2nV_t \ln \left[ 1 + \exp \left( \frac{V_{\text{gs}} - V_{\text{th}}}{2nV_t} \right) \right]}{1 + 2nC_{\text{ox}} \sqrt{\frac{2\Phi_t}{q\varepsilon_0 N_{\text{ch}}}} \exp \left( \frac{V_{\text{gs}} - V_{\text{th}} - 2V_{\text{eff}}}{2nV_t} \right)} \]  

(3.1.3)

The unified channel charge density at the source end for both subthreshold and inversion region can therefore be written as:

\[ Q_{\text{ch}0} = C_{\text{ox}} V_{\text{gsteff}} \]  

(3.1.4)

Figures 3-1 and 3-2 show the "smoothness" of Eq. (3.1.4) from subthreshold to strong inversion regions. The \( V_{\text{gsteff}} \) expression will be used again in subsequent sections of this chapter to model the drain current.
Unified Channel Charge Density Expression

Figure 3-1. The $V_{gsteff}$ function vs. $(V_{gs} - V_{th})$ in linear scale.

Figure 3-2. $V_{gsteff}$ function vs. $(V_{gs} - V_{th})$ in log scale.
Eq. (3.1.4) serves as the cornerstone of the unified channel charge expression at the source for small $V_{ds}$. To account for the influence of $V_{ds}$, the $V_{gsteff}$ function must keep track of the change in channel potential from the source to the drain. In other words, Eq. (3.1.4) will have to include a $y$ dependence. To initiate this formulation, consider first the re-formulation of channel charge density for the case of strong inversion:

$$Q_{ch}(y) = C_{ox}(V_{gs} - V_{th} - A_{bulk}V_{F(y)})$$  \hspace{1cm} (3.1.5)

The parameter $V_{F(y)}$ stands for the quasi-Fermi potential at any given point, $y$, along the channel with respect to the source. This equation can also be written as:

$$Q_{ch}(y) = Q_{ch0} + \Delta Q_{ch(y)}$$  \hspace{1cm} (3.1.6)

The term $\Delta Q_{ch(y)}$ is the incremental channel charge density induced by the drain voltage at point $y$. It can be expressed as:

$$\Delta Q_{ch(y)} = -C_{ox}A_{bulk}V_{F(y)}$$  \hspace{1cm} (3.1.7)

For the subthreshold region ($V_{gs}<<V_{th}$), the channel charge density along the channel from source to drain can be written as:
Unified Channel Charge Density Expression

\[ Q_{\text{chsub}(y)} = Q_0 \exp\left(\frac{V_{gs} - V_{th} - A_{bulk} V_{F(y)}}{nV_t}\right) \]
\[ = Q_{\text{chsub0}} \exp\left(-\frac{A_{bulk} V_{F(y)}}{nV_t}\right) \]

A Taylor series expansion of the right-hand side of Eq. (3.1.8) yields the following (keeping only the first two terms):

\[ Q_{\text{chsub}(y)} = Q_{\text{chsub0}} \left(1 - \frac{A_{bulk} V_{F(y)}}{nV_t}\right) \]

(3.1.9)

Analogous to Eq. (3.1.6), Eq. (3.1.9) can also be written as:

\[ Q_{\text{chsub}(y)} = Q_{\text{chsub0}} + \Delta Q_{\text{chsub(y)}} \]

(3.1.10)

The parameter \( \Delta Q_{\text{chsub}(y)} \) is the incremental channel charge density induced by the drain voltage in the subthreshold region. It can be written as:

\[ \Delta Q_{\text{chsub}(y)} = -\frac{A_{bulk} V_{F(y)}}{nV_t} Q_{\text{chsub0}} \]

(3.1.11)

Note that Eq. (3.1.9) is valid only when \( V_{F(y)} \) is very small, which is maintained, fortunately, due to the fact that Eq. (3.1.9) is only used in the linear regime (i.e. \( V_{ds} \leq 2V_t \)).

Eqs. (3.1.6) and (3.1.10) both have drain voltage dependencies. However, they are decuple and a unified expression for \( Q_{\text{ch}(y)} \) is desperately needed. To obtain a unified expression along the channel, we first assume:
Here, $\Delta Q_{ch(y)}$ is the incremental channel charge density induced by the drain voltage. Substituting Eq. (3.1.7) and (3.1.11) into Eq. (3.1.12), we obtain:

$$\Delta Q_{ch(y)} = \frac{V_{F(y)}}{V_b} Q_{ch0}$$

(3.1.13)

where $V_b = (V_{gsteff} + n^*V_t) / A_{bulk}$.

In order to remove any association between the variable $n$ and bias dependencies ($V_{gsteff}$) as well as to ensure more precise modeling of Eq. (3.1.8) for linear regimes (under subthreshold conditions), the variable $n$ is replaced with 2. The expression for $V_b$ now becomes:

$$V_b = \frac{V_{gsteff} + 2V_t}{A_{bulk}}$$

(3.1.14)

A unified expression for $Q_{ch(y)}$ from subthreshold to strong inversion regimes is now at hand:

$$Q_{ch(y)} = Q_{ch0}(1 - \frac{V_{F(y)}}{V_b})$$

(3.1.15)

The variable $Q_{ch0}$ is given by Eq. (3.1.4).

### 3.2 Unified Mobility Expression

BSIM3v3 uses a unified mobility expression based on the $V_{gsteff}$ expression of Eq. 3.1.3. Thus, we have:
Unified Linear Current Expression

(Mobmod=1) \hspace{1cm} (3.2.1)

\[
\mu_{\text{eff}} = \frac{\mu_0}{1 + (U_a + U_c V_{\text{beff}})(\frac{V_{\text{gs eff}} + 2V_{\text{th}}}{T_{\text{ox}}}) + U_b(\frac{V_{\text{gs eff}} + 2V_{\text{th}}}{T_{\text{ox}}})^2}
\]

To account for depletion mode devices, another mobility model option is given by the following:

(Mobmod=2) \hspace{1cm} (3.2.2)

\[
\mu_{\text{eff}} = \frac{\mu_0}{1 + (U_a + U_c V_{\text{beff}})(\frac{V_{\text{gs eff}}}{T_{\text{ox}}}) + U_b(\frac{V_{\text{gs eff}}}{T_{\text{ox}}})^2}
\]

To consider the body bias dependence of Eq. 3.2.1 further, we have introduced the following expression:

(For Mobmod=3) \hspace{1cm} (3.2.3)

\[
\mu_{\text{eff}} = \frac{\mu_0}{1 + [U_a(\frac{V_{\text{gs eff}} + 2V_{\text{th}}}{T_{\text{ox}}}) + U_b(\frac{V_{\text{gs eff}} + 2V_{\text{th}}}{T_{\text{ox}}})^2](1 + U_c V_{\text{beff}})}
\]

3.3 Unified Linear Current Expression

3.3.1 Intrinsic case (Rds=0)

Generally, the following expression [2] is used to account for both drift and diffusion current:
Unified Linear Current Expression

\[ I_d(y) = WQ_{ch(y)}\mu_{sat(y)} \frac{dV_{F(y)}}{dy} \]  \hspace{1cm} (3.3.1)

where the parameter \( \mu_{sat(y)} \) can be written as:

\[ \mu_{sat(y)} = \frac{\mu_{\text{eff}}}{1 + \frac{E_y}{E_{\text{sat}}}} \]  \hspace{1cm} (3.3.2)

Substituting Eq. (3.3.2) in Eq. (3.3.1) we get:

\[ I_d(y) = WQ_{\text{cho}}(1 - \frac{V_{F(y)}}{V_b}) \frac{\mu_{\text{eff}}}{1 + \frac{E_y}{E_{\text{sat}}}} \frac{dV_{F(y)}}{dy} \]  \hspace{1cm} (3.3.3)

Eq. (3.3.3) resembles the equation used to model drain current in the strong inversion regime. However, it can now be used to describe the current characteristics in the subthreshold regime when \( V_{ds} \) is very small (\( V_{ds} < 2V_d \)). Eq. (3.3.3) can now be integrated from the source to drain to get the expression for linear drain current in the channel. This expression is valid from the subthreshold regime to the strong inversion regime:

\[ I_{d0} = \frac{W\mu_{\text{eff}}Q_{\text{cho}}V_{ds}(1 - \frac{V_{ds}}{2V_b})}{L(1 + \frac{V_{ds}}{V_a})} \]  \hspace{1cm} (3.3.4)
3.3.2 Extrinsic Case (Rds > 0)

The current expression when Rds > 0 can be obtained based on Eq. (2.5.9) and Eq. (3.3.4). The expression for linear drain current from subthreshold to strong inversion is:

\[
I_{ds} = \frac{I_{do}}{1 + \frac{R_{ds}I_{do}}{V_{ds}}}
\]  

(3.3.5)

Chapter 8 will illustrate the "smoothness" of this expression.

3.4 Unified Vdsat Expression

3.4.1 Intrinsic case (Rds=0)

To get an expression for the electric field as a function of y along the channel, we integrate Eq. (3.3.1) from 0 to an arbitrary point y. The expression is as follows:

\[
E_{y} = \frac{I_{do}}{\sqrt{(WQ_{chem})V_{eff} - \left(\frac{I_{do}}{E_{sat}}\right)^2 - \frac{2I_{do}WQ_{chem}V_{eff}y}{V_{b}}}}
\]

(3.4.1)

If we assume that drift velocity saturates when \(E_{y}=E_{sat}\), we get the following expression for Idsat:
Unified Vdsat Expression

Let $V_{ds} = V_{dsat}$ in Eq. (3.3.4) and set this equal to Eq. (3.4.2), we get the following expression for $V_{dsat}$:

$$V_{dsat} = \frac{E_{satL}(V_{gs}^{\text{eff}} + 2V_t)}{A_{bulk}E_{satL} + V_{gs}^{\text{eff}} + 2V_t}$$  \hspace{1cm} (3.4.3)

### 3.4.2 Extrinsic Case ($R_{ds} > 0$)

The Vdsat expression for the extrinsic case is formulated from Eq. (3.4.3) and Eq. (2.5.10) to be the following:

$$V_{dsat} = \frac{-b - \sqrt{b^2 - 4ac}}{2a}$$  \hspace{1cm} (3.4.4a)

where,

$$a = A_{bulk} W_{eff} V_{sas} C_{sd} R_{DS} + \left( \frac{1}{\lambda} - 1 \right) A_{bulk}$$  \hspace{1cm} (3.4.4b)

$$b = -\left( V_{gs}^{\text{eff}} + 2V_t \right) \left( \frac{2}{\lambda} - 1 \right) A_{bulk} E_{satL}^{\text{eff}} + 3 A_{bulk} \left( V_{gs}^{\text{eff}} + 2V_t \right) W_{eff} V_{sas} C_{sd} R_{DS}$$  \hspace{1cm} (3.4.4c)

$$c = \left( V_{gs}^{\text{eff}} + 2V_t \right) E_{satL}^{\text{eff}} + 2 \left( V_{gs}^{\text{eff}} + 2V_t \right)^2 W_{eff} V_{sas} C_{sd} R_{DS}$$  \hspace{1cm} (3.4.4d)
Unified Saturation Current Expression

\[ \lambda = A_1 V_{\text{gsteff}} + A_2 \]  

(3.4.4e)

The parameter \( \lambda \) is introduced to account for non-saturation effects. The parameters \( A_1 \) and \( A_2 \) are extracted.

3.5 Unified Saturation Current Expression

A unified expression for the saturation current from the subthreshold to the strong inversion regime can be formulated by introducing the \( V_{\text{gsteff}} \) function into Eq. (2.6.15). The resulting equations are the following:

\[ I_{ds} = \frac{I_{dso(V_{dsat})}}{1 + \frac{R_{ds} I_{dso(V_{dsat})}}{V_{dsat}} \left( 1 + \frac{V_{ds} - V_{dsat}}{V_A} \right) \left( 1 + \frac{V_{ds} - V_{dsat}}{V_{ASCBE}} \right)} \]

where,

\[ V_A = V_{Asat} + (1 + \frac{P_{weg} V_{gsteff}}{E_{\text{sat}L}} \left( \frac{1}{V_{ACL}} + \frac{1}{V_{AD/BLC}} \right))^{-1} \]

\[ E_{\text{sat}L} + V_{dsat} + 2R_{ds} V_{A} W_{eff} V_{gsteff} [1 - \frac{A_{bulk} V_{dsat}}{2(V_{gsteff} + 2V_t)}] \]

\[ V_{Asat} = \frac{E_{\text{sat}L} + V_{dsat} + 2R_{ds} V_{A} W_{eff} A_{bulk}}{2 / \lambda - 1 + R_{ds} V_{A} W_{eff} A_{bulk}} \]

\[ V_{ACL} = \frac{A_{bulk} E_{\text{sat}L} + V_{gsteff}}{P_{CL} A_{bulk} E_{\text{sat}L} \text{litl}} (V_{ds} - V_{dsat}) \]
Single Current Expression for All Operational Regimes of \( V_{gs} \) and \( V_{ds} \)

\[
V_{ADIBC} = \frac{(V_{gs}^{eff} + 2V_t)}{\theta_{rot}(1 + P_{DIBC}V_{bs}^{eff}) \left(1 - \frac{A_{bulk}V_{ds}^{sat}}{A_{bulk}V_{ds}^{sat} + V_{gs}^{eff} + 2V_t}\right)}
\]  

(3.5.5)

\[
\theta_{rot} = P_{DIBC} \left[\exp\left(-D_{ROUT} \frac{L_{eff}}{2l_0}\right) + 2\exp\left(-D_{ROUT} \frac{L_{eff}}{l_0}\right)\right] + P_{DIBC}^2
\]

(3.5.6)

\[
\frac{1}{V_{ASCBE}^{eff}} = \frac{P_{scbe2}}{L_{eff}} \exp\left(-\frac{P_{scbe1} l_{it}}{V_{ds} - V_{ds}^{sat}}\right)
\]

(3.5.7)

### 3.6 Single Current Expression for All Operational Regimes of \( V_{gs} \) and \( V_{ds} \)

The \( V_{gs}^{eff} \) function introduced in Chapter 2 gave a unified expression for the linear drain current from subthreshold to strong inversion as well as for the saturation drain current from subthreshold to strong inversion, separately. In order to link the continuous linear current with that of the continuous saturation current, a smooth function for \( V_{ds} \) is introduced. In the past, several smooth functions have been proposed for MOSFET modeling [22-24]. For BSIM3v3, the smooth function used is similar to that proposed by R. M. D. A. Velghe et al [24]. The overall current equation for both linear and saturation current now becomes:

\[
I_{ds} = \frac{I_{ds(V_{gss}^{eff})}}{1 + \frac{R_{ds}I_{ds(V_{gss}^{eff})}}{V_{ds}^{eff}} \left(1 + \frac{V_{ds} - V_{ds}^{eff}}{V_A}\right) \left(1 + \frac{V_{ds} - V_{ds}^{eff}}{V_{ASCBE}^{eff}}\right)}
\]

(3.6.1)

Most of the previous equations which contain \( V_{ds} \) and \( V_{ds}^{sat} \) dependencies are now substituted with the \( V_{gss}^{eff} \) function. For example, Eq. (3.5.4) now becomes:

---

BSIM3v3 Manual Copyright © 1995, 1996, UC Berkeley
Single Current Expression for All Operational Regimes of $V_{gs}$ and $V_{ds}$

\[
V_{ACLM} = \frac{A_{bulkE_{sat}}L_{eff} + V_{gseff}}{P_{CLMA_{bulkE_{sat}}l_{itl}}}(V_{ds} - V_{ddeff})
\]  

(3.6.2)

Similarly, Eq. (3.5.7) now becomes:

\[
\frac{1}{V_{ASCBE}} = \frac{P_{scbe2}}{L_{eff}} \exp\left(\frac{-P_{scbe1}l_{itl}}{V_{ds} - V_{ddeff}}\right)
\]  

(3.6.3)

The $V_{dseff}$ expression is written as:

\[
V_{dseff} = V_{dsat} - \frac{1}{2}\left(V_{dsat} - V_{ds} - \delta + \sqrt{(V_{dsat} - V_{ds} - \delta)^2 + 4\delta V_{dsat}}\right)
\]  

(3.6.4)

The expression for $V_{dsat}$ is that given under Section 3.4. The parameter $\delta$ is an extracted constant. The dependence of $V_{dseff}$ on $V_{ds}$ is given in Figure 3-3. The $V_{dseff}$ function follows $V_{ds}$ in the linear region and tends to $V_{dsat}$ in the saturation region. Figure 3-4 shows the effect of $\delta$ on the transition region between linear and saturation regimes.
Single Current Expression for All Operational Regimes of Vgs and Vds

Figure 3-3. Vdseff vs. Vds for δ=0.01 and different Vgs.

Figure 3-4. Vdseff vs. Vds for Vgs=3V and different δ values.
3.7 Substrate Current

BSIMv3 uses the Eq. (3.7.1) to model substrate current.

\[
I_{sub} = \frac{\alpha_0}{L_{eff}} (V_{ds} - V_{dss}) \exp\left(-\frac{\beta_0}{V_{ds} - V_{dss}}\right) \frac{I_{do}}{1 + \frac{V_{ds} - V_{dss}}{V_{A}}} 
\]

(3.7.1)

The parameters \(\alpha_0\) and \(\beta_0\) refer to impact ionization current.

3.8 A Note on Vbs

In BSIM3v3, all Vbs terms which have appeared in Chapters 2 and 3 have been substituted with a \(V_{bss}\) expression as shown in Eq. (3.8.1). This is done in order to set an upper bound for the body bias value during simulations. Unreasonable values can occur if this expression is not introduced.

\[
V_{bss} = V_{bc} + 0.5[V_{bs} - V_{bc} - \delta_1 + \sqrt{(V_{bs} - V_{bc} - \delta_1)^2 - 4\delta_1 V_{bc}}]
\]

(3.8.1)

where \(\delta_1 = 0.001\).

The parameter \(V_{bc}\) is the maximum allowable \(V_{bs}\) value and is obtained based on the condition of \(dV_{th}/dV_{bs} = 0\) for the \(V_{th}\) expression of 2.1.4.
CHAPTER 4: Capacitance Model

Previous BSIM capacitance models used long channel charge models in which the ratio of $C_{ij}/L_{eff}$ (where $i$ and $j$ are the transistor nodes) did not scale with $L_{eff}$. This resulted in an overestimation of capacitance values for devices smaller than a $L_{drawn}$ of 2 $\mu$m. This effect was particularly severe at low drain biases. In addition, previous capacitance models also showed appalling discontinuities for the gate capacitance at threshold voltage. These factors as well as others necessitated the development of a new charge and capacitance model.

4.1 General Information

In BSIM3v3, a new capacitance formulation addresses the above concerns. This new model incorporates the following enhancements:

- Separate effective channel length and width are used for capacitance and I-V models.
- A simple short channel capacitance model with accuracy down to the 0.2 $\mu$m $L_{eff}$ range.
- Intrinsic C-V model is no longer piece-wise (i.e. divided into inversion, depletion, triode and saturation regions). Instead, a single equation is used for each nodal charge covering all regions of operation. This ensures continuity of all derivatives and enhances convergence properties. The inversion
capacitance and substrate capacitance are also no longer discontinuous at the threshold voltage.

- Threshold voltage formulation is consistent with the I-V model. Effects such as body effect and DIBL are automatically incorporated in the capacitance model.
- Overlap capacitance comprises two parts: 1) a bias independent part which models the effective overlap capacitance between the gate and the heavily doped source/drain, and 2) a gate bias dependent part between the gate and the lightly doped source/drain region.
- Bias independent, fringing capacitances are added between the gate and source as well as the gate and drain.

To accommodate these changes, new parameters are introduced (Table 4-1).

<table>
<thead>
<tr>
<th>Name</th>
<th>Function</th>
<th>Default</th>
<th>Unit</th>
</tr>
</thead>
<tbody>
<tr>
<td>CAPMOD</td>
<td>Flag for short channel capacitance model</td>
<td>2</td>
<td>(True)</td>
</tr>
<tr>
<td>CGS1</td>
<td>Lightly-doped source to gate overlap capacitance</td>
<td>0</td>
<td>(F/m)</td>
</tr>
<tr>
<td>CGD1</td>
<td>Lightly-doped drain to gate overlap capacitance</td>
<td>0</td>
<td>(F/m)</td>
</tr>
<tr>
<td>CKAPPA</td>
<td>Coefficient for lightly-doped overlap capacitance</td>
<td>0.6</td>
<td></td>
</tr>
<tr>
<td>CF</td>
<td>Fringing field capacitance</td>
<td>equation (4.4.2)</td>
<td>(F/m)</td>
</tr>
<tr>
<td>CLC</td>
<td>Constant term for short channel model</td>
<td>0.1</td>
<td>μm</td>
</tr>
<tr>
<td>CLE</td>
<td>Exponential term for short channel model</td>
<td>0.6</td>
<td></td>
</tr>
<tr>
<td>DWC</td>
<td>Long channel gate capacitance width offset</td>
<td>Wint</td>
<td>μm</td>
</tr>
<tr>
<td>DLC</td>
<td>Long channel gate capacitance length offset</td>
<td>Lint</td>
<td>μm</td>
</tr>
</tbody>
</table>

Table 4-1. New parameters for BSIM3v3 capacitance model.
4.2 A Note on Device Geometry Dependencies

For capacitance modeling considerations, a transistor can be divided into 2 regions: intrinsic and extrinsic. The intrinsic part is the region between the metallurgical source and drain junction when the gate to S/D region is at flat band voltage. The extrinsic part, basically the parasitics, is further divided into three regions: 1) the outer fringing capacitance between the polysilicon gate and the source/drain, 2) the overlap between the gate and the heavily doped S/D region (relatively insensitive to bias conditions), and 3) the overlap between the gate and lightly doped S/D region which changes with bias.

In the previous C-V model (BSIM3 Version 2.0), both the I-V and C-V parts of the model used the same Leff and Weff expressions. This is not so in the new model BSIM3v3. The geometry dependence for the intrinsic capacitance part is given as the following:

\[
\delta W_{\text{eff}} = DWC + \frac{Wl}{L^{W_{\text{ln}}}} + \frac{W}{W^{W_{\text{ln}}}} + \frac{Wwl}{W} \\
\delta L_{\text{eff}} = DLC + \frac{Ll}{L^{L_{\text{ln}}}} + \frac{L}{L^{W_{\text{ln}}}} + \frac{Lwl}{L} \\
L_{\text{active}} = L_{\text{drawn}} - 2\delta L_{\text{eff}} \\
W_{\text{active}} = W_{\text{drawn}} - 2\delta W_{\text{eff}}
\]  

(4.2.1)  
(4.2.2)  
(4.2.3)  
(4.2.4)

The meanings of DWC and DLC are different from those of Wint and Lint in the I-V model. \(L_{\text{active}}\) and \(W_{\text{active}}\) are the effective length and width of the intrinsic
A Note on Device Geometry Dependencies

device for capacitance calculations. Unlike the case with I-V, we assumed that these dimensions have no voltage bias dependence. The parameter $\delta$Leff is equal to the source/drain to gate overlap length plus the difference between drawn and actual POLY CD due to processing (gate printing, etching and oxidation) on one side. Overall, a distinction should be made between the effective channel length extracted from the capacitance measurement and from the I-V measurement.

Traditionally, the Leff extracted during I-V model characterization is used to gauge a technology. However this Leff does not necessarily carry a physical meaning. It is just a parameter used in the I-V formulation so that the measured I-V characteristics match those calculated by the model. This Leff is therefore very sensitive to the I-V equations used and also to the conduction characteristics of the LDD region relative to the channel region. A device with a large Leff and a small parasitic resistance can have a similar current drive as another with a smaller Leff but larger $R_{ds}$. In some cases Leff can be larger than the polysilicon gate length giving Leff a dubious physical meaning (negative Leff).

The $L_{active}$ parameter extracted from the capacitance method is a closer representation of the metallurgical junction length (physical length). Due to the graded source/drain junction profile the source to drain length can have a very strong bias dependence. We therefore define $L_{active}$ to be that measured at gate to source/drain flat band voltage. If the values for DWC and DLC are not specified in the SPICE model card, BSIM3v3's capacitance model will assume that the device in question has the same effective dimensions for both I-V and C-V models (i.e. $DWC = W_{int}$ and $DLC = L_{int}$).
4.3 Intrinsic Capacitance

4.3.1 Background Information

There has been no recent major work performed in the area of intrinsic capacitance modeling suitable for implementation into a circuit simulator. One bottleneck is the difficulty in capacitance measurement, especially in the deep micron regime. At very short channel lengths, the MOSFET intrinsic capacitance is very small yet the conductance is large. The large conductance results in large in-phase currents during high frequency measurement and overloads the C-V meter. Also the effects of the parasitic inductance in the experimental setup will be more profound. Moreover, since charge can only be measured at high impedance nodes (i.e. the gate and substrate nodes), only 8 of the 16 capacitance components in an intrinsic MOSFET, can be directly measured.

An alternative solution is to use a 2-D device simulator such as PISCES. However, the simulation results are not always satisfactory. Another reason for the lack of development work is the observation that most circuits used to be dominated by interconnect and junction capacitances. An exact model for the intrinsic transistor capacitance is of lesser importance. However, this may no longer be true with the continuous shrinking of design rules. Also, a well behave capacitance model will help circuit simulation convergence. In low power and analog applications, designers are interested in device operation near threshold voltage. Thus, the model must also be accurate in transition regions as well. To ensure proper behavior, both the I-V and C-V model equations should be
Intrinsic Capacitance

developed from an identical set of charge equations so that $C_{ij}/I_d$ is well behaved.

Similar to the I-V model, the development of the capacitance model was carried out with an effort to balance physics with simulation efficiency. Several physical models have been published. These were either too complicated or lacked continuity from one operation region to another. A good model should be simple yet include most of the physical concepts.

4.3.2 Basic Formulation

To ensure charge conservation, terminal charges instead of the terminal voltages are used as state variables. The terminal charges $Q_g$, $Q_b$, $Q_s$, and $Q_d$ are the charges associated with the gate, bulk, source, and drain, respectively. The gate charge is comprised of mirror charges from 3 components: the channel minority (inversion) charge ($Q_{inv}$), the channel majority (accumulation) charge ($Q_{acc}$) and the substrate fix charge ($Q_{sub}$).

The accumulation charge and the substrate charge are associated with the substrate node while the channel charge comes from the source and drain nodes:

\[
\begin{align*}
Q_g &= -(Q_{sub} + Q_{inv} + Q_{acc}) \\
Q_b &= Q_{acc} + Q_{sub} \\
Q_{inv} &= Q_s + Q_d
\end{align*}
\]

The substrate charge can be divided into two components - the substrate charge at zero source-drain bias ($Q_{sub0}$), which is a function of gate to
Intrinsic Capacitance

substrate bias, and the additional non-uniform substrate charge in the presence of a drain bias \((\delta Q_{\text{sub}})\). \(Q_{g}\) now becomes:

\[
Q_{g} = -(Q_{\text{inv}} + Q_{\text{acc}} + Q_{\text{sub}} + \delta Q_{\text{sub}})
\]  

(4.3.2)

The total charge is computed by integrating the charge along the channel. The threshold voltage along the channel is modified due to the non-uniform substrate charge by:

\[
V_{th}(y) = V_{th}(0) + (A_{\text{bulk}} - I W_y)
\]  

(4.3.3)

\[
\begin{align*}
Q_c &= W_{\text{active}} \int_0^{L_{\text{act}}} q_c \, dy = W_{\text{active}} C_{\text{ox}} \int_0^{L_{\text{act}}} (V_{gs} - A_{\text{bulk}} V_y) \, dy \\
Q_g &= W_{\text{active}} \int_0^{L_{\text{act}}} q_g \, dy = W_{\text{active}} C_{\text{ox}} \int_0^{L_{\text{act}}} (V_{gs} + V_{th} - V_{FB} - \phi_s - V_y) \, dy \\
Q_b &= W_{\text{active}} \int_0^{L_{\text{act}}} q_b \, dy = -W_{\text{active}} C_{\text{ox}} \int_0^{L_{\text{act}}} (V_{ih} - V_{FB} - \phi_s - (1 - A_{\text{bulk}}) V_y) \, dy
\end{align*}
\]

Therefore

(4.3.4)

Substituting the following:

\[
dy = \frac{dV_y}{\varepsilon_y}
\]

and

\[
J_{ds} = \frac{\mu_{\text{eff}} C_{\text{ox}}}{L_{\text{active}}} (V_{gs} - \frac{A_{\text{bulk}}}{2} V_{ds}) \varepsilon_y = \mu_{\text{eff}} C_{\text{ox}} (V_{gs} - A_{\text{bulk}} V_{ds}) \varepsilon_y
\]  

(4.3.5)
Intrinsic Capacitance

into Eq. (4.3.4), we have the following upon integration:

\[
Q_c = -W_{\text{active}} L_{\text{active}} C_{ox} \left( V_{gs} - \frac{A_{\text{bulk}} V_d}{2} \right) + \frac{A_{\text{bulk}} V_d^2}{12 \left( V_{gs} - \frac{A_{\text{bulk}} V_d}{2} \right)}
\]

\[
Q_b = -Q_c - Q_e = Q_{\text{sub0}} + \delta Q_{\text{sub}}
\]

\[
Q_g = -Q_{\text{sub0}} + W_{\text{active}} L_{\text{active}} C_{ox} \left( V_{gs} - \frac{V_d}{2} \right) + \frac{A_{\text{bulk}} V_d^2}{12 \left( V_{gs} - \frac{A_{\text{bulk}} V_d}{2} \right)}
\]

where,

\[
Q_{\text{sub0}} = -W_{\text{active}} L_{\text{active}} \sqrt{2 \varepsilon_{Si} Q^N_b \left( 2 \phi_b - V_{bs} \right)}
\]

\[
\delta Q_{\text{sub}} = W_{\text{active}} L_{\text{active}} C_{ox} \left( \frac{1 - A_{\text{bulk}} V_d}{2} - \frac{(1 - A_{\text{bulk}}) A_{\text{bulk}} V_d^2}{12 \left( V_{active} - \frac{A_{\text{bulk}} V_d}{2} \right)} \right)
\]

The inversion charges are supplied from the source and drain electrodes such that \( Q_{\text{inv}} = Q_S + Q_D \). The ratio of \( Q_D \) and \( Q_S \) is the charge partitioning ratio. Existing charge partitioning schemes are 0/100, 50/50 and 40/60 (\( XPART = 0, 0.5 \) and 1) which are the ratios of \( Q_D \) to \( Q_S \) in the saturation region. We will revisit charge partitioning in Section 4.3.4.

All capacitances are derived from the charges to ensure charge conservation. Since there are 4 nodes, there are altogether 16 components. For each component:
Intrinsic Capacitance

\[ C_{ij} = \frac{\partial Q}{\partial V_j} \]  

(4.3.8)

where \( i \) and \( j \) denote transistor nodes. In addition:

\[ \sum_i C_{ij} = \sum_j C_{ij} = 0 \]

### 4.3.3 Short Channel Model

In deriving the long channel charge model, mobility is assumed to be constant with no velocity saturation. Therefore in the saturation region \((V_{ds} \geq V_{dsat})\), the carrier density at the drain end is zero. Since no channel length modulation is assumed, the channel charge will remain a constant throughout the saturation region. In essence, the channel charge in the saturation region is assumed to be zero. This is a good approximation for long channel devices but fails when \( L_{eff} < 2 \mu m \). If we define a drain bias, \( V_{dsat,cv} \), in which the channel charge becomes a constant, we will find that \( V_{dsat,cv} \) in general is larger than \( V_{dsat} \) but smaller than the long channel \( V_{dsat} \) given by \( V_{gs}/A_{bulk} \) (\( A_{bulk} \) is a parameter modeling the non-uniform substrate charge). However, in the old long channel charge model \( V_{dsat,cv} \) is set to \( V_{gs}/A_{bulk} \) independent of channel length. Consequently, \( C_{ij}/L_{eff} \) also has no channel length dependence (Eqs. (4.3.6), (4.37)). A pseudo short channel modification from the long channel has been used in the past. It involved the parameter \( A_{bulk} \) in the capacitance model which was redefined to be equal to \( V_{gs}/V_{dsat} \), thereby equating \( V_{dsat,cv} \) and \( V_{dsat} \). This
Intrinsic Capacitance

overestimated the effect of velocity saturation and resulted in a smaller channel capacitance.

The difficulty in developing a short channel model lies in calculating the charge in the saturation region. Although current continuity stipulates that the charge density in the saturation region is almost constant, it is difficult to calculate accurately the length of the saturation region. Moreover, due to the exponentially increasing lateral electric field, most of the charge in the saturation region are not controlled by the gate electrode. However, one would expect that the total charge in the channel will exponentially decrease with drain bias. A physical model has been developed to reflect this but will not be presented here. A simpler model is adopted to empirically fit \( V_{\text{dsat,cv}} \) to channel length. Experimentally,

\[
V_{\text{sat, } jv < V_{\text{sat, } cv} < V_{\text{sat, } L_{\text{sat}} = 0}} = \frac{V_{\text{steff, } cv}}{A_{\text{bulk}}}
\]

and \( V_{\text{dsat,cv}} \) is fitted empirically by the following:

\[
V_{\text{dsat,cv}} = \frac{V_{\text{steff, } cv}}{A_{\text{bulk}} \left( 1 + \left( \frac{CLC}{L_{\text{active}}} \right)^{CLE} \right)}
\]

\[
V_{\text{gsteff, } cv} = nV_t \ln \left( 1 + \exp \left( \frac{V_g - V_{th}}{nV_t} \right) \right)
\]
Intrinsic Capacitance

The parameter $A_{bulk}$ can now be substituted by $A_{bulk}'$ in the long channel equation where:

$$A_{bulk}' = A_{bulk0} \left( 1 + \left( \frac{CLC}{L_{active}} \right)^{CLE} \right)$$

By setting $CLC$ to zero, the new model reduces back to the old model. At very short channel lengths where velocity overshoot is prominent, the channel charges is only a weak function of channel length and saturation velocity. The effect of velocity overshoot is minimal and is not implemented into the model.

4.3.4 New Single Equation Formulation

In the old formulation, the capacitance is divided into four regions. There were separate equations modeling the nodal charges in each region. From one region to another the charges were conserved, but not their slopes. Therefore, the capacitances in some of these transitions were discontinuous. In the new model, a single equation is used to model each charge for all regions.

(a) Transition from depletion to inversion region

The biggest discontinuity is the inversion capacitance at threshold voltage. The old model uses a step function and the inversion capacitance changes
Intrinsic Capacitance

abruptly from 0 to $C_{ox}$. Concurrently, since the substrate charge is a constant, the substrate capacitance drops abruptly to 0 at threshold voltage. Both of these effects cause oscillation during circuit simulation. Experimentally, capacitance starts to increase almost quadratically at ~0.2V below threshold voltage and levels off at ~0.3V above threshold voltage. For analog and low power circuits, an accurate capacitance model around the threshold voltage is very important.

The non-abrupt channel inversion capacitance and substrate capacitance model is developed from the new I-V model which uses a single equation to formulate the subthreshold, transition and inversion regions. The new channel inversion charge model can be modified to any charge model by substituting $V_{gt}$ with $V_{gs\text{eff, cv}}$ as in the following:

$$Q_{\text{inv, d}}(V_{gt}) = Q_{\text{inv, d}}(V_{gs\text{eff, cv}})$$

Now,

$$C_{\text{inv, d}}(V_{gt}) = C_{\text{inv, d}}(V_{gs\text{eff, cv}}) \frac{\partial V_{gs}}{\partial V_{gs}}$$

$$C_{\text{inv, d}}(V_{gs\text{eff, cv}}) = C_{\text{inv, d}}(V_{gs\text{eff, cv}}) \left( V_{gs\text{eff, cv}} \right)$$

where,
Intrinsic Capacitance

\[
\frac{\partial V_{gst, cv}}{\partial V_{gs}} = \frac{\exp\left(\frac{V_{gst}}{nV_t}\right)}{1 + \exp\left(\frac{V_{gst}}{nV_t}\right)}
\]

The "inversion" (minority) charge is always non-zero, even in the accumulation region. However, it decreases exponentially with gate bias in the subthreshold region.

(b) Transition from accumulation to depletion region

A parameter \(V_{FB, eff}\) is used to smooth out the transition between accumulation and depletion regions. It affects the accumulation and depletion charges:

\[
V_{FB, eff} = V_{fb} - 0.5\left(V_s + \sqrt{V_s^2 + 4\delta_s V_{fb}}\right) \quad \text{where} \quad V_s = V_{fb} - V_{st} - \delta_s; \quad \delta_s = 0.02
\]

\[
V_{fb} = V_{th} - \phi_s - K_1\sqrt{\phi_s}
\]

\[
Q_{acc} = -W_{active} L_{active} C_{ox} (V_{FB, eff} - V_{fb})
\]

\[
Q_{sub0} = -W_{active} L_{active} C_{ox} \frac{K_1^2}{2} \left(-1 + \sqrt{1 + \frac{4(V_s - V_{FB, eff} - V_{gst, cv} - V_{bseff})}{K_1^2}}\right)
\]
(c) Transition from linear to saturation region

A parameter \(V_{\text{cveff}}\) is used to smooth out the transition between linear and saturation regions. It affects the inversion charge.

\[
V_{\text{cveff}} = V_{\text{dss, cv}} - 0.5\left\{V_4 + \sqrt{V_4^2 + 4\delta_4 V_{\text{dss, cv}}} \right\} \text{ where } V_4 = V_{\text{dss, cv}} - V_{\text{ds}} - \delta_4; \quad \delta_4 = 0.02
\]

\[
Q_{\text{inv}} = -W_{\text{active}} L_{\text{active}} C_{\text{ox}} \left( V_{\text{gsteff}} \frac{A_{\text{bulk}}}{2} V_{\text{cveff}} \right) + \frac{A_{\text{bulk}}^2 V_{\text{cveff}}^2}{12 \left( V_{\text{gsteff}} \frac{A_{\text{bulk}}}{2} V_{\text{cveff}} \right)}
\]

Below is a list of all the three partitioning schemes for the inversion charge:

\[
\delta Q_{\text{sub}} = W_{\text{active}} L_{\text{active}} C_{\text{ox}} \left( \frac{1 - A_{\text{bulk}}}{2} \frac{V_{\text{cveff}}}{V_{\text{cveff}}} - \frac{(1 - A_{\text{bulk}})A_{\text{bulk}}}{12 \left( V_{\text{gsteff}} \frac{A_{\text{bulk}}}{2} V_{\text{cveff}} \right)} \right)
\]

(i) The 50/50 Charge partition

This is the simplest of all partitioning schemes in which the inversion charges are assumed to be contributed equally from the source and drain nodes. Despite its simplicity it is found to approximate the simulation data well.
Intrinsic Capacitance

\[ Q_s = Q_d = 0.5 Q_{\text{inv}} = - \frac{W_{\text{active}} L_{\text{active}} C_{\text{ox}}}{2} \left( V_{g_{\text{stiff, cv}}} \frac{A_{\text{bulk,活跃}}}{2} V_{\text{cutoff}} + \frac{A_{\text{bulk,活跃}}^2 V_{\text{cutoff}}^2}{12 \left( V_{g_{\text{stiff, cv}}} \frac{A_{\text{bulk,活跃}}}{2} V_{\text{cutoff}} \right)^2} \right) \]  

(ii) The 40/60 Channel-charge Partition

This is the most physical model of the three partitioning schemes in which the channel charges are allocated to the source and drain electrodes by assuming a linear dependence to the distance.

\[
\begin{align*}
Q_s &= W_{\text{active}} \int_0^{L_{\text{active}}} q_e \left( 1 - \frac{y}{L_{\text{active}}} \right) \, dy \\
Q_d &= W_{\text{active}} \int_0^{L_{\text{active}}} q_e \frac{y}{L_{\text{active}}} \, dy
\end{align*}
\]

\[ Q = -\frac{W_{\text{active}} L_{\text{active}} C_{\text{ox}}}{2 \left( V_{g_{\text{stiff, cv}}} \frac{A_{\text{bulk,活跃}}}{2} V_{\text{cutoff}} \right)^2} \left( V_{g_{\text{stiff, cv}}}^3 \frac{4}{3} V_{g_{\text{stiff, cv}}}^2 (A_{\text{bulk,活跃}}' V_{\text{cutoff}}) + \frac{2}{3} V_{g_{\text{stiff, cv}}} (A_{\text{bulk,活跃}}' V_{\text{cutoff}})^2 \frac{2}{15} (A_{\text{bulk,活跃}}' V_{\text{cutoff}})^3 \right) \] 

\[ Q_d = -\frac{W_{\text{active}} L_{\text{active}} C_{\text{ox}}}{2 \left( V_{g_{\text{stiff, cv}}} \frac{A_{\text{bulk,活跃}}}{2} V_{\text{cutoff}} \right)^2} \left( V_{g_{\text{stiff, cv}}}^3 \frac{5}{3} V_{g_{\text{stiff, cv}}}^2 (A_{\text{bulk,活跃}}' V_{\text{cutoff}}) + V_{g_{\text{stiff, cv}}} (A_{\text{bulk,活跃}}' V_{\text{cutoff}})^2 \frac{1}{5} (A_{\text{bulk,活跃}}' V_{\text{cutoff}})^3 \right) \]

(iii) The 0/100 Charge Partition
Intrinsic Capacitance

In fast transient simulations, the use of a quasi-static model may result in a large unrealistic drain current spike. This partitioning scheme is developed to artificially suppress the drain current spike by assigning all inversion charges in the saturation region to the source electrode. Notice that this charge partitioning scheme will still give drain current spikes in the linear region and aggravate the source current spike problem.

\[
Q_s = -W_{active} L_{active} C_{ox} \left( \frac{V_{gsteff, cv}}{2} + \frac{A_{bulk} V_{cveff}}{4} - \frac{(A_{bulk} V_{cveff})^2}{24 \left( V_{gsteff, cv} - \frac{A_{bulk} V_{cveff}}{2} \right)} \right) \tag{4.3.26}
\]

\[
Q_d = -W_{active} L_{active} C_{ox} \left( \frac{V_{gsteff, cv}}{2} - \frac{3A_{bulk} V_{cveff}}{4} + \frac{(A_{bulk} V_{cveff})^2}{8 \left( V_{gsteff, cv} - \frac{A_{bulk} V_{cveff}}{2} \right)} \right) \tag{4.3.27}
\]

(d) Bias dependent threshold voltage effects on capacitance

The effects of body bias and DIBL is included in the capacitance model by modifying the threshold voltage to make it consistent with the I-V model. In deriving the capacitances additional differentiations are need to account for the dependence of threshold voltage on drain and substrate biases. The intrinsic capacitances can be derived based on the above charge equations.
4.4 Extrinsic Capacitance: Fringing Capacitance

The fringing capacitance consists of a bias independent outer fringing capacitance and a bias dependent inner fringing capacitance. In the present release only the bias independent outer fringing capacitance is implemented. Experimentally, it is virtually impossible to separate this capacitance with the overlap capacitance. Nonetheless, the outer fringing capacitance can be theoretically calculated:

\[ CF = \frac{e_{ox}}{\alpha} \ln \left( 1 + \frac{I_{poly}}{I_{ox}} \right) \quad \alpha = \frac{\pi}{2} \]

If \( CF \) is not given in the above expression, it can be calculated by:
Extrinsic Capacitance: Overlap Capacitance

Extrinsic Capacitance: Overlap Capacitance

A accurate model for the overlap capacitance is essential. This is especially true for the drain side where the effect of the capacitance is amplified by the transistor gain. In old capacitance models this capacitance is assumed to be bias independent. However, experimental data show that the overlap capacitance changes with gate to source and gate to drain biases. In a single drain structure or the heavily doped S/D to gate overlap region in a LDD structure the bias dependence is the result of depleting the surface of the source and drain regions. Since the modulation is expected to be very small we can model this region with a constant capacitance. However in LDD MOSFETs a substantial portion of the LDD region can be depleted, both in the vertical and lateral directions. This can lead to a large reduction of overlap capacitance. This LDD region can be in accumulation or depletion. We use a single equation for both regions by using such smoothing parameters as $V_{gs,overlap}$ and $V_{gd,overlap}$ for the source and drain side, respectively. Unlike the case with the intrinsic capacitance, the overlap capacitances are reciprocal. In other words, $C_{gs,overlap} = C_{sg,overlap}$ and $C_{gd,overlap} = C_{dg,overlap}$.

(a) Source Overlap Charge
Extrinsic Capacitance: Overlap Capacitance

\[
\frac{Q_{\text{overlap}, s}}{W_{\text{active}}} = \text{CGSO}_V g_s + \text{CGS}_1 \left\{ V_{g_s} - V_{g_s, \text{overlap}} + \frac{\text{CKAPPA}}{2} \left( -1 + \sqrt{1 + \frac{4 V_{g_s, \text{overlap}}}{\text{CKAPPA}}} \right) \right\}
\]  

(4.5.1)

\[
V_{g_s, \text{overlap}} = \frac{1}{2} \left\{ \left( V_{g_s} - \delta_1 \right) + \sqrt{\left( V_{g_s} - \delta_1 \right)^2 - 4 \delta_1} \right\} \quad \text{where} \quad \delta_1 = 0.02
\]  

(4.5.2)

where \( \text{CKAPPA} \) is a user input parameter. If the average doping in the LDD region is known, \( \text{CKAPPA} \) can be calculated by:

\[
\frac{2e_g q N_{LDD}}{C_{ox}^2}
\]

The typical value for \( N_{LDD} \) is 5\( \times \)10\(^{17} \) cm\(^{-3} \).

(b) Drain Overlap Charge

\[
\frac{Q_{\text{overlap}, d}}{W_{\text{active}}} = \text{CGD}_0 V_{g_d} + \text{CGD}_1 \left\{ V_{g_d} - V_{g_d, \text{overlap}} + \frac{\text{CKAPPA}}{2} \left( -1 + \sqrt{1 + \frac{4 V_{g_d, \text{overlap}}}{\text{CKAPPA}}} \right) \right\}
\]  

(4.5.3)

\[
V_{g_d, \text{overlap}} = \frac{1}{2} \left\{ \left( V_{g_d} - \delta_2 \right) + \sqrt{\left( V_{g_d} - \delta_2 \right)^2 - 4 \delta_2} \right\} \quad \text{where} \quad \delta_2 = 0.02
\]  

(4.5.4)

(c) Gate Overlap Charge

\[
Q_{\text{overlap}, g} = -\left( Q_{\text{overlap}, s} + Q_{\text{overlap}, d} \right)
\]  

(4.5.5)
Graphical Results

In the above expressions, if \( CGS0 \) and \( CGD0 \) (the heavily doped S/D region to gate overlap capacitance) are not given, they are calculated according to the following:

\[
\begin{align*}
CGS0 &= (DLC \times Cox) - CGS1 \quad \text{(if DLC is given and DLC > 0)} \\
CGS0 &= 0 \quad \text{(if the previously calculated CGSO is less than 0)} \\
CGS0 &= 0.6 \times j \times Cox \quad \text{(otherwise)}
\end{align*}
\]

\[
\begin{align*}
CGD0 &= (DLC \times Cox) - CGD1 \quad \text{(if DLC is given and DLC > CGD1/Cox)} \\
CGD0 &= 0 \quad \text{(if previously calculated CDGO is less than 0)} \\
CGD0 &= 0.6 \times j \times Cox \quad \text{(otherwise)}
\end{align*}
\]

4.6 Graphical Results

Figures 4-1 through 4-4 are included to show the good behavior of the expressions introduced in this chapter. Note that both capacitance and charge are continuous under both \( Vds \) bias ranges (linear to saturation) and \( Vgs \) bias conditions (subthreshold to strong inversion). Figure 4-5 is also included to highlight the \( VFB_{eff} \) equation used to ensure this continuity.
Graphical Results

Figure 4-1. Normalized charge versus Vds bias.

Figure 4-2. Normalized capacitance versus Vds bias.

BSIM3v3 Manual Copyright © 1995, 1996, UC Berkeley
Figure 4-3. Normalized charge versus Vgs bias.

Figure 4-4. Normalized capacitance versus Vgs bias.
Graphical Results

Figure 4-5. Continuity of the $V_{fb_{eff}}$ function.
CHAPTER 5: Non-Quasi Static Model

5.1 Background Information

As the MOS transistor becomes more performance-driven, the need to accurately predict circuit performance operating near device cut-off frequency becomes more essential as well. However, most device models available in circuit simulators such as SPICE fall short this need. They include models which are formulated upon Quasi-Static (QS) assumptions. In other words, the finite charging time for the inversion layer is ignored. When these models are used with the common 40/60 charge partitioning option, unrealistically large drain current spikes frequently occur [31]. In addition, the inability of these models to accurately simulate channel charge re-distribution causes problems in fast switched-capacitor type circuits. Many Non-Quasi-Static (NQS) models have been published, but these models have two shortcomings: 1) they assume, unrealistically, no velocity saturation, and 2) They are complex in their formulations; intuitive insights into NQS effects and solutions are lost. In addition, these models increase circuit simulation times by 4 to 5 times.

5.2 The NQS Model in BSIM3v3

BSIM3v3 includes a physical NQS transient model which alleviates the above problems. Although it is a physical model that takes in account velocity saturation
Model Formulation

effects, it is conceptually simple to understand because its formulation is based on familiar channel relaxation principles.

5.3 Model Formulation

The channel of a MOSFET is analogous to a bias dependent RC distributed transmission line (Figure 5-1a). In the Quasi-Static (QS) approach, the gate capacitor node is lumped with both the external source and drain nodes (Figure 5-1b). This ignores the finite time for the channel charge to build-up. One Non-Quasi-Static (NQS) solution is to represent the channel as \( n \) transistors in series (Figure 5-1c). This model, although accurate, comes at the expense of simulation time. BSIM3v3 uses a more efficient approach formulated from the circuit of Figure 5-1d. This Elmore equivalent circuit models channel charge build-up accurately because it retains the lowest frequency pole of the original RC network (Figure 5-1a). To accommodate this new NQS model, two new parameters are introduced (See Table 5-1).

<table>
<thead>
<tr>
<th>Name</th>
<th>Function</th>
<th>Default</th>
<th>Unit</th>
</tr>
</thead>
<tbody>
<tr>
<td>NQSMOD</td>
<td>Flag for the NQS model</td>
<td>0</td>
<td>(False)</td>
</tr>
<tr>
<td>ELM</td>
<td>Elmore constant of the channel</td>
<td>5</td>
<td>none</td>
</tr>
</tbody>
</table>

Table 5-1. New NQS model parameters.
Figure 5-1. Quasi-Static and Non-Quasi-Static models for SPICE transient analysis.

The NQS model also includes the use of the model parameter Xpart (usually associated with the A.C. model) to control charge partition to the source/drain. In BSIM3v3, the Elmore resistance, $R_{Elmore}$, is calculated from the channel resistance under strong inversion as:

$$R_{Elmore} = \frac{L_{eff}^2}{\varepsilon \mu_{eff} Q_{ch}} \approx \frac{L_{eff}^2}{\varepsilon \mu_{eff} Q_{cheq}}$$

(5.2.1)
where $\varepsilon$ is the Elmore constant of the RC network in the channel with a theoretical value close to 5. $Q_{ch}$ is the actual channel charge in the channel and $Q_{cheq}$ represents the quasi-static equilibrium channel charge. The value $R_{Elmore}C_{Channel}$ is the relaxation time constant for charging and discharging the channel. Under strong inversion, the conduction is mainly due to drift current. As such, the relaxation time constant due to drift current is given by:

$$\tau_{drift} \approx R_{Elmore}C_{ox}W_{eff}L_{eff} \approx \frac{C_{ox}W_{eff}L_{eff}^3}{\varepsilon\mu_{eff}Q_{cheq}}$$

(5.2.2)

Under weak inversion, conduction is mainly due to diffusion current. The relaxation time constant can be approximated by:

$$\tau_{diff} \approx \frac{q(L_{eff}/4)^3}{\mu_{eff}kT}$$

(5.2.3)

The overall relaxation time for channel charging and discharging is given by the combination of both the diffusion and the drift terms:

$$\frac{1}{\tau} = \frac{1}{\tau_{diff}} + \frac{1}{\tau_{drift}}$$

(5.2.4)

Using this relaxation time concept, the NQS transient effect in BSIM3v3 is implemented with the subcircuit given in Figure 5-2. The parameters $X_d$ and $X_s$ are the charge partition allocated to the drain and source and are assigned values of 0.4 and 0.6, respectively.
Model Formulation

The state variable, \( Q_{\text{def}} \), is an additional node created to keep track of the amount of deficit (or surplus) channel charge necessary to achieve equilibrium. \( Q_{\text{def}} \) will decay exponentially into the channel with a bias dependent NQS relaxation time \( \tau \). The derivative of \( Q_{\text{def}} \) with respect to time is the gate charging current. This gate current is partitioned into separate drain and source current components. A complete list of all NQS model equations is provided in the Appendix.

\[
\frac{\partial Q_{\text{cheq}}}{\partial t} = \tau \frac{Q_{\text{def}}}{\tau}
\]

\[
i_d = I_d \left( dc \right) + X_d \frac{Q_{\text{def}}}{\tau}
\]

\[
i_s = -I_d \left( dc \right) + X_s \frac{Q_{\text{def}}}{\tau}
\]

\[X_s + X_d = 1\]

Figure 5-2. NQS subcircuit implementation in BSIM3v3.
CHAPTER 6: Parameter Extraction

Parameter extraction is an important part of model development. Many different extraction methods have been developed [23, 24]. The appropriate methodology depends on the model and on the way the model is used. Based on the properties of the BSIM3v3, a combination of a local optimization and the group device extraction strategy is adopted for parameter extraction.

6.1 Optimization strategy

There are two main, different optimization strategies: global optimization and local optimization. Global optimization relies on the explicit use of a computer to find one set of model parameters which will best fit the available experimental (measured) data. This methodology may give the minimum average error between measured and simulated (calculated) data points, but it also treats each parameter as a "fitting" parameter. Physical parameters extracted in such a manner might yield values that are not consistent with their physical intent.

In local optimization, many parameters are extracted independently of one another. Parameters are extracted from device bias conditions which correspond to dominant physical mechanisms. Parameters which are extracted in this manner might not fit experimental data in all the bias conditions. Nonetheless, these extraction methodologies are developed specifically with respect to a given parameter's physical meaning. If properly executed, it should, overall, predict
device performance quite well. Values extracted in this manner will now have some physical relevance.

6.2 Extraction Strategies

Two different strategies are available for extracting parameters: the single device extraction strategy and group device extraction strategy. In single device extraction strategy, experimental data from a single device is used to extract a complete set of model parameters. This strategy will fit one device very well but will not fit other devices with different geometries. Furthermore, single device extraction strategy cannot guarantee that the extracted parameters are physical. If only one set of channel length and width is used, parameters related to channel length and channel width dependencies cannot be determined.

BSIM3v3 uses group device extraction strategy. This requires measured data from devices with different geometries. All devices are measured under the same bias conditions. The resulting fit might not be absolutely perfect for any single device but will be better for the group of devices under consideration.

6.3 Extraction Procedure

6.3.1 Parameter Extraction Requirements

One large size device and two sets of smaller-sized devices are needed to extract parameters, as shown in Figure 6-1.
device performance quite well. Values extracted in this manner will now have some physical relevance.

6.2 Extraction Strategies

Two different strategies are available for extracting parameters: the single device extraction strategy and group device extraction strategy. In single device extraction strategy, experimental data from a single device is used to extract a complete set of model parameters. This strategy will fit one device very well but will not fit other devices with different geometries. Furthermore, single device extraction strategy can not guarantee that the extracted parameters are physical. If only one set of channel length and width is used, parameters related to channel length and channel width dependencies can not be determined.

BSIM3v3 uses group device extraction strategy. This requires measured data from devices with different geometries. All devices are measured under the same bias conditions. The resulting fit might not be absolutely perfect for any single device but will be better for the group of devices under consideration.

6.3 Extraction Procedure

6.3.1 Parameter Extraction Requirements

One large size device and two sets of smaller-sized devices are needed to extract parameters, as shown in Figure 6-1.
Extraction Procedure

The large-sized device \( (W \geq 10\mu m, L \geq 10\mu m) \) is used to extract parameters which are independent of short/narrow channel effects and parasitic resistance. Specifically, these are: mobility, the large-sized device threshold voltage \( V_{th,ld} \), and the body effect coefficients \( K_1 \) and \( K_2 \) which depend on the vertical doping concentration distribution. The set of devices with a fixed large channel width but different channel lengths are used to extract parameters which are related to the short channel effects. Similarly, the set of devices with a fixed, long channel length but different channel widths are used to extract parameters which are related to narrow width.

Figure 6-1. Device geometries used for parameter extraction
Extraction Procedure

effects. Regardless of device geometry, each device will have to be measured under four, distinct bias conditions.

1) \(I_{ds} \text{ vs. } V_{gs} @ V_{ds} = 0.05V \) with different \(V_{bs}\).

2) \(I_{ds} \text{ vs. } V_{gs} \text{ @ } V_{bs} = 0V \) with different \(V_{gs}\).

3) \(I_{ds} \text{ vs. } V_{gs} @ V_{ds} = V_{dd} \) with different \(V_{bs}\). \((V_{dd} \text{ is the maximum drain voltage})\)

4) \(I_{ds} \text{ vs. } V_{gs} @ V_{bs} = V_{bb} \) with different \(V_{gs}\). \((V_{bb} \text{ is the maximum body bias})\)

6.3.2 Optimization

The optimization process recommended for BSIM3v3 is a combination of Newton-Raphson's iteration and linear-squares fit of either one, two, or three variables. This methodology was discussed by M. C. Jeng [18]. A flow chart of this optimization process is shown in Figure 6-2. The model equation is first arranged in a form suitable for Newton-Raphson's iteration as shown in Eq. (6.3.1):

\[
f_{\text{exp}}(P_{10}, P_{20}, P_{30}) - f_{\text{sim}}(P_{1}^{(m)}, P_{2}^{(m)}, P_{3}^{(m)}) = \frac{\partial f_{\text{sim}}}{\partial P_{1}} \Delta P_{1}^{m} + \frac{\partial f_{\text{sim}}}{\partial P_{2}} \Delta P_{2}^{m} + \frac{\partial f_{\text{sim}}}{\partial P_{3}} \Delta P_{3}^{m}
\]

(6.3.1)

The variable \(f_{\text{sim}}()\) is the objective function to be optimized. The variable \(f_{\text{exp}}()\) stands for the experimental data. \(P_{10}, P_{20}, \text{ and } P_{30}\) represent the desired extracted parameter values. \(P_{1}^{(m)}, P_{2}^{(m)}, \text{ and } P_{3}^{(m)}\) represent parameter values after the \(m\)th iteration.
To change Eq. (6.3.1) into a form that a linear least-squares fit routine can be use (i.e. in a form of $y = a + bx_1 + cx_2$), both sides of the Eq. (6.3.1) are divided by $\frac{\partial f_{sim}}{\partial P_I}$. This gives the change in $P_I$, $\Delta P_I^{(m)}$, for the next iteration such that:

$$\frac{\Delta P_i}{P_i^{(m)}} < \delta$$


Extraction Procedure

\[ p^{(m+1)}_i = p^{(m)}_i + \Delta p^{(m)}_i \]  

(6.3.2)

where \( i = 1, 2, 3 \) for this example. The \((m+1)\) parameter values for \( P_2 \) and \( P_3 \) are obtained in an identical fashion. This process is repeated until the incremental parameter change in parameter values \( \Delta p^{(m)}_i \) are smaller than a pre-determined value. At this point, the parameters \( P_1, P_2, \) and \( P_3 \) have been extracted.

6.3.3 Extraction Routine

Before any model parameters can be extracted, some process parameters have to be provided. They are listed below in Table 6-1:

<table>
<thead>
<tr>
<th>Input Parameters Names</th>
<th>Physical Meaning</th>
</tr>
</thead>
<tbody>
<tr>
<td>( T_{\text{ox}} )</td>
<td>Gate oxide thickness</td>
</tr>
<tr>
<td>( N_{\text{ch}} )</td>
<td>Doping concentration in the channel</td>
</tr>
<tr>
<td>( T )</td>
<td>Temperature at which the data is taken</td>
</tr>
<tr>
<td>( L_{\text{drawn}} )</td>
<td>Mask level channel length</td>
</tr>
<tr>
<td>( W_{\text{drawn}} )</td>
<td>Mask level channel width</td>
</tr>
<tr>
<td>( X_j )</td>
<td>Junction depth</td>
</tr>
</tbody>
</table>

Table 6-1. Prerequisite input parameters prior to extraction process.

The parameters are extracted in the following procedure. These procedures are based on a physical understanding of the model and based on local
Extraction Procedure

optimization. (Note: *Fitting Target Data* refers to measurement data used for model extraction.)

**Step 1**

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Device &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>( V_{th}, K_1, K_2 )</td>
<td>Large Size Device (Large ( W ) &amp; ( L )).</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: ( V_{th}(V_{bs}) )</td>
<td>( I_{ds} ) vs. ( V_{gs} ) @ ( V_{ds} = 0.05V ) at Different ( V_{bs} ).</td>
</tr>
<tr>
<td></td>
<td>Extracted Experimental Data ( V_{th}(V_{bs}) )</td>
</tr>
</tbody>
</table>

**Step 2**

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>( \mu_0, U_a, U_b, U_c )</td>
<td>Large Size Device (Large ( W ) &amp; ( L )).</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: Strong Inversion region ( I_{ds}(V_{gs}, V_{bs}) )</td>
<td>( I_{ds} ) vs. ( V_{gs} ) @ ( V_{ds} = 0.05V ) at Different ( V_{bs} ).</td>
</tr>
</tbody>
</table>

**Step 3**

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>( L_{int}, R_{ds}(R_{dsw} W, V_{bs}) )</td>
<td>One Set of Devices (Large and Fixed ( W ) &amp; Different ( L )).</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: Strong Inversion region ( I_{ds}(V_{gs}, V_{bs}) )</td>
<td>( I_{ds} ) vs. ( V_{gs} ) @ ( V_{ds} = 0.05V ) at Different ( V_{bs} ).</td>
</tr>
</tbody>
</table>
## Extraction Procedure

### Step 4

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>$W_{int}, R_{ds}(R_{dsW}, W, V_{bs})$</td>
<td>One Set of Devices (Large and Fixed $L$ &amp; Different $W$). $I_{ds}$ vs. $V_{gs} @ V_{ds} = 0.05V$ at Different $V_{bs}$</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: Strong Inversion region $I_{ds}(V_{gs}, V_{bs})$</td>
<td></td>
</tr>
</tbody>
</table>

### Step 5

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>$R_{dsW, Prwb}, W_r$</td>
<td>$R_{ds}(R_{dsW}, W, V_{bs})$</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: $R_{ds}(R_{dsW}, W, V_{bs})$</td>
<td></td>
</tr>
</tbody>
</table>

### Step 6

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>$D_{vt0}, D_{vt1}, D_{vt2}, N_{lx}$</td>
<td>One Set of Devices (Large and Fixed $W$ &amp; Different $L$). $V_{th} (V_{bs}, L, W)$</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: $V_{th}(V_{bs}, L, W)$</td>
<td></td>
</tr>
</tbody>
</table>
### Extraction Procedure

#### Step 7

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>Data</td>
<td>One Set of Devices (Large and Fixed L &amp; Different W).</td>
</tr>
<tr>
<td>$D_{vt1w}, D_{vt2w}$</td>
<td>$V_{th}(V_{bs}, L, W)$</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: $V_{th}(V_{bs}, L, W)$</td>
<td></td>
</tr>
</tbody>
</table>

#### Step 8

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>Data</td>
<td>One Set of Devices (Large and Fixed L &amp; Different W).</td>
</tr>
<tr>
<td>$K3, K3b, W_0$</td>
<td>$V_{th}(V_{bs}, L, W)$</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: $V_{th}(V_{bs}, L, W)$</td>
<td></td>
</tr>
</tbody>
</table>

#### Step 9

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>Data</td>
<td>One Set of Devices (Large and Fixed W &amp; Different L).</td>
</tr>
<tr>
<td>$V_{off}, N_{factor}, C_{dso}, C_{dsbc}$</td>
<td>$I_{ds} vs. V_{gs} @ V_{ds} = 0.05V$ at Different $V_{bs}$</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: Subthreshold region $I_{ds}(V_{gs}, V_{bs})$</td>
<td></td>
</tr>
</tbody>
</table>

#### Step 10

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
</table>
Extraction Procedure

<table>
<thead>
<tr>
<th>$C_{ds,0}$</th>
<th>One Set of Devices (Large and Fixed $W$ &amp; Different $L$). $I_{ds}$ vs. $V_{gs} @ V_{ds} = V_{bb}$ at Different $V_{ds}$</th>
</tr>
</thead>
<tbody>
<tr>
<td>Fitting Target Exp. Data: Subthreshold region $I_{ds}(V_{gs}, V_{bs})$</td>
<td></td>
</tr>
</tbody>
</table>

### Step 11

<table>
<thead>
<tr>
<th>extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>$dWb$</td>
<td>One Set of Devices (Large and Fixed $W$ &amp; Different $L$). $I_{ds}$ vs. $V_{gs} @ V_{ds} = 0.05V$ at Different $V_{bs}$</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: Strong Inversion region $I_{ds}(V_{gs}, V_{bs})$</td>
<td></td>
</tr>
</tbody>
</table>

### Step 12

<table>
<thead>
<tr>
<th>extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>$v_{sat}, A_0, A_{gs}$</td>
<td>One Set of Devices (Large and Fixed $W$ &amp; Different $L$). $I_{ds}$ vs. $V_{ds} @ V_{bs} = 0V$ at Different $V_{gs}$</td>
</tr>
<tr>
<td>Fitting Target Exp. Data $I_{sat}(V_{gs}, V_{bs})/W$</td>
<td></td>
</tr>
<tr>
<td>$A_1, A_2$ (PMOS Only)</td>
<td></td>
</tr>
<tr>
<td>Fitting Target Exp. Data $V_{asx}(V_{gs})$</td>
<td></td>
</tr>
</tbody>
</table>

### Step 13

<table>
<thead>
<tr>
<th>extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
</table>
### Extraction Procedure

<table>
<thead>
<tr>
<th>$B_0$, $B_1$</th>
<th>Fitting Target Exp. Data: $I_{sd}(V_{gs}, V_{bs})/W$</th>
<th>One Set of Devices (Large and Fixed $L$ &amp; Different $W$). $I_{ds}$ vs. $V_{ds} @ V_{bs} = 0V$ at Different $V_{gs}$</th>
</tr>
</thead>
</table>

**Step 14**

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>$dW_g$</td>
<td>One Set of Devices (Large and Fixed $L$ &amp; Different $W$). $I_{ds}$ vs. $V_{ds} @ V_{bs} = 0V$ at Different $V_{gs}$</td>
</tr>
<tr>
<td>$I_{sd}(V_{gs}, V_{bs})/W$</td>
<td></td>
</tr>
</tbody>
</table>

**Step 15**

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>$P_{sbe1}, P_{sbe2}$</td>
<td>One Set of Devices (Large and Fixed $W$ &amp; Different $L$). $I_{ds}$ vs. $V_{ds} @ V_{bs} = 0V$ at Different $V_{gs}$</td>
</tr>
<tr>
<td>$R_{out}(V_{gs}, V_{ds})$</td>
<td></td>
</tr>
</tbody>
</table>

**Step 16**

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>$P_{clm} (D_{out}, P_{diblc1}, P_{diblc2}, L), P_{avg}$</td>
<td>One Set of Devices (Large and Fixed $W$ &amp; Different $L$). $I_{ds}$ vs. $V_{ds} @ V_{bs} = 0V$ at Different $V_{gs}$</td>
</tr>
<tr>
<td>$R_{out}(V_{gs}, V_{ds})$</td>
<td></td>
</tr>
</tbody>
</table>
### Extraction Procedure

#### Step 17

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>$D_{\text{rain}}, P_{\text{dibl1}}, P_{\text{dibl2}}$</td>
<td>One Set of Devices (Large and Fixed $W$ &amp; Different $L$). $\theta(D_{\text{rain}}, P_{\text{dibl1}}, P_{\text{dibl2}}, L)$</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: $\theta(D_{\text{rain}}, P_{\text{dibl1}}, P_{\text{dibl2}}, L)$</td>
<td></td>
</tr>
</tbody>
</table>

#### Step 18

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>$P_{\text{dibl1b}}$</td>
<td>One Set of Devices (Large and Fixed $W$ &amp; Different $L$). $I_{ds}$ vs. $V_{gs}$ @ fixed $V_{gs}$ at Different $V_{bs}$</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: $\theta(D_{\text{rain}}, P_{\text{dibl1}}, P_{\text{dibl2}}, L, V_{bs})$</td>
<td></td>
</tr>
</tbody>
</table>

#### Step 19

<table>
<thead>
<tr>
<th>Extracted Parameters &amp; Fitting Target Data</th>
<th>Devices &amp; Experimental Data</th>
</tr>
</thead>
<tbody>
<tr>
<td>$\theta_{\text{dibl}}(E_{ta0}, E_{tab}, D_{sub}, L)$</td>
<td>One Set of Devices (Large and Fixed $W$ &amp; Different $L$). $I_{ds}$ vs. $V_{gs}$ @ $V_{ds} = V_{dd}$ at Different $V_{bs}$</td>
</tr>
<tr>
<td>Fitting Target Exp. Data: Subthreshold region $I_{ds}(V_{gs}, V_{bs})$</td>
<td></td>
</tr>
</tbody>
</table>
### Step 20

**Extracted Parameters & Fitting Target Data**

<table>
<thead>
<tr>
<th>$E_{ta0}$, $E_{tab}$, $D_{sub}$</th>
</tr>
</thead>
</table>

**Fitting Target Exp. Data:**

- $\theta_{dib}(E_{ta0}, E_{tab}, L)$
- $I_{ds}$ vs. $V_{gs}$ @ $V_{ds} = V_{dd}$ at Different $V_{bs}$

**Devices & Experimental Data**

- One Set of Devices (Large and Fixed $W$ & Different $L$)

### Step 21

**Extracted Parameters & Fitting Target Data**

<table>
<thead>
<tr>
<th>$K_{eta}$</th>
</tr>
</thead>
</table>

**Fitting Target Exp. Data:**

- $I_{sd}(V_{gs}, V_{bs})/W$
- $I_{ds}$ vs. $V_{ds}$ @ $V_{bs} = V_{bb}$ at Different $V_{gs}$

**Devices & Experimental Data**

- One Set of Devices (Large and Fixed $W$ & Different $L$)

### Step 22

**Extracted Parameters & Fitting Target Data**

<table>
<thead>
<tr>
<th>$\alpha$, $\beta$</th>
</tr>
</thead>
</table>

**Fitting Target Exp. Data:**

- $I_{sd}(V_{gs}, V_{bs})/W$
- $I_{ds}$ vs. $V_{ds}$ @ $V_{bs} = V_{bb}$ at Different $V_{ds}$

**Devices & Experimental Data**

- One Set of Devices (Large and Fixed $W$ & Different $L$)

---

BSIM3v3 Manual Copyright © 1995, 1996, UC Berkeley  
6-13
6.4 Notes on Parameter Extraction

6.4.1 Parameters with Special Notes

Below is a list of model parameters which have special notes for parameter extraction.

<table>
<thead>
<tr>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default Value</th>
<th>Unit</th>
<th>Notes</th>
</tr>
</thead>
<tbody>
<tr>
<td>vth0</td>
<td>Threshold voltage for large W and L device @ Vbs=0V</td>
<td>0.7 (NMOS)</td>
<td>V</td>
<td>nI-1</td>
</tr>
<tr>
<td></td>
<td></td>
<td>-0.7 (PMOS)</td>
<td></td>
<td></td>
</tr>
<tr>
<td>k1</td>
<td>First order body effect coefficient</td>
<td>0.5</td>
<td>V(^{1/2})</td>
<td>nI-2</td>
</tr>
<tr>
<td>k2</td>
<td>Second order body effect coefficient</td>
<td>0</td>
<td>none</td>
<td>nI-2</td>
</tr>
<tr>
<td>vbm</td>
<td>Maximum applied body bias</td>
<td>-3</td>
<td>V</td>
<td>nI-2</td>
</tr>
<tr>
<td>nch</td>
<td>Channel doping concentration</td>
<td>1.7E17</td>
<td>1/cm(^3)</td>
<td>nI-3</td>
</tr>
<tr>
<td>gamma1</td>
<td>Body-effect coefficient near interface</td>
<td>calculated</td>
<td>V(^{1/2})</td>
<td>nI-4</td>
</tr>
<tr>
<td>gamma2</td>
<td>Body-effect coefficient in the bulk</td>
<td>calculated</td>
<td>V(^{1/2})</td>
<td>nI-5</td>
</tr>
<tr>
<td>vbx</td>
<td>Vbs at which the depletion width equals xt</td>
<td>calculated</td>
<td>V</td>
<td>nI-6</td>
</tr>
<tr>
<td>cgso</td>
<td>Non-LDD source-gate overlap capacitance per channel length</td>
<td>calculated</td>
<td>F/m</td>
<td>nC-1</td>
</tr>
<tr>
<td>cgdo</td>
<td>Non-Ldd drain-gate overlap capacitance per channel length</td>
<td>calculated</td>
<td>F/m</td>
<td>nC-2</td>
</tr>
<tr>
<td>cf</td>
<td>Fringing field capacitance</td>
<td>calculated</td>
<td>F/m</td>
<td>nC-3</td>
</tr>
</tbody>
</table>

Table 6-2. Parameters with notes for extraction.
6.4.2 Explanation of Notes

**nI-1.** If $V_{th0}$ is not specified, it is calculated using:

$$V_{th0} = V_{FB} + \phi + K_1 \sqrt{\phi}$$

where $V_{FB} = -1.0$. If $V_{th0}$ is specified, $V_{FB}$ is calculated using

$$V_{FB} = V_{th0} - \phi - K_1 \sqrt{\phi}$$

**nI-2.** If $k1$ and $k2$ are not given, they are calculated using:

$$K_1 = \gamma_2 - 2K_2 \sqrt{\phi - V_{bm}}$$

$$K_2 = \frac{(\gamma_1 - \gamma_2)(\sqrt{\phi - V_{bm}} - \sqrt{\phi})}{2(\sqrt{\phi - V_{bm}} - \sqrt{\phi} + V_{bm})}$$

where the parameter $\phi$ is calculated using:

$$\phi_s = 2v_{tm0} \ln\left(\frac{Nch}{ni}\right)$$

$$v_{tm0} = \frac{k_BT_{nom}}{q}$$
Notes on Parameter Extraction

\[ n_i = 1.45 \times 10^{10} \left( \frac{T_{\text{nom}}}{300.15} \right)^{1.5} \exp \left( 21.5565981 - \frac{E_{g0}}{2v_{m0}} \right) \]

\[ E_{g0} = 1.16 - \frac{7.02 \times 10^{-4} T_{\text{nom}}^2}{T_{\text{nom}} + 1108} \]

where \( E_{g0} \) is the energy bandgap at temperature \( T_{\text{nom}} \).

**nI-3.** If \( n_{\text{ch}} \) is not given and \( \gamma_1 \) is given, \( n_{\text{ch}} \) is calculated from:

\[ N_{\text{ch}} = \frac{\gamma_1^2 C_{\alpha}^2}{2q\varepsilon_{\text{si}}} \]

If both \( \gamma_1 \) and \( n_{\text{ch}} \) are not given, \( n_{\text{ch}} \) defaults to 1.7e23 1/m\(^3\) and \( \gamma_1 \) is calculated from \( n_{\text{ch}} \).

**nI-4.** If \( \gamma_1 \) is not given, it is calculated using:

\[ \gamma_1 = \frac{\sqrt{2q\varepsilon_{\text{si}} N_{\text{ch}}}}{C_{\alpha}} \]

**nI-5.** If \( \gamma_2 \) is not given, it is calculated using:

\[ \gamma_2 = \frac{\sqrt{2q\varepsilon_{\text{si}} N_{\text{sub}}}}{C_{\alpha}} \]
nI-6. If vbx is not given, it is calculated using:

\[ V_{bx} = \phi - \frac{qN_cX_i^2}{2\varepsilon_{si}} \]

nC-1. If cgso is not given then it is calculated using:

if (dlc is given and is greater 0) then,

\[ cgso = p1 = (dlc*cox) - cgsl \]

if (the previously calculated cgso <0), then

\[ cgso=0 \]

else \( cgso = 0.6 \times j*cox \)

nC-2. If cgdo is not given then it is calculated using:

if (dlc is given and is greater than 0) then,

\[ cgdo = p2 = (dlc*cox) - cgdl \]

if (the previously calculated cgdo <0), then

\[ cgdo=0 \]

else \( cgdo = 0.6 \times j*cox \)
nC-3. If cf is not given then it is calculated using:

$$CF = \frac{2e_{ox}}{\pi} \ln \left( 1 + \frac{4 \times 10^{-7}}{Tox} \right)$$
CHAPTER 7: Benchmark Test Results

A series of tests [26] have been performed on BSIM3v3 to check its robustness (lack of discontinuities), accuracy, and performance. Although all benchmark test results could not be included in this chapter, the most important ones will be presented in this chapter for a 0.5μm, 90 Angstrom, 3.3V technology.

7.1 Benchmark Test Types

Table 7-1 lists the various benchmark tests and its associated figure number included in this section. Notice that for each plot, smooth transitions are apparent for current, transconductance, and source to drain resistance for all transition regions regardless of bias conditions.

<table>
<thead>
<tr>
<th>Device Size</th>
<th>Bias Conditions</th>
<th>Notes</th>
<th>Figure Number</th>
</tr>
</thead>
<tbody>
<tr>
<td>W/L=20/5</td>
<td>Ids vs. Vgs @ Vbs=0V; Vds=0.05, 3.3V</td>
<td>Log scale</td>
<td>7-1</td>
</tr>
<tr>
<td>W/L=20/5</td>
<td>Ids vs. Vgs @ Vbs=0V; Vds=0.05, 3.3V</td>
<td>Linear scale</td>
<td>7-2</td>
</tr>
<tr>
<td>W/L=20/0.5</td>
<td>Ids vs. Vgs @ Vbs=0V; Vds=0.05, 3.3V</td>
<td>Log scale</td>
<td>7-3</td>
</tr>
<tr>
<td>W/L=20/0.5</td>
<td>Ids vs. Vgs @ Vbs=0V; Vds=0.05, 3.3V</td>
<td>Linear scale</td>
<td>7-4</td>
</tr>
<tr>
<td>W/L=20/5</td>
<td>Ids vs. Vgs @ Vds=0.05V; Vbs=0 to -3.3V</td>
<td>Log scale</td>
<td>7-5</td>
</tr>
<tr>
<td>W/L=20/5</td>
<td>Ids vs. Vgs @ Vds=0.05V; Vbs=0 to -3.3V; W/L=20/5</td>
<td>Linear scale</td>
<td>7-6</td>
</tr>
<tr>
<td>W/L=20/0.5</td>
<td>Ids vs. Vgs @ Vds=0.05V; Vbs=0 to -3.3V</td>
<td>Log scale</td>
<td>7-7</td>
</tr>
</tbody>
</table>
### Benchmark Test Results (Figures)

<table>
<thead>
<tr>
<th>Device Size</th>
<th>Bias Conditions</th>
<th>Notes</th>
<th>Figure Number</th>
</tr>
</thead>
<tbody>
<tr>
<td>W/L=20/0.5</td>
<td>$I_{ds} \text{ vs. } V_{gs} @ V_{ds}=0.05V; V_{bs}=0 \text{ to } -3.3V$</td>
<td>Linear scale</td>
<td>7-8</td>
</tr>
<tr>
<td>W/L=20/5</td>
<td>$G_{m}/I_{ds} \text{ vs. } V_{gs} @ V_{ds}=0.05V, 3-3V; \ V_{bs}=0V$</td>
<td>Linear scale</td>
<td>7-9</td>
</tr>
<tr>
<td>W/L=20/0.5</td>
<td>$G_{m}/I_{ds} \text{ vs. } V_{gs} @ V_{ds}=0.05V, 3-3V; \ V_{bs}=0V$</td>
<td>Linear scale</td>
<td>7-10</td>
</tr>
<tr>
<td>W/L=20/5</td>
<td>$G_{m}/I_{ds} \text{ vs. } V_{gs} @ V_{ds}=0.05V, V_{bs}=0V \text{ to } -3.3V$</td>
<td>Linear scale</td>
<td>7-11</td>
</tr>
<tr>
<td>W/L=20/0.5</td>
<td>$G_{m}/I_{ds} \text{ vs. } V_{gs} @ V_{ds}=0.05V; V_{bs}=0V \text{ to } -3.3V$</td>
<td>Linear scale</td>
<td>7-12</td>
</tr>
<tr>
<td>W/L=20/0.5</td>
<td>$I_{ds} \text{ vs. } V_{ds} @ V_{bs}=0V; V_{gs}=0.5V, 0.55V, 0.6V$</td>
<td>BSIM3 Version 2.0 vs. BSIM3v3</td>
<td>7-13</td>
</tr>
<tr>
<td>W/L=20/5</td>
<td>$I_{ds} \text{ vs. } V_{ds} @ V_{bs}=0V; V_{gs}=1.15V \text{ to } 3.3V$</td>
<td>Linear scale</td>
<td>7-14</td>
</tr>
<tr>
<td>W/L=20/0.5</td>
<td>$I_{ds} \text{ vs. } V_{ds} @ V_{bs}=0V; V_{gs}=1.084V \text{ to } 3.3V$</td>
<td>Linear scale</td>
<td>7-15</td>
</tr>
<tr>
<td>W/L=20/0.5</td>
<td>$R_{out} \text{ vs. } V_{ds} @ V_{bs}=0V; V_{gs}=1.084V \text{ to } 3.3V$</td>
<td>Linear scale</td>
<td>7-16</td>
</tr>
</tbody>
</table>

Table 7-1. Benchmark tests.

### 7.2 Benchmark Test Results (Figures)

All of the figures listed in Table 7-1 will now be listed in order. Unless indicated otherwise, symbols represent actual data and lines represent the results of BSIM3v3 calculations. All of these plots serve to demonstrate the robustness and continuous behavior of the unified model expression for not only $I_{ds}$ but $G_{m}$, $G_{m}/I_{ds}$, and $R_{out}$ as well.
Figure 7-1. Continuity from subthreshold to strong inversion (log scale).

Figure 7-2. Continuity from subthreshold to strong inversion (linear scale).
Figure 7-3. Same as Figure 7-1 but for short channel device.

Figure 7-4. Same as Figure 7-2 but for short channel device.
CHAPTER 8: Noise Model

8.1 Flicker Noise

8.1.1 Parameters

There exists two models for flicker noise. One is called as Spice2 flicker noise model, another one is called as BSIM3 flicker noise model [33,34].

The parameters in the models are listed in Table 8-1.

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
</tr>
</thead>
<tbody>
<tr>
<td>Noia</td>
<td>noia</td>
<td>Noise parameter A</td>
<td>(NMOS) 1e20</td>
<td>none</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>(PMOS) 9.9e18</td>
<td></td>
</tr>
<tr>
<td>Noib</td>
<td>noib</td>
<td>Noise parameter B</td>
<td>(NMOS) 5e4</td>
<td>none</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>(PMOS) 2.4e3</td>
<td></td>
</tr>
<tr>
<td>Noic</td>
<td>noic</td>
<td>Noise parameter C</td>
<td>(NMOS) -1.4e-12</td>
<td>none</td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>(PMOS) 1.4e-12</td>
<td></td>
</tr>
<tr>
<td>Em</td>
<td>em</td>
<td>Saturation field</td>
<td>4.1e7</td>
<td>V/m</td>
</tr>
<tr>
<td>Af</td>
<td>af</td>
<td>Frequency exponent</td>
<td>1</td>
<td>none</td>
</tr>
<tr>
<td>Ef</td>
<td>ef</td>
<td>Flicker exponent</td>
<td>1</td>
<td>none</td>
</tr>
<tr>
<td>Kf</td>
<td>kf</td>
<td>Flicker noise parameter</td>
<td>0</td>
<td>none</td>
</tr>
</tbody>
</table>

Table 8-1. Flicker Noise Model Parameters.
8.1.2 Expressions

1. For Spice2 model

\[
Flicker\ Noise = \frac{K_d a_{\text{ref}}}{C_\text{ox} L_\text{eff}^2 f_{\text{eff}}^2}
\]  
(8.1a)

2. For BSIM3v3 model

1.1) If \(V_{gs} > V_{th} + 0.1\):

\[
Flicker\ Noise = \frac{v_n q^2 I_{ds\text{eff}}}{f_{\text{eff}} L_\text{eff}^2 C_\text{ox} 10^8} \left[ N_{oa} \log\left( \frac{N_0 + 2 \times 10^{14}}{N_l + 2 \times 10^{14}} \right) + N_{oib}(N_0 - N_l) \right] + 0.5 N_{oic}(N_0^2 - N_l^2)
\]  
\[+ \frac{v_n I_{ds}^2 \Delta L_{\text{clm}}}{f_{\text{eff}} L_\text{eff}^2 W_{\text{eff}} C_\text{ox} 10^8} \frac{N_{oa} + N_{oib} N_l + N_{oic} N_l^2}{(N_l + 2 \times 10^{14})^2}
\]

where \(V_{tn}\) is the thermal voltage, \(\mu_{\text{eff}}\) is the effective mobility at the given bias condition, \(L_{\text{eff}}\) and \(W_{\text{eff}}\) are the effective channel length and width, respectively. The parameter \(N_0\) is the charge density at the source given by:

\[
N_0 = \frac{C_\text{ox} (V_{GS} - V_{TH})}{q}
\]  
(8.2)

The parameter \(N_l\) is the charge density at the drain given by:

\[
N_l = \frac{C_\text{ox} (V_{GS} - V_{TH} - V_{DS'})}{q}
\]  
\[V_{DS'} = \text{MIN}(V_{DS}, V_{DSAT})
\]

\(\Delta L_{\text{clm}}\) refers to channel length reduction due to CLM and is given by:
\[ \Delta L_{clm} = \begin{cases} \text{Litl} \times \log \left( \frac{L_{it}}{E_{sat}} \right) + E_{m} & \text{if } V_{DS} > V_{DSAT} \\ 0 & \text{otherwise} \end{cases} \]

\[ E_{sat} = \frac{2 \times V_{sat}}{u_{eff}} \]

2. Otherwise,

\[ FlickerNoise = \frac{S_{limit} \times S_{wi}}{S_{limit} + S_{wi}} \]

Where, \( S_{limit} \) is the flicker noise calculated at \( V_{gs} = V_{th} + 0.1 \) and \( S_{wi} \) is given by:

\[ S_{wi} = \frac{N_{oia}V_{lds}^2}{W_{eff}L_{eff} \times 4 \times 10^{36}} \]

### 8.2 Channel Thermal Noise

There also exists two models for channel thermal noise. One is called as Spice2 thermal noise model. Another one is called as BSIM3v3 thermal noise model. Each of these can be toggled by the \texttt{noimod} flag.

1. For Spice2 thermal noise model
Noise Model Flag

\[ \frac{8KT}{3} (gm + gds + gmb) \]

2. For BSIM3v3 thermal noise model

\[ \frac{4KT|Q_{inv}|}{L_{eff}^2} \]

\[ Q_{inv} = -W_{eff} L_{eff} C_{ox} V_{sneff} (1 - \frac{A_{bulk}}{2(V_{sneff} + 2V_t)} V_{sneff}) \]

The derivation for this last thermal noise expression is based on the noise model found in [35].

8.3 Noise Model Flag

The `noimod` flag is used to select different combination of flicker and thermal noise models discussed above, as given in Table 8.2.

<table>
<thead>
<tr>
<th>noimod flag</th>
<th>Flicker noise model</th>
<th>Thermal noise model</th>
</tr>
</thead>
<tbody>
<tr>
<td>1</td>
<td>Spice2</td>
<td>Spice2</td>
</tr>
<tr>
<td>2</td>
<td>BSIM3v3</td>
<td>BSIM3v3</td>
</tr>
<tr>
<td>3</td>
<td>BSIM3v3</td>
<td>Spice2</td>
</tr>
<tr>
<td>4</td>
<td>Spice2</td>
<td>BSIM3v3</td>
</tr>
</tbody>
</table>

Table 8-2. Noimod flag for different noise models
CHAPTER 9: MOS Diode Model

9.1 MOS Diode DC Current Model

9.1.1 Model Equations

9.1.1.1 Source/bulk Diode

If the saturation current Isbs is larger than zero, the following equations is used to calculate the source/bulk diode current:

\[ V_{bs} < 0.5V \]

\[ I_{bs} = I_{bs}[\exp\left(\frac{V_{bs}}{N_{vm}}\right) - 1] + G_{\min} V_{bs} \]  

\[ V_{bs} > 0.5V \]

\[ I_{bs} = I_{bs}[\exp\left(\frac{0.5}{N_{vm}}\right) - 1] + \frac{I_{bs}}{N_{vm}} \exp\left(\frac{0.5}{N_{vm}}\right)(V_{bs} - 0.5) + G_{\min} V_{bs} \]

Where \( N_{vm} = n_jK_T/q \), \( n_j \) is the emission coefficient of the source junction, and Isbs is calculated by

\[ I_{bs} = A_s J_s + P_s J_{sw} \]
where $J_s$ is the saturation current density of the source/bulk diode, $A_S$ is the area of the source junction. $J_{ssw}$ is the sidewall saturation current density of the source/bulk diode, $P_s$ is the perimeter of the source junction. $J_s$ and $J_{ssw}$ are functions of temperature and can be described by:

\begin{align}
J_s & = J_{s0} \exp\left[\frac{E_{\phi0} - \frac{E_g}{V_m} + XTln\left(\frac{T}{T_{nom}}\right)}{N_j} \right] \\
J_{ssw} & = J_{ss0} \exp\left[\frac{E_{\phi0} - \frac{E_g}{V_m} + XTln\left(\frac{T}{T_{nom}}\right)}{N_j} \right] \\
E_g & = 1.16 - \frac{7.02e^{-4}T^2}{T + 1108.0}
\end{align}

where $J_{s0}$ is the saturation current density at $T_{nom}$. If $J_{s0}$ is not given in the simulation, $J_{s0} = 1.0e-4A/m^2$. $J_{ss0}$ is the sidewall saturation current density at $T_{nom}$. The default value of $J_{ss0}$ is 0.

If $I_{bs}$ is less than zero, the source/bulk diode current is calculated by:

\begin{align}
I_{bs} & = G_{mn} V_{bs}
\end{align}
9.1.1.2 Drain/bulk Diode

If the saturation current Isbd is larger than zero, the following equations are used to calculate the drain/bulk diode current:

\[ V_{bd} < 0.5V \]

\[ I_{bd} = I_{sbd} \left[ \exp\left(\frac{V_{bd}}{N_{v_{tm}}}\right) - 1 \right] + G_{\min} V_{bd} \]  \hspace{1cm} (9.1.7)

\[ V_{bd} > 0.5V \]

\[ I_{bd} = I_{sbd} \left[ \exp\left(\frac{0.5}{N_{v_{tm}}}\right) - 1 \right] + \frac{I_{sbd}}{N_{v_{tm}}} \exp\left(\frac{0.5}{N_{v_{tm}}}\right) V_{bd} - 0.5) + G_{\min} V_{bd} \]  \hspace{1cm} (9.1.8)

Where \( N_{v_{tm}} = n_{j}kT/q \), \( n_{j} \) is the emission coefficient of the drain junction, and \( I_{sbd} \) is calculated by

\[ I_{sbd} = J_s A_D + J_{sw} P_D \]  \hspace{1cm} (9.1.9)

where \( J_s \) is the saturation current density of the drain/bulk diode, \( A_D \) is the area of the drain junction, \( J_{sw} \) is the sidewall saturation current density of the drain/bulk diode, \( P_D \) is the perimeter of the drain junction. \( J_s \) and \( J_{sw} \) are functions of temperature and given by (9.1.4a), (9.1.4b) and (9.1.5).

If \( I_{sbd} \) is less than zero, the drain/bulk diode current is calculated by

\[ I_{sbd} = G_{\min} V_{bd} \]  \hspace{1cm} (9.1.10)
9.1.2 Parameters

The parameters for the DC model of the source/drain diode are listed in Table 9-1.

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
</tr>
</thead>
<tbody>
<tr>
<td>Js0</td>
<td>js</td>
<td>Saturation current density</td>
<td>1.e-4</td>
<td>A/m²</td>
</tr>
<tr>
<td>Js0sw</td>
<td>jssw</td>
<td>Side wall saturation current density</td>
<td>0</td>
<td>A/m</td>
</tr>
<tr>
<td>nj</td>
<td>nj</td>
<td>Emission coefficient</td>
<td>1</td>
<td>none</td>
</tr>
<tr>
<td>XTI</td>
<td>xti</td>
<td>Junction current temperature exponent coefficient</td>
<td>3.0</td>
<td>none</td>
</tr>
</tbody>
</table>

Table 9-1. MOS Diode Model Parameters.

9.2 MOS Diode Capacitance Model

9.2.1 Model Equations

Source and drain junction capacitance can be divided into two components: the junction bottom area capacitance $C_{jb}$ and the junction periphery capacitance $C_{jp}$. The formula for both the capacitances is similar, but with different model parameters. The equation of $C_{jb}$ includes the parameters such as $C_j$, $M_j$, and $P_b$. The equation of $C_{jp}$ includes the parameters such as $C_{jsw}$, $M_{jsw}$, $P_{bsw}$, $C_{jswg}$, $M_{jswg}$, $P_{bswg}$.

9.2.1.1 Source/bulk Junction Capacitance

The source/bulk junction capacitance can be calculated by:
MOS Diode Capacitance Model

If $P_s > W_{eff}$

$$C_{aps} = A_s C_{jbs} + (P_s - W_{eff})C_{jbsw} + W_{eff}C_{jbswg}$$

Otherwise:

$$C_{aps} = A_s C_{jbs} + P_s C_{jbsw}$$

where $C_{jbs}$ is the bottom area capacitance of the source/bulk junction, $C_{jbsw}$ is the periphery capacitance of the source/bulk junction along the field oxide side, and $C_{jbswg}$ is the periphery capacitance of the source/bulk junction along the gate oxide side.

If $C_j$ is larger than zero, $C_{jbs}$ is calculated by:

if $V_{bs} < 0$

$$C_{jbs} = C_j \left(1 - \frac{V_{bs}}{P_b}\right)^{-M_j}$$

if $V_{bs} > 0$

$$C_{jbs} = C_j (1 + M_j \frac{V_{bs}}{P_b})$$

If $C_{jsw}$ is larger than zero, $C_{jbsw}$ is calculated by:

if $V_{bs} < 0$
MOS Diode Capacitance Model

\[
C_{jbsw} = C_{jsw}(1 - \frac{V_{bs}}{P_{bsw}})^{-M_{jsw}}
\]

if \( V_{bs} > 0 \)

\[
C_{jbsw} = C_{jsw}(1 + M_{jsw} \frac{V_{bs}}{P_{bsw}})
\]

If \( C_{jswg} \) is larger than zero, \( C_{jbsw} \) is calculated by:

if \( V_{bs} < 0 \)

\[
C_{jbswg} = C_{jswg}(1 - \frac{V_{bs}}{P_{bswg}})^{-M_{jswg}}
\]

if \( V_{bs} > 0 \)

\[
C_{jbswg} = C_{jswg}(1 + M_{jswg} \frac{V_{bs}}{P_{bswg}})
\]

9.2.1.2 Drain/bulk Junction Capacitance

The drain/bulk junction capacitance can be calculated by:
MOS Diode Capacitance Model

If $P_b > W_{eff}$:

$$\text{Cap}_{bd} = A_d C_{jbd} + (P_b - W_{eff}) C_{jbd,sw} + W_{eff} C_{jbd,swg}$$

Otherwise:

$$\text{Cap}_{bd} = A_d C_{jbd} P_b C_{jbd,swg}$$

where $C_{jbd}$ is the bottom area capacitance of the drain/bulk junction, $C_{jbd,sw}$ is the periphery capacitance of the drain/bulk junction along the field oxide side, and $C_{jbd,swg}$ is the periphery capacitance of the drain/bulk junction along the gate oxide side.

If $C_j$ is larger than zero, $C_{jbd}$ is calculated by:

if $V_{bd} < 0$

$$C_{jbd} = C_j(1 - \frac{V_{bd}}{P_b})^{-M_j}$$

if $V_{bd} > 0$

$$C_{jbd} = C_j(1 + M_j \frac{V_{bd}}{P_b})$$

if $C_{jsw}$ is larger than zero, $C_{jbd,sw}$ is calculated by:
MOS Diode Capacitance Model

if $V_{bd} < 0$

\[ C_{jbdw} = C_{jow} (1 - \frac{V_{bd}}{P_{bow}})^{-M_{jw}} \]

if $V_{bd} > 0$

\[ C_{jbdw} = C_{jow} (1 + M_{jw} \frac{V_{bd}}{P_{bow}}) \]

if $C_{jswg}$ is larger than zero, $C_{jbdswg}$ is calculated by:

if $V_{bd} < 0$

\[ C_{jbdswg} = C_{jswg} (1 - \frac{V_{bd}}{P_{bow}})^{-M_{jswg}} \]

if $V_{bd} > 0$

\[ C_{jbdswg} = C_{jswg} (1 + M_{jswg} \frac{V_{bd}}{P_{bow}}) \]
The parameters for the capacitance model of the source/drain diode are listed in Table 9-2.

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
</tr>
</thead>
<tbody>
<tr>
<td>Cj</td>
<td>cj</td>
<td>Bottom junction capacitance per unit area at zero bias</td>
<td>5e-4</td>
<td>F/m²</td>
</tr>
<tr>
<td>Mj</td>
<td>mj</td>
<td>Bottom junction capacitance grading coefficient</td>
<td>0.5</td>
<td>none</td>
</tr>
<tr>
<td>Pb</td>
<td>pb</td>
<td>Bottom junction built-in potential</td>
<td>1.0</td>
<td>V</td>
</tr>
<tr>
<td>Cjsw</td>
<td>cjsw</td>
<td>Source/drain sidewall junction capacitance grading coefficient per unit length at zero bias</td>
<td>5e-10</td>
<td>F/m</td>
</tr>
<tr>
<td>Mjsw</td>
<td>mjsw</td>
<td>Source/drain sidewall junction capacitance grading coefficient</td>
<td>0.33</td>
<td>none</td>
</tr>
<tr>
<td>Pbsw</td>
<td>pbsw</td>
<td>Source/drain sidewall junction built-in potential</td>
<td>1.0</td>
<td>V</td>
</tr>
<tr>
<td>Cjswg</td>
<td>cjswg</td>
<td>Source/drain gate sidewall junction capacitance per unit length at zero bias</td>
<td>Cjsw</td>
<td>F/m</td>
</tr>
<tr>
<td>Mjswg</td>
<td>mjswg</td>
<td>Source/drain gate sidewall junction capacitance grading coefficient</td>
<td>Mjsw</td>
<td>none</td>
</tr>
<tr>
<td>Pbswg</td>
<td>pbswg</td>
<td>Source/drain gate sidewall junction built-in potential</td>
<td>Pbsw</td>
<td>V</td>
</tr>
</tbody>
</table>

Table 9-2. MOS Diode Capacitance Model Parameters.
### APPENDIX A: Parameter List

#### A.1 BSIM3v3 Model Control Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>none</td>
<td>level</td>
<td>BSIMv3 model selector</td>
<td>8</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Mobmod</td>
<td>mobmod</td>
<td>Mobility model selector</td>
<td>1</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Capmod</td>
<td>capmod</td>
<td>Flag for the short channel capacitance model</td>
<td>2</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Nqsmod</td>
<td>nqsmod</td>
<td>Flag for NQS model</td>
<td>0</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Noimod</td>
<td>noimod</td>
<td>Flag for noise model</td>
<td>1</td>
<td>none</td>
<td></td>
</tr>
</tbody>
</table>

#### A.2 DC Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Vth0</td>
<td>vth0</td>
<td>Threshold voltage @Vbs=0 for Large L.</td>
<td>0.7 (NMOS) -0.7 (PMOS)</td>
<td>V</td>
<td>nl-1</td>
</tr>
<tr>
<td>K1</td>
<td>k1</td>
<td>First order body effect coefficient</td>
<td>0.5</td>
<td>$V^{1/2}$</td>
<td>nl-2</td>
</tr>
</tbody>
</table>
### DC Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>K2</td>
<td>k2</td>
<td>Second order body effect coefficient</td>
<td>0.0</td>
<td>none</td>
<td>ni-2</td>
</tr>
<tr>
<td>K3</td>
<td>k3</td>
<td>Narrow width coefficient</td>
<td>80.0</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>K3b</td>
<td>k3b</td>
<td>Body effect coefficient of k3</td>
<td>0.0</td>
<td>1/V</td>
<td></td>
</tr>
<tr>
<td>W0</td>
<td>w0</td>
<td>Narrow width parameter</td>
<td>2.5e-6</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>NLx</td>
<td>nlx</td>
<td>Lateral non-uniform doping parameter</td>
<td>1.74e-7</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>Vbm</td>
<td>vbm</td>
<td>Maximum applied body bias in Vth calculation</td>
<td>-3.0</td>
<td>V</td>
<td></td>
</tr>
<tr>
<td>Dvt0</td>
<td>dvt0</td>
<td>First coefficient of short-channel effect on Vth</td>
<td>2.2</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Dvt1</td>
<td>dvt1</td>
<td>Second coefficient of short-channel effect on Vth</td>
<td>0.53</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Dvt2</td>
<td>dvt2</td>
<td>Body-bias coefficient of short-channel effect on Vth</td>
<td>-0.032</td>
<td>1/V</td>
<td></td>
</tr>
<tr>
<td>Dvt0w</td>
<td>dvt0w</td>
<td>First coefficient of narrow width effect on Vth for small channel length</td>
<td>0</td>
<td>1/m</td>
<td></td>
</tr>
<tr>
<td>Dvt1w</td>
<td>dvt1w</td>
<td>Second coefficient of narrow width effect on Vth for small channel length</td>
<td>5.3e6</td>
<td>1/m</td>
<td></td>
</tr>
<tr>
<td>Dvt2w</td>
<td>dvt2w</td>
<td>Body-bias coefficient of narrow width effect for small channel length</td>
<td>-0.032</td>
<td>1/V</td>
<td></td>
</tr>
<tr>
<td>𝜇₀</td>
<td>u0</td>
<td>Mobility at Temp = Tnom NMOSFET PMOSFET</td>
<td>670.0</td>
<td>cm²/V/sec</td>
<td></td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>250.0</td>
<td></td>
<td></td>
</tr>
</tbody>
</table>
## DC Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Ua</td>
<td>ua</td>
<td>First-order mobility degradation coefficient</td>
<td>2.25E-9</td>
<td>m/V</td>
<td></td>
</tr>
<tr>
<td>Ub</td>
<td>ub</td>
<td>Second-order mobility degradation coefficient</td>
<td>5.87E-19</td>
<td>(m/V)^2</td>
<td></td>
</tr>
<tr>
<td>Uc</td>
<td>uc</td>
<td>Body-effect of mobility degradation coefficient</td>
<td>mobmod=1, 2:</td>
<td>m/V^2</td>
<td></td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>-4.65e-11</td>
<td></td>
<td></td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>mobmod=3:</td>
<td></td>
<td></td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>-0.046</td>
<td></td>
<td></td>
</tr>
<tr>
<td>vsat</td>
<td>vsat</td>
<td>Saturation velocity at Temp = Tnom</td>
<td>8.0E4</td>
<td>m/sec</td>
<td></td>
</tr>
<tr>
<td>A0</td>
<td>a0</td>
<td>Bulk charge effect coefficient for channel length</td>
<td>1.0</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Ags</td>
<td>ags</td>
<td>gate bias coefficient of Abulk</td>
<td>0.0</td>
<td>1/V</td>
<td></td>
</tr>
<tr>
<td>B0</td>
<td>b0</td>
<td>Bulk charge effect coefficient for channel width</td>
<td>0.0</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>B1</td>
<td>b1</td>
<td>Bulk charge effect width offset</td>
<td>0.0</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>Keta</td>
<td>keta</td>
<td>Body-bias coefficient of bulk charge effect</td>
<td>-0.047</td>
<td>1/V</td>
<td></td>
</tr>
<tr>
<td>A1</td>
<td>a1</td>
<td>First non-saturation effect parameter</td>
<td>0.0</td>
<td>1/V</td>
<td></td>
</tr>
<tr>
<td>A2</td>
<td>a2</td>
<td>Second non-saturation factor</td>
<td>1.0</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Rdsw</td>
<td>rdsw</td>
<td>Parasitic resistance per unit width</td>
<td>0.0</td>
<td>Q-\mu m^W</td>
<td></td>
</tr>
<tr>
<td>Prwb</td>
<td>prwb</td>
<td>Body effect coefficient of Rdsw</td>
<td>0</td>
<td>V^-1/2</td>
<td></td>
</tr>
<tr>
<td>Prwg</td>
<td>prwg</td>
<td>Gate bias effect coefficient of Rdsw</td>
<td>0</td>
<td>1/V</td>
<td></td>
</tr>
</tbody>
</table>
## DC Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Wr</td>
<td>wr</td>
<td>Width Offset from Weff for Rds calculation</td>
<td>1.0</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Wint</td>
<td>wint</td>
<td>Width offset fitting parameter from I-V without bias</td>
<td>0.0</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>Lint</td>
<td>lint</td>
<td>Length offset fitting parameter from I-V without bias</td>
<td>0.0</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>dWg</td>
<td>dwg</td>
<td>Coefficient of Weff’s gate dependence</td>
<td>0.0</td>
<td>m/V</td>
<td></td>
</tr>
<tr>
<td>dWb</td>
<td>dwb</td>
<td>Coefficient of Weff’s substrate body bias dependence</td>
<td>0.0</td>
<td>m/V</td>
<td>1/2</td>
</tr>
<tr>
<td>Voff</td>
<td>voff</td>
<td>Offset voltage in the subthreshold region at large W and L</td>
<td>-0.08</td>
<td>V</td>
<td></td>
</tr>
<tr>
<td>Nfactor</td>
<td>nfactor</td>
<td>Subthreshold swing factor</td>
<td>1.0</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Eta0</td>
<td>eta0</td>
<td>DIBL coefficient in subthreshold region</td>
<td>0.08</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Etab</td>
<td>etab</td>
<td>Body-bias coefficient for the subthreshold DIBL effect</td>
<td>-0.07</td>
<td>1/V</td>
<td></td>
</tr>
<tr>
<td>Dsub</td>
<td>dsub</td>
<td>DIBL coefficient exponent in subthreshold region</td>
<td>drout</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Cit</td>
<td>cit</td>
<td>Interface trap capacitance</td>
<td>0.0</td>
<td>F/m²</td>
<td></td>
</tr>
<tr>
<td>Cdsc</td>
<td>cdsc</td>
<td>Drain/Source to channel coupling capacitance</td>
<td>2.4E-4</td>
<td>F/m²</td>
<td></td>
</tr>
<tr>
<td>Cdscb</td>
<td>cdscb</td>
<td>Body-bias sensitivity of Cdsc</td>
<td>0.0</td>
<td>F/Vm²</td>
<td></td>
</tr>
<tr>
<td>Cdscd</td>
<td>cdscd</td>
<td>Drain-bias sensitivity of Cdsc</td>
<td>0.0</td>
<td>F/Vm²</td>
<td></td>
</tr>
<tr>
<td>Pclm</td>
<td>pclm</td>
<td>Channel length modulation parameter</td>
<td>1.3</td>
<td>none</td>
<td></td>
</tr>
</tbody>
</table>
## DC Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Pdiblc1</td>
<td>pdiblc1</td>
<td>First output resistance DIBL effect correction parameter</td>
<td>0.39</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Pdiblc2</td>
<td>pdiblc2</td>
<td>Second output resistance DIBL effect correction parameter</td>
<td>0.0086</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Pdiblcb</td>
<td>pdiblcb</td>
<td>Body effect coefficient of DIBL correction parameters</td>
<td>0</td>
<td>1/V</td>
<td></td>
</tr>
<tr>
<td>Drout</td>
<td>drout</td>
<td>L dependence coefficient of the DIBL correction parameter in Rout</td>
<td>0.56</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Pscbe1</td>
<td>pscbe1</td>
<td>First substrate current body-effect parameter</td>
<td>4.24E8</td>
<td>V/m</td>
<td></td>
</tr>
<tr>
<td>Pscbe2</td>
<td>pscbe2</td>
<td>Second substrate current body-effect parameter</td>
<td>1.0E-5</td>
<td>m/V</td>
<td></td>
</tr>
<tr>
<td>Pvag</td>
<td>pvag</td>
<td>Gate dependence of Early voltage</td>
<td>0.0</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>$\delta$</td>
<td>delta</td>
<td>Effective Vds parameter</td>
<td>0.01</td>
<td>V</td>
<td></td>
</tr>
<tr>
<td>Ngate</td>
<td>ngate</td>
<td>poly gate doping concentration</td>
<td>0</td>
<td>cm$^{-3}$</td>
<td></td>
</tr>
<tr>
<td>$\alpha_0$</td>
<td>alpha0</td>
<td>The first parameter of impact ionization current</td>
<td>0</td>
<td>m/V</td>
<td></td>
</tr>
<tr>
<td>$\beta_0$</td>
<td>beta0</td>
<td>The second parameter of impact ionization current</td>
<td>30</td>
<td>V</td>
<td></td>
</tr>
<tr>
<td>Rsh</td>
<td>rsh</td>
<td>Source drain sheet resistance in ohm per square</td>
<td>0.0</td>
<td>$\Omega$/square</td>
<td></td>
</tr>
<tr>
<td>Js0sw</td>
<td>jsw</td>
<td>Side wall saturation current density</td>
<td>0</td>
<td>A/m</td>
<td></td>
</tr>
<tr>
<td>Jso</td>
<td>js</td>
<td>Source drain junction saturation current per unit area</td>
<td>1.0E-4</td>
<td>A/m$^{-2}$</td>
<td></td>
</tr>
</tbody>
</table>
## A.3 AC and Capacitance Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Xpert</td>
<td>xpart</td>
<td>Charge partitioning rate flag</td>
<td>0</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>CGS0</td>
<td>cgso</td>
<td>Non LDD region source-gate overlap capacitance per channel length</td>
<td>calculated</td>
<td>F/m</td>
<td>nC-1</td>
</tr>
<tr>
<td>CGD0</td>
<td>cgdo</td>
<td>Non LDD region drain-gate overlap capacitance per channel length</td>
<td>calculated</td>
<td>F/m</td>
<td>nC-2</td>
</tr>
<tr>
<td>CGB0</td>
<td>cgbo</td>
<td>Gate bulk overlap capacitance per unit channel length</td>
<td>0.0</td>
<td>F/m</td>
<td></td>
</tr>
<tr>
<td>Cj</td>
<td>cj</td>
<td>Bottom junction per unit area</td>
<td>5e-4</td>
<td>F/m²</td>
<td></td>
</tr>
<tr>
<td>Mj</td>
<td>mj</td>
<td>Bottom junction capacitance grating coefficient</td>
<td>0.5</td>
<td></td>
<td></td>
</tr>
<tr>
<td>Mjsw</td>
<td>mjsw</td>
<td>Source/Drain side junction capacitance grading coefficient</td>
<td>0.33</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Cjsw</td>
<td>cjsw</td>
<td>Source/Drain side junction capacitance per unit area</td>
<td>5.E-10</td>
<td>F/m</td>
<td></td>
</tr>
<tr>
<td>Cjswg</td>
<td>cjswg</td>
<td>Source/drain gate sidewall junction capacitance grading coefficient</td>
<td>Cjsw</td>
<td>F/m</td>
<td></td>
</tr>
<tr>
<td>Mjswg</td>
<td>mjswg</td>
<td>Source/drain gate sidewall junction capacitance coefficient</td>
<td>Mjsw</td>
<td>none</td>
<td></td>
</tr>
</tbody>
</table>
### AC and Capacitance Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Pbsw</td>
<td>pbsw</td>
<td>Source/drain side junction built-in potential</td>
<td>1.0</td>
<td>V</td>
<td></td>
</tr>
<tr>
<td>Pb</td>
<td>pb</td>
<td>Bottom built-in potential</td>
<td>1.0</td>
<td>V</td>
<td></td>
</tr>
<tr>
<td>Pbswg</td>
<td>pbswg</td>
<td>Source/Drain gate sidewall junction built-in potential</td>
<td>Pbsw</td>
<td>V</td>
<td></td>
</tr>
<tr>
<td>CGS1</td>
<td>cgs1</td>
<td>Light doped source-gate region overlap capacitance</td>
<td>0.0</td>
<td>F/m</td>
<td></td>
</tr>
<tr>
<td>CGD1</td>
<td>cgd1</td>
<td>Light doped drain-gate region overlap capacitance</td>
<td>0.0</td>
<td>F/m</td>
<td></td>
</tr>
<tr>
<td>CKAPPA</td>
<td>ckappa</td>
<td>Coefficient for lightly doped region overlap capacitance Fringing field capacitance</td>
<td>0.6</td>
<td>F/m</td>
<td></td>
</tr>
<tr>
<td>Cf</td>
<td>cf</td>
<td>fringing field capacitance</td>
<td>calculated</td>
<td>F/m</td>
<td>nC-3</td>
</tr>
<tr>
<td>CLC</td>
<td>clc</td>
<td>Constant term for the short channel model</td>
<td>0.1E-6</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>CLE</td>
<td>cle</td>
<td>Exponential term for the short channel model</td>
<td>0.6</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>DLC</td>
<td>dlc</td>
<td>Length offset fitting parameter from C-V</td>
<td>lint</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>DWC</td>
<td>dwc</td>
<td>Width offset fitting parameter from C-V</td>
<td>wint</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>Vfb</td>
<td>vfb</td>
<td>Flat-band voltage parameter (for capmod=0 only)</td>
<td>-1</td>
<td>V</td>
<td></td>
</tr>
</tbody>
</table>
### A.4 NQS Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Elm</td>
<td>elm</td>
<td>Elmore constant of the channel</td>
<td>5</td>
<td></td>
<td>none</td>
</tr>
</tbody>
</table>

### A.5 dW and dL Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>W1</td>
<td>wl</td>
<td>Coefficient of length dependence for width offset</td>
<td>0.0</td>
<td>m(^Wn)</td>
<td></td>
</tr>
<tr>
<td>Wln</td>
<td>wln</td>
<td>Power of length dependence of width offset</td>
<td>1.0</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Ww</td>
<td>ww</td>
<td>Coefficient of width dependence for width offset</td>
<td>0.0</td>
<td>m(^Wwn)</td>
<td></td>
</tr>
<tr>
<td>Wwn</td>
<td>wwn</td>
<td>Power of width dependence of width offset</td>
<td>1.0</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Wwl</td>
<td>wwl</td>
<td>Coefficient of length and width cross term for width offset</td>
<td>0.0</td>
<td>m(^Wwn+Wln)</td>
<td></td>
</tr>
<tr>
<td>L1</td>
<td>ll</td>
<td>Coefficient of length dependence for length offset</td>
<td>0.0</td>
<td>m(^Ln)</td>
<td></td>
</tr>
<tr>
<td>Lln</td>
<td>lln</td>
<td>Power of length dependence for length offset</td>
<td>1.0</td>
<td>none</td>
<td></td>
</tr>
</tbody>
</table>
### Temperature Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Lw</td>
<td>lw</td>
<td>Coefficient of width dependence for length offset</td>
<td>0.0</td>
<td>m(^Lwn)</td>
<td></td>
</tr>
<tr>
<td>Lwn</td>
<td>lwn</td>
<td>Power of width dependence for length offset</td>
<td>1.0</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Lwl</td>
<td>lwl</td>
<td>Coefficient of length and width cross term for length offset</td>
<td>0.0</td>
<td>m(^{Lwn+Ln})</td>
<td></td>
</tr>
</tbody>
</table>

### A.6 Temperature Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Tnom</td>
<td>tnom</td>
<td>Temperature at which parameters are extracted</td>
<td>27</td>
<td>°C</td>
<td></td>
</tr>
<tr>
<td>(\mu_t)</td>
<td>ute</td>
<td>Mobility temperature exponent</td>
<td>-1.5</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Kt1</td>
<td>kt1</td>
<td>Temperature coefficient for threshold voltage</td>
<td>-0.11</td>
<td>V</td>
<td></td>
</tr>
<tr>
<td>Kt11</td>
<td>kt11</td>
<td>Channel length dependence of the temperature coefficient for threshold voltage</td>
<td>0.0</td>
<td>V*m</td>
<td></td>
</tr>
<tr>
<td>Kt2</td>
<td>kt2</td>
<td>Body-bias coefficient of Vth temperature effect</td>
<td>0.022</td>
<td>none</td>
<td></td>
</tr>
</tbody>
</table>
## Temperature Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Ua1</td>
<td>ua1</td>
<td>Temperature coefficient for Ua</td>
<td>4.31E-9</td>
<td>m/V</td>
<td></td>
</tr>
<tr>
<td>Ub1</td>
<td>ub1</td>
<td>Temperature coefficient for Ub</td>
<td>-7.61E-18</td>
<td>(m/V)^2</td>
<td></td>
</tr>
<tr>
<td>Uc1</td>
<td>uc1</td>
<td>Temperature coefficient for Uc</td>
<td>mob-mod=1, 2: -5.6E-11 mob-mod=3: -0.056</td>
<td>m/V^2</td>
<td>1/V</td>
</tr>
<tr>
<td>At</td>
<td>at</td>
<td>Temperature coefficient for saturation velocity</td>
<td>3.3E4</td>
<td>m/sec</td>
<td></td>
</tr>
<tr>
<td>Prt</td>
<td>prt</td>
<td>Temperature coefficient for Rdsw</td>
<td>0</td>
<td>Ω·µm</td>
<td></td>
</tr>
<tr>
<td>At</td>
<td>at</td>
<td>Temperature coefficient for saturation velocity</td>
<td>3.3E4</td>
<td>m/sec</td>
<td></td>
</tr>
<tr>
<td>nj</td>
<td>nj</td>
<td>Emission coefficient of junction</td>
<td>1</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>XTI</td>
<td>xti</td>
<td>Junction current temperature exponent coefficient</td>
<td>3.0</td>
<td>none</td>
<td></td>
</tr>
</tbody>
</table>
## A.7 Flicker Noise Model Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Noia</td>
<td>noia</td>
<td>Noise parameter A</td>
<td>(NMOS) $1 \times 10^20$</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>(PMOS) $9.9 \times 10^18$</td>
<td></td>
<td></td>
</tr>
<tr>
<td>Noib</td>
<td>noib</td>
<td>Noise parameter B</td>
<td>(NMOS) $5 \times 10^4$</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>(PMOS) $2.4 \times 10^3$</td>
<td></td>
<td></td>
</tr>
<tr>
<td>Noic</td>
<td>noic</td>
<td>Noise parameter C</td>
<td>(NMOS) $-1.4 \times 10^{-12}$</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td></td>
<td></td>
<td></td>
<td>(PMOS) $1.4 \times 10^{-12}$</td>
<td></td>
<td></td>
</tr>
<tr>
<td>Em</td>
<td>em</td>
<td>Saturation field</td>
<td>$4.1 \times 10^7$</td>
<td>V/m</td>
<td></td>
</tr>
<tr>
<td>Af</td>
<td>af</td>
<td>Frequency exponent</td>
<td>$1$</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Ef</td>
<td>ef</td>
<td>Flicker exponent</td>
<td>$1$</td>
<td>none</td>
<td></td>
</tr>
<tr>
<td>Kf</td>
<td>kf</td>
<td>Flicker noise parameter</td>
<td>$0$</td>
<td>none</td>
<td></td>
</tr>
</tbody>
</table>

## A.8 Process Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>Tox</td>
<td>tox</td>
<td>Gate oxide thickness</td>
<td>$1.5 \times 10^{-8}$</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>Xj</td>
<td>xj</td>
<td>Junction Depth</td>
<td>$1.5 \times 10^{-7}$</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>$\gamma_1$</td>
<td>gamma1</td>
<td>Body-effect coefficient near the surface</td>
<td>calculated</td>
<td>$\sqrt{1/2}$</td>
<td>nI-4</td>
</tr>
</tbody>
</table>
### A.9 Bin Description Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>( \gamma_2 )</td>
<td>( \text{gamma2} )</td>
<td>Body-effect coefficient in the bulk</td>
<td>calculated</td>
<td>( \gamma^{1/2} )</td>
<td>nI-5</td>
</tr>
<tr>
<td>( N_{\text{ch}} )</td>
<td>( \text{nch} )</td>
<td>Channel doping concentration</td>
<td>1.7e17</td>
<td>1/cm³</td>
<td>nI-3</td>
</tr>
<tr>
<td>( N_{\text{sub}} )</td>
<td>( \text{nsub} )</td>
<td>Substrate doping concentration</td>
<td>6e16</td>
<td>1/cm³</td>
<td></td>
</tr>
<tr>
<td>( V_{\text{bx}} )</td>
<td>( \text{vbx} )</td>
<td>( V_{\text{bs}} ) at which the depletion region width equals ( x_t )</td>
<td>calculated</td>
<td>( V )</td>
<td>nI-6</td>
</tr>
<tr>
<td>( x_t )</td>
<td>( \text{xt} )</td>
<td>Doping depth</td>
<td>1.55e-7</td>
<td>m</td>
<td></td>
</tr>
</tbody>
</table>

### A.9 Bin Description Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Default</th>
<th>Unit</th>
<th>Note</th>
</tr>
</thead>
<tbody>
<tr>
<td>( L_{\text{min}} )</td>
<td>( \text{lmin} )</td>
<td>Minimum channel length</td>
<td>0.0</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>( L_{\text{max}} )</td>
<td>( \text{lmax} )</td>
<td>Maximum channel length</td>
<td>1.0</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>( W_{\text{min}} )</td>
<td>( \text{wmin} )</td>
<td>Minimum channel width</td>
<td>0.0</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>( W_{\text{max}} )</td>
<td>( \text{wmax} )</td>
<td>Maximum channel width</td>
<td>1.0</td>
<td>m</td>
<td></td>
</tr>
<tr>
<td>( \text{binunit} )</td>
<td>( \text{binunit} )</td>
<td>Bin unit scale selector</td>
<td>1</td>
<td>none</td>
<td></td>
</tr>
</tbody>
</table>
A.10 Model Parameter Notes

nI-1. If \( V_{th0} \) is not specified, it is calculated using:

\[
V_{th0} = V_{FB} + \phi_t + K_1 \sqrt{\phi_t}
\]

where \( V_{FB} = -1 \). If \( V_{th0} \) is specified, \( V_{FB} \) is calculated using

\[
V_{FB} = V_{th0} - \phi_t - K_1 \sqrt{\phi_t}
\]

nI-2. If \( k_1 \) and \( k_2 \) are not given, they are calculated using:

\[
K_1 = \gamma_1 - 2K_2 \sqrt{\phi_t - V_{th0}}
\]

\[
K_2 = \frac{(\gamma_1 - \gamma_2)(\sqrt{\phi_t - V_{th0}} - \sqrt{\phi_t})}{2\sqrt{\phi_t - V_{th0}} - V_{th0}}
\]

where the parameter \( \phi_t \) is calculated using:

\[
\phi_t = 2v_m 0 \ln \left( \frac{N c h}{n_i} \right)
\]

\[
v_m 0 = \frac{k_B T_{nom}}{q}
\]
$n_i = 1.45 \times 10^{10} \left( \frac{T_{\text{nom}}}{300.15} \right)^{1.5} \exp \left( 21.5565981 - \frac{E_{g0}}{2V_{\text{lim}0}} \right)$

$E_{g0} = 1.16 - \frac{7.02 \times 10^{-4} T_{\text{nom}}^2}{T_{\text{nom}} + 1108}$

where $E_{g0}$ is the energy bandgap at temperature $T_{\text{nom}}$.

**nI-3.** If $n_{\text{ch}}$ is not given and $\gamma_1$ is given, $n_{\text{ch}}$ is calculated from:

$$N_{\text{ch}} = \frac{\gamma_1^2 C_{\text{ox}}^2}{2q \varepsilon_{\text{si}}}$$

If both $\gamma_1$ and $n_{\text{ch}}$ are not given, $n_{\text{ch}}$ defaults to $1.7e23$ $/m^3$ and $\gamma_1$ is calculated from $n_{\text{ch}}$.

**nI-4.** If $\gamma_1$ is not given, it is calculated using:

$$\gamma_1 = \sqrt{2q \varepsilon_{\text{si}} N_{\text{ch}}} / C_{\text{ox}}$$

**nI-5.** If $\gamma_2$ is not given, it is calculated using:

$$\gamma_2 = \sqrt{2q \varepsilon_{\text{si}}} N_{\text{sub}} / C_{\text{ox}}$$
**Model Parameter Notes**

**nI-6.** If vbx is not given, it is calculated using:

\[ V_{he} = \phi_e - \frac{qN_{ea}X_e^2}{2e_{si}} \]

**nC-1.** If cgso is not given then it is calculated using:

if (die is given and is greater 0) then,

\[ cgso = p1 = (dlc*cox) - cgsl \]

if (the previously calculated cgso <0), then

\[ cgso=0 \]

else cgso = 0.6 xj*cox

**nC-2.** If cgdo is not given then it is calculated using:

if (dlc is given and is greater than 0) then,

\[ cgdo = p2 = (dlc*cox) - cgdl \]

if (the previously calculated cgdo <0), then

\[ cgdo=0 \]

else cgdo = 0.6 xj*cox
Model Parameter Notes

nC-3. If $\alpha$ is not given then it is calculated using:

$$CF = \frac{2\varepsilon_{ox} \ln \left(1 + \frac{4 \times 10^{-7}}{Tox}\right)}{\pi}$$
APPENDIX B: Equation List

B.1 I-V Model

B.1.1 Threshold Voltage

\[
V_{\text{th}} = V_{\text{th0}} + K_1 (\sqrt{\Phi_s - V_{\text{bseff}}} - \sqrt{\Phi_s}) - K_2 V_{\text{bseff}}
\]

\[
+ K_1 \left( \sqrt{1 + \frac{N_{LX}}{L_{\text{eff}}} - 1} \right) \sqrt{\Phi_s} + (K_3 + K_{3b} V_{\text{bseff}}) \frac{\Phi_s}{W_{\text{eff}} + W_0}
\]

\[
- D_{\text{VT0w}} \left( \exp(-D_{\text{VT1w}} \frac{W_{\text{eff}} L_{\text{eff}}}{2 l_{\text{w}}}) + 2 \exp(-D_{\text{VT1w}} \frac{W_{\text{eff}} L_{\text{eff}}}{l_{\text{w}}}) \right) (V_{\text{bi}} - \Phi_s)
\]

\[
- D_{\text{VT0}} \left( \exp(-D_{\text{VT1}} \frac{L_{\text{eff}}}{2 l_t}) + 2 \exp(-D_{\text{VT1}} \frac{L_{\text{eff}}}{l_t}) \right) (V_{\text{bi}} - \Phi_s)
\]

\[
- \left( \exp(-D_{\text{sub}} \frac{L_{\text{eff}}}{2 l_{\text{t0}}}) + 2 \exp(-D_{\text{sub}} \frac{L_{\text{eff}}}{l_{\text{t0}}}) \right) (E_{\text{tao}} + E_{\text{tab}} V_{\text{bseff}}) V_{\text{ds}}
\]

\[
l_t = \sqrt{\varepsilon_{\text{si}} X_{\text{dep}} / C_{\text{ox}}} (1 + D_{\text{VT2}} V_{\text{bseff}})
\]

\[
l_{\text{tw}} = \sqrt{\varepsilon_{\text{si}} X_{\text{dep}} / C_{\text{ox}}} (1 + D_{\text{VT2w}} V_{\text{bseff}})
\]

\[
l_{\text{t0}} = \sqrt{\varepsilon_{\text{si}} X_{\text{dep0}} / C_{\text{ox}}}
\]

\[
X_{\text{dep}} = \sqrt{\frac{2 \varepsilon_{\text{s}} (\Phi_s - V_{\text{bseff}})}{q N_{\text{cs}}}}
\]
I-V Model

\[ X_{dep} = \frac{2 \varepsilon_s \Phi_s}{q N_{ch}} \]

\[ V_{bs\text{eff}} = V_{bc} + 0.5[V_{bs} - V_{bc} - \delta_1 + \sqrt{(V_{bs} - V_{bc} - \delta_1)^2 - 4 \delta_1 V_{bc}}] \]

\[ V_{bc} = 0.9(\phi_s - \frac{K_1^2}{4 K_2^2}) \]

\[ V_{bi} = n_i \ln\left(\frac{N_{ch} N_{DS}}{n_i^2}\right) \]

B.1.2 Effective Vgs-Vth

\[ V_{gs\text{eff}} = \frac{2 n \nu_i \ln\left[1 + \exp\left(\frac{V_{gs} - V_{th}}{2 n \nu_i}\right)\right]}{1 + 2 n \nu_i \ln\left[1 + \exp\left(-\frac{V_{gs} - V_{th} - 2 V_{off}}{2 n \nu_i}\right)\right]} \]

\[ n = 1 + N_{factor} \frac{C_d}{C_{ox}} + \frac{(C_{dsc} + C_{dscd} V_{ds} + C_{dscb} V_{s\text{eff}}) \left(\exp\left(-\frac{L_{eff}}{2 l_t}\right) + 2 \exp\left(-\frac{D_{vth} L_{eff}}{l_t}\right)\right)}{C_{ox}} + \frac{C_d}{C_{ox}} \]

\[ C_d = \frac{\varepsilon_s}{X_{dep}} \]

B.1.3 Mobility

For Mobmod=1
I-V Model

\[ \mu_{\text{eff}} = \frac{\mu_0}{1 + \left( U_a + U_c V_{\text{beff}} \right) \left( \frac{V_{\text{beff}} + 2 V_{\text{th}}}{T_{\text{OX}}} \right) + U_b \left( \frac{V_{\text{beff}} + 2 V_{\text{th}}}{T_{\text{OX}}} \right)^2} \]

For Mobmod=2

\[ \mu_{\text{eff}} = \frac{\mu_0}{1 + \left( U_a + U_c V_{\text{beff}} \right) \left( \frac{V_{\text{beff}}}{T_{\text{OX}}} \right) + U_b \left( \frac{V_{\text{beff}}}{T_{\text{OX}}} \right)^2} \]

For Mobmod=3

\[ \mu_{\text{eff}} = \frac{\mu_0}{1 + \left[ U_a \left( \frac{V_{\text{beff}} + 2 V_{\text{th}}}{T_{\text{OX}}} \right) + U_b \left( \frac{V_{\text{beff}} + 2 V_{\text{th}}}{T_{\text{OX}}} \right)^2 \right] \left( 1 + U_c V_{\text{beff}} \right)} \]

B.1.4 Drain Saturation Voltage

For \( R_{DS} > 0 \) or \( \lambda \neq 1 \):

\[ V_{\text{dsat}} = \frac{-b - \sqrt{b^2 - 4ac}}{2a} \]

\[ a = A_{\text{bulk}}^2 W_{\text{eff}} N_{\text{Sat}} C_{\text{ox}} R_{DS} + \left( \frac{1}{\lambda} - 1 \right) A_{\text{bulk}} \]
I-V Model

\[ b = -\left( \frac{2}{\lambda} - 1 \right) + A_{bulk} E_{sat} L_{eff} + 3 A_{bulk} (V_{gsteff} + 2V_t) W_{eff} N_{at} C_{ox} R_{DS} \]

\[ c = (V_{gsteff} + 2V_t) E_{sat} L_{eff} + 2(V_{gsteff} + 2V_t) W_{eff} N_{at} C_{ox} R_{DS} \]

\[ \lambda = A_1 V_{gsteff} + A_2 \]

For \( R_{DS} = 0 \), \( \lambda = 1 \):

\[ V_{dsat} = \frac{E_{sat} L_{eff} (V_{gsteff} + 2V_t)}{A_{bulk} E_{sat} L_{eff} + (V_{gsteff} + 2V_t)} \]

\[ A_{bulk} = (1 + \frac{K_1}{2 \sqrt{D_s} - L_{eff}}) \left[ \frac{A_0 L_{eff}}{L_{eff} + 2 \sqrt{X_0 X_{dep}}} \right] (1 - A_{et} V_{gsteff} \left( \frac{L_{eff}}{L_{eff} + 2 \sqrt{X_0 X_{dep}}} \right)^2 + \frac{B_e}{W_{eff} + B_1}) \frac{1}{1 + K_{et} V_{gsteff}} \]

\[ E_{sat} = \frac{2V_{sat}}{\mu_{eff}} \]

**B.1.5 Effective Vds**

\[ V_{dseff} = V_{dsat} - \frac{1}{2} \left( V_{dsat} - V_d - \delta + \sqrt{(V_{dsat} - V_d - \delta)^2 + 4\delta V_{dsat}} \right) \]
B.1.6 Drain Current Expression

\[ I_{ds} = \frac{I_{dso(V_{ds+eff})}}{1 + \frac{R_{ds}I_{dso(V_{ds+eff})}}{V_{ds+eff}} \left(1 + \frac{V_{ds} - V_{ds+eff}}{V_A}\right) \left(1 + \frac{V_{ds} - V_{ds+eff}}{V_{ASCBE}}\right)} \]

\[ I_{dso} = \frac{W_{eff} \mu_{eff} C_{ox} V_{gs+eff} (1 - A_{bulk} \frac{V_{ds+eff}}{2(V_{gs+eff} + 2V_i)}) V_{ds+eff}}{L_{eff} \left[1 + V_{ds+eff} \left(\frac{V_{sat}}{V_{ASCBE}}\right)\right]} \]

\[ V_A = V_{A+sat} + (1 + \frac{P_{vag} V_{gs+eff}}{V_{sat} L_{eff}}) \left(\frac{1}{V_{ACLM}} + \frac{1}{V_{ADIBLC}}\right)^{-1} \]

\[ V_{ACLM} = \frac{A_{bulk} V_{sat} L_{eff} + V_{gs+eff}}{P_{CLM} A_{bulk} V_{sat} litl} (V_{ds} - V_{ds+eff}) \]

\[ V_{ADIBLC} = \frac{(V_{gs+eff} + 2V_i)}{\theta_{roul}(1 + P_{DIBLC2} V_{ds+eff})} \left(1 - \frac{A_{bulk} V_{sat}}{A_{bulk} V_{sat} + V_{gs+eff} + 2V_i}\right) \]

\[ \theta_{roul} = P_{DIBLC1} \left[\exp\left(-D_{ROUT} \frac{L_{eff}}{2l_0}\right) + 2\exp\left(-D_{ROUT} \frac{L_{eff}}{l_0}\right)\right] + P_{DIBLC2} \]

\[ \frac{1}{V_{ASCBE}} = \frac{P_{sche2}}{L_{eff}} \exp\left(-\frac{P_{sche1}}{V_{ds} - V_{ds+eff}}\right) \]
I-V Model

\[ V_{\text{Sat}} = \frac{E_{\text{sat,eff}} + V_{\text{dsat}} + 2R_{\text{DSSsat,ox}}W_{\text{eff}}V_{\text{gsat}}}{2(1 + \lambda + R_{\text{DSSsat,ox}}W_{\text{eff}}/A_{\text{bulk}})} \]

\[ l_{\text{itl}} = \sqrt{\frac{\varepsilon_{\text{si}}T_{\text{ox}}X_j}{\varepsilon_{\text{ox}}}} \]

B.1.7 Substrate Current

\[ I_{\text{sub}} = \frac{\alpha_o}{L_{\text{eff}}} (V_{\text{ds}} - V_{\text{dref}}) \exp(-\frac{b_o}{V_{\text{ds}} - V_{\text{dref}}}) \frac{I_{\text{dso}}}{1 + \frac{V_{\text{ds}} - V_{\text{dref}}}{V_{\text{A}}}} \]

B.1.8 Polysilicon Depletion Effect

\[ V_{\text{poly}} = \frac{1}{2} X_{\text{poly}} E_{\text{poly}} = \frac{qN_{\text{gate}}X_{\text{poly}}^2}{2\varepsilon_{\text{si}}} \]

\[ \varepsilon_{\text{ox}} E_{\text{ox}} = \varepsilon_{\text{si}} E_{\text{poly}} = \sqrt{2q\varepsilon_{\text{si}}N_{\text{gate}}V_{\text{poly}}} \]

\[ V_{\text{gs}} - V_{\text{FB}} - \phi_s = V_{\text{poly}} + V_{\text{ox}} \]

\[ a(V_{\text{gs}} - V_{\text{FB}} - \phi_s - V_{\text{poly}})^2 - V_{\text{poly}} = 0 \]
I-V Model

\[ a = \frac{2}{\varepsilon_{ox}} \frac{\varepsilon_{ox}}{2q\varepsilon_{si}N_{gate}T_{ox}^2} \]

\[ V_{gs_{-eff}} = V_{FB} + \phi_s + \frac{q\varepsilon_{si}N_{gate}T_{ox}^2}{\varepsilon_{ox}} \left( \sqrt{1 + \frac{2\varepsilon_{ox}}{q\varepsilon_{si}N_{gate}T_{ox}^2} (V_{gs} - V_{FB} - \phi_s)} - 1 \right) \]

B.1.9 Effective Channel Length and Width

\[ L_{eff} = L_{drawn} - 2dL \]

\[ W_{eff} = W_{drawn} - 2dW \]

\[ W_{eff'} = W_{drawn} - 2dW' \]

\[ dW = dW' + dW_s V_{gs_{eff}} + dW_s (\sqrt{\phi_s} - V_{beff} - \sqrt{\phi_s}) \]

\[ dW' = W_{int} + \frac{W_i}{L_{W_{ln}}} + \frac{W_w}{W_{W_{wn}}} + \frac{W_{wl}}{L_{W_{ln}} W_{W_{wn}}} \]

\[ dL = L_{int} + \frac{L_i}{L_{L_{ln}}} + \frac{L_w}{W_{L_{wn}}} + \frac{L_{wl}}{L_{L_{ln}} W_{L_{wn}}} \]
B.1.10 Drain/Source Resistance

\[
R_{ds} = \frac{R_{ds}(1 + P_{r} V_{gsf} + P_{r} W_{eff}(\sqrt{\phi_{t}} - V_{t} - \sqrt{\phi_{t}}))}{\left(10^b W_{eff}\right)^{\mu_{r}}}
\]

B.1.11 Temperature Effects

\[
V_{th}(T) = V_{th}(T_{norm}) + (K_{T1} + K_{T2} / L_{eff} + K_{T3} V_{bseg})(T / T_{norm} - 1)
\]

\[
\mu_{o}(T) = \mu_{o}(T_{norm}) \left(\frac{T}{T_{norm}}\right)^{\mu_{r}}
\]

\[
V_{sat}(T) = V_{sat}(T_{norm}) - A_{T}(T / T_{norm} - 1)
\]

\[
R_{ds}(T) = R_{ds}(T_{norm}) + P_{r} \left(\frac{T}{T_{norm}} - 1\right)
\]

\[
U_{a}(T) = U_{a}(T_{norm}) + U_{a1}(T / T_{norm} - 1)
\]

\[
U_{b}(T) = U_{b}(T_{norm}) + U_{b1}(T / T_{norm} - 1)
\]

\[
U_{c}(T) = U_{c}(T_{norm}) + U_{c1}(T / T_{norm} - 1)
\]
B.2 Capacitance Model Equations

B.2.1 Dimension Dependence

\[ \delta W_{\text{eff}} = DWC + \frac{W_l}{L_{\text{in}}} + \frac{W_w}{W_{\text{wn}}} + \frac{W_{wl}}{L_{\text{in}}W_{\text{wn}}} \]

\[ \delta L_{\text{eff}} = DLC + \frac{L_l}{L_{\text{in}}} + \frac{L_w}{W_{\text{wn}}} + \frac{L_{wl}}{L_{\text{in}}W_{\text{wn}}} \]

\[ L_{\text{active}} = L_{\text{down}} - 2\delta L_{\text{eff}} \]

\[ W_{\text{active}} = W_{\text{down}} - 2\delta W_{\text{eff}} \]

B.2.2 Overlap Capacitance (for NMOS)

B.2.2.1 Source Overlap Capacitance

(1) for capmod=0

\[ \frac{Q_{\text{overlap,s}}}{W_{\text{active}}} = \text{CGSO}V_{gs} \]

(2) for capmod=1
Capacitance Model Equations

if (Vgs < 0)

\[
\frac{Q_{\text{overlap},s}}{W_{\text{active}}} = \text{CGS0} V_{gs} + \frac{\text{CKAPPACGS1}}{2} \left( -1 + \sqrt{1 + \frac{4V_{gs}}{\text{CKAPPAP}}} \right)
\]

else

\[
\frac{Q_{\text{overlap},s}}{W_{\text{active}}} = (\text{CGS0} + \text{CKAPPACGS1}) V_{gs}
\]

(3) for capmod=2

\[
V_{gs,\text{overlap}} = \frac{1}{2} \left( (V_{gs} - \delta) + \sqrt{(V_{gs} - \delta)^2 - 4\delta} \right) \quad \text{where} \quad \delta = 0.02
\]

\[
\frac{Q_{\text{overlap},s}}{W_{\text{active}}} = \text{CGS0} V_{gs} + \text{CGS1} \left\{ V_{gs} - V_{gs,\text{overlap}} + \frac{\text{CKAPPAP}}{2} \left( -1 + \sqrt{1 + \frac{4V_{gs,\text{overlap}}}{\text{CKAPPAP}}} \right) \right\}
\]

B.2.2.2 Drain Overlap Capacitance

(1) for capmod=0
Capacitance Model Equations

\[ \frac{Q_{\text{overlap.d}}}{W_{\text{active}}} = \text{CGD0} V_{gd} \]

(2) for capmod=1

if (Vgd < 0)

\[ \frac{Q_{\text{overlap.d}}}{W_{\text{active}}} = \text{CGD0} V_{gd} + \frac{\text{CKappaCGD1}}{2} \left( -1 + \sqrt{1 - \frac{4V_{gd}}{\text{CKappa}}} \right) \]

else

\[ \frac{Q_{\text{overlap.d}}}{W_{\text{active}}} = (\text{CGD0} + \text{CKappaCGD1}) V_{gd} \]

(3) for capmod=2

\[ V_{gd,\text{overlap}} = \frac{1}{2} \left( (V_{gd} - \delta_2) + \sqrt{(V_{gd} - \delta_2)^2 - 4\delta_2} \right) \text{ where } \delta_2 = 0.02 \]

\[ \frac{Q_{\text{overlap.d}}}{W_{\text{active}}} = \text{CGD0} V_{gd} + \text{CGD1} \left( V_{gd} - V_{gd,\text{overlap}} + \frac{\text{CKappa}}{2} \left( -1 + \sqrt{1 + \frac{4V_{gd,\text{overlap}}}{\text{CKappa}}} \right) \right) \]
Capacitance Model Equations

B.2.2.3 Gate Overlap Charge

\[ Q_{\text{overlap,}g} = -(Q_{\text{overlap,}s} + Q_{\text{overlap,}d}) \]

B.2.3 Intrinsic Charges

(1) for \( \text{capmod}=0 \)

a) Accumulation region (\( V_{gs} < V_{fb} + V_{bs} \))

\[ Q_{g} = W_{\text{active}} L_{\text{active}} C_{ox} \left( V_{gs} - V_{bs} - V_{fb} \right) \]

\[ Q_{\text{sub}} = -Q_{g} \]

\[ Q_{\text{inv}} = 0 \]

b) Subthreshold region (\( V_{gs} < V_{th} \))

\[ Q_{b} = -W_{\text{active}} L_{\text{active}} C_{ox} \frac{K_{1}^{2}}{2} \left( -1 + \sqrt{1 + \frac{4(V_{gs} - V_{fb} - V_{bs})}{K_{1}^{2}}} \right) \]
Capacitance Model Equations

\[ Q_g = -Q_b \]

\[ Q_{inv} = 0 \]

c) Strong inversion (\( V_{gs} > V_{th} \))

\[ V_{dsat,cv} = \frac{V_{gs} - V_{th}}{A_{bulk}'} \]

\[ A_{bulk}' = A_{bulk0} \left( 1 + \left( \frac{CLC}{L_{eff}} \right)^{CLE} \right) \]

\[ A_{bulk0} = \left( 1 + \frac{K_1}{2\sqrt{\Phi_s - V_{bs}}} \left\{ \frac{A_0 L_{eff}}{L_{eff} + 2\sqrt{X_l X_{dep}}} + \frac{B_o}{W_{eff}} + B_1 \right\} \right) \frac{1}{1 + K_{ETA} V_{bs}} \]

\[ V_{th} = V_{fb} + \Phi_s + K_1 \sqrt{\Phi_s - V_{bsf}} \]
(i) 50/50 Charge partition

if $V_{ds} < V_{dsat}$

$$Q_8 = C_ox W_{active} L_{active} \left[ V_{gs} - V_{fb} - \Phi_s - \frac{V_{ds}}{2} + \frac{A_{bulk} V_{ds}^2}{12 \left( V_{gs} - V_{th} - \frac{A_{bulk} V_{ds}}{2} \right)} \right]$$

$$Q_{inv} = -W_{active} L_{active} C_ox \left[ V_{gs} - V_{th} - \frac{A_{bulk} V_{ds}}{2} + \frac{A_{bulk}^2 V_{ds}^2}{12 \left( V_{gs} - V_{th} - \frac{A_{bulk} V_{ds}}{2} \right)} \right]$$

$$Q_b = W_{active} L_{active} C_ox \left[ V_f - V_{th} + \Phi_s + \frac{(1 - A_{bulk}) V_{ds}}{2} - \frac{(1 - A_{bulk}) A_{bulk} V_{ds}^2}{12 \left( V_{gs} - V_{th} - \frac{A_{bulk}}{2} V_{ds} \right)} \right]$$

$$Q_s = Q_d = 0.5 Q_{inv} = -W_{active} L_{active} C_ox \left[ V_{gs} - V_{th} - \frac{A_{bulk} V_{ds}}{2} + \frac{A_{bulk}^2 V_{ds}^2}{12 \left( V_{gs} - V_{th} - \frac{A_{bulk} V_{ds}}{2} \right)} \right]$$

otherwise

$$Q_8 = W_{active} L_{active} C_ox \left( V_{gs} - V_{fb} - \Phi_s - \frac{V_{dsat}}{3} \right)$$
Capacitance Model Equations

\[ Q_s = Q_d = -\frac{1}{3} W_{\text{active}} L_{\text{active}} C_{\text{ox}} (V_{gs} - V_{th}) \]

\[ Q_b = -W_{\text{active}} L_{\text{active}} C_{\text{ox}} (V_{fb} + \Phi_z - V_{th} + \frac{(1 - A_{\text{bulk}}') V_{ds}}{3} ) \]

(ii) 40/60 channel-charge Partition

if (Vds < V_{dsat})

\[ Q_s = C_{\text{ox}} W_{\text{active}} L_{\text{active}} \left[ V_{gs} - V_{fb} - \Phi_z - \frac{V_{ds}}{2} + \frac{A_{\text{bulk}}' V_{ds}^2}{12(V_{gs} - V_{th} - \frac{A_{\text{bulk}}' V_{ds}}{2})} \right] \]

\[ Q_{\text{inv}} = -W_{\text{active}} L_{\text{active}} C_{\text{ox}} \left[ V_{gs} - V_{th} - \frac{A_{\text{bulk}}' V_{ds}}{2} + \frac{A_{\text{bulk}}'^2 V_{ds}^2}{12(V_{gs} - V_{th} - \frac{A_{\text{bulk}}' V_{ds}}{2})} \right] \]

\[ Q_b = W_{\text{active}} L_{\text{active}} C_{\text{ox}} \left[ V_{fb} - V_{th} + \Phi_z + \frac{(1 - A_{\text{bulk}}') V_{ds}}{2} - \frac{(1 - A_{\text{bulk}}') A_{\text{bulk}}' V_{ds}^2}{12(V_{gs} - V_{th} - \frac{A_{\text{bulk}}' V_{ds}}{2})} \right] \]
Capacitance Model Equations

$Q_d = -W_{\text{active}} L_{\text{active}} C_{\text{ox}}$

$$\left[ \frac{V_{gs} - V_{th}}{2} - A_{\text{bulk}}' V_{ds} + \frac{A_{\text{bulk}}' V_{ds} (V_{gs} - V_{th})}{6} - \frac{A_{\text{bulk}}' V_{ds} (V_{gs} - V_{th})}{8} - \frac{(A_{\text{bulk}}' V_{ds})^2}{40} \right]$$

$Q_s = -(Q_b + Q_d)$

otherwise

$Q_b = -W_{\text{active}} L_{\text{active}} C_{\text{ox}} (V_{fb} + \Phi_s - V_{th} + \frac{(1 - A_{\text{bulk}}') V_{dsat}}{3})$

(iii) 0/100 Channel-charge Partition

if $V_{ds} < V_{dsat}$
Capacitance Model Equations

\[
Q_s = C_{ox} W_{active} L_{active} \left[ V_{gs} - V_{fb} - \Phi_s - \frac{V_{ds}}{2} + \frac{A_{bulk} V_{ds}^2}{12(V_{gs} - V_{th} - \frac{A_{bulk} V_{ds}}{2})} \right]
\]

\[
Q_{inv} = -W_{active} L_{active} C_{ox} \left[ V_{gs} - V_{th} - \frac{A_{bulk} V_{ds}}{2} + \frac{A_{bulk}^2 V_{ds}^2}{12(V_{gs} - V_{th} - \frac{A_{bulk} V_{ds}}{2})} \right]
\]

\[
Q_b = W_{active} L_{active} C_{ox} \left[ V_{fb} - V_{th} + \Phi_s + \frac{(1 - A_{bulk}) V_{ds}}{2} - \frac{(1 - A_{bulk}) A_{bulk} V_{ds}^2}{12(V_{gs} - V_{th} - \frac{A_{bulk} V_{ds}}{2})} \right]
\]

\[
Q_d = -W_{active} L_{active} C_{ox} \left[ \frac{V_{gs} - V_{th}}{2} + \frac{A_{bulk}}{4} V_{ds} - \frac{(A_{bulk} V_{ds})^2}{24(V_{gs} - V_{th} - \frac{A_{bulk} V_{ds}}{2})} \right]
\]

\[
Q_s = -(Q_s + Q_b + Q_d)
\]

otherwise

\[
Q_s = W_{active} L_{active} C_{ox} \left( V_{gs} - V_{fb} - \Phi_s - \frac{V_{ds}}{3} \right)
\]
Capacitance Model Equations

\[ Q_b = -W_{\text{active}} L_{\text{active}} C_{\text{ox}} (V_{fb} + \Phi_s - V_{th} + \frac{(1 - A_{\text{bulk}}') V_{dsat}}{3}) \]

\[ Q_d = 0 \]

\[ Q_t = -(Q_s + Q_b) \]

(2) for capmod=1

if \((V_{gs} < V_{fb} + V_{bs} + V_{gsteffcv})\)

\[ Q_{s1} = -W_{\text{active}} L_{\text{active}} C_{\text{ox}} (V_{gs} - V_{fb} - V_{bs} - V_{gsteffcv}) \]

else

\[ Q_{s1} = W_{\text{active}} L_{\text{active}} C_{\text{ox}} \frac{K_1^2}{2} \left( -1 + \sqrt{1 + \frac{4(V_{gs} - V_{FB} - V_{gsteffcv} - V_{bs})}{K_1^2}} \right) \]

\[ Q_{b1} = -Q_{s1} \]
Capacitance Model Equations

\[ V_{dsat,cv} = \frac{V_{gsteff,cv}}{A_{bulk}'} \]

\[ A_{bulk} = A_{bulk0} \left( 1 + \left( \frac{CLC}{L_{eff}} \right)^{CLE} \right) \]

\[ A_{bulk0} = \left( 1 + \frac{K_1}{2\sqrt{\phi_d - V_{\text{eff}}}} \right) \left( \frac{A_0 L_{eff}}{L_{eff} + 2\sqrt{\chi X_{dep}}} + \frac{B_0}{W_{eff} + B_1} \right) \frac{1}{1 + K_{ETA} V_{\text{eff}}} \]

\[ V_{gsteff,cv} = n \nu_t \ln \left[ 1 + \exp \left( \frac{V_{gs} - V_{th}}{n \nu_t} \right) \right] \]

if \( (V_{ds} \leq V_{dsat}) \)

\[ Q_g = Q_{g1} + W_{\text{active}} L_{active} C_{ox} \left( \frac{V_{gsteff,cv} - \frac{V_{ds}}{2}}{2} + \frac{A_{bulk} V_{ds}^2}{12 \left( V_{gsteff,cv} - \frac{A_{bulk} V_{ds}}{2} \right)} \right) \]

\[ Q_b = Q_{b1} + W_{\text{active}} L_{active} C_{ox} \left( \frac{1 - A_{bulk} V_{ds}^2}{2} - \frac{(1 - A_{bulk}) A_{bulk} V_{ds}^2}{12 \left( V_{gsteff,cv} - \frac{A_{bulk} V_{ds}}{2} \right)} \right) \]


(i) 50/50 Channel-charge Partition

\[ Q_s = Q_d = -\frac{W_{\text{active}} L_{\text{active}} C_{\text{ox}}}{2} \left( V_{\text{gsteff cv}} - \frac{A_{\text{bulk}}'}{2} V_{ds} + \frac{A_{\text{bulk}}'}{12} \left( V_{\text{gsteff cv}} - \frac{A_{\text{bulk}}'}{2} V_{ds} \right)^2 \right) \]

(ii) 40/60 Channel-charge partition

\[ Q_s = -\frac{W_{\text{active}} L_{\text{active}} C_{\text{ox}}}{2 \left( V_{\text{gsteff cv}} - \frac{A_{\text{bulk}}'}{2} V_{ds} \right)^2} \left( V_{\text{gsteff cv}}^3 - \frac{4}{3} V_{\text{gsteff cv}}^2 \left( A_{\text{bulk}}' V_{ds} \right) + \frac{2}{3} V_{\text{gsteff cv}} \left( A_{\text{bulk}}' V_{ds} \right)^2 - \frac{2}{15} \left( A_{\text{bulk}}' V_{ds} \right)^3 \right) \]

\[ Q_d = -(Q_s + Q_b + Q_s) \]

(iii) 0/100 Channel-charge Partition

\[ Q_s = -W_{\text{active}} L_{\text{active}} C_{\text{ox}} \left( \frac{V_{\text{gsteff cv}}}{2} + \frac{A_{\text{bulk}}'}{4} V_{ds} - \frac{\left( A_{\text{bulk}}' V_{ds} \right)^2}{24 \left( V_{\text{gsteff cv}} - \frac{A_{\text{bulk}}'}{2} V_{ds} \right)} \right) \]

\[ Q_d = -(Q_s + Q_b + Q_s) \]
if \((V_{ds} > V_{dsat})\)

\[
Q_g = Q_{b1} + W_{\text{active}} L_{\text{active}} C_{ox} \left( V_{\text{gsteffcv}} - \frac{V_{dsat}}{3} \right)
\]

\[
Q_b = Q_{b1} - W_{\text{active}} L_{\text{active}} C_{ox} \left( V_{\text{gsteffcv}} - \frac{V_{dsat}}{3} \right)
\]

(i) 50/50 Channel-charge Partition

\[
Q_s = Q_d = -\frac{W_{\text{active}} L_{\text{active}} C_{ox}}{3} V_{\text{gsteffcv}}
\]

(ii) 40/60 Channel-charge Partition

\[
Q_s = -\frac{2W_{\text{active}} L_{\text{active}} C_{ox}}{5} V_{\text{gsteffcv}}
\]

\[
Q_d = -(Q_s + Q_b + Q_s)
\]

(iii) 0/100 Channel-charge Partition

\[
Q_s = -W_{\text{active}} L_{\text{active}} C_{ox} \frac{2V_{\text{gsteffcv}}}{3}
\]
Capacitance Model Equations

\[ Q_d = -(Q_s + Q_b + Q_s) \]

(3) for \( \text{capmod}=2 \)

\[ Q_s = -(Q_{\text{inv}} + Q_{\text{acc}} + Q_{\text{sub0}} + \delta Q_{\text{sub}}) \]

\[ Q_b = Q_{\text{acc}} + Q_{\text{sub0}} + \delta Q_{\text{sub}} \]

\[ Q_{\text{inv}} = Q_s + Q_d \]

\[ V_{\text{FBeff}} = vfb - 0.5\{V_s + \sqrt{V_s^2 + 4\delta_s vfb}\} \quad \text{where} \quad V_s = vfb - V_{gs} - \delta_s; \quad \delta_s = 0.02 \]

\[ vfb = V_{th} - \phi_s - K_1\sqrt{\phi_s} \]

\[ Q_{\text{acc}} = -W_{\text{active}} L_{\text{active}} C_{ox} (V_{\text{FBeff}} - vfb) \]

\[ Q_{\text{sub0}} = -W_{\text{active}} L_{\text{active}} C_{ox} \frac{K_1^2}{2} \left( -1 + \sqrt{1 + \frac{4(V_{gs} - V_{FBeff} - V_{\text{gsteff}} - V_{\text{bs} \text{eff}})}{K_1^2}} \right) \]

\[ V_{\text{ds} \text{at, cv}} = \frac{V_{\text{gsteff}}}{A_{\text{bulk}}} \]
Capacitance Model Equations

\[ A_{\text{bulk}}' = A_{\text{bulk}0} \left( I + \left( \frac{CLC}{L_{\text{active}}} \right)^{CL} \right) \]

\[ A_{\text{bulk}0} = \left( 1 + \frac{K_1}{2\sqrt{\Phi_i - V_{\text{subf}}} - \frac{A_0 L_{\text{ef}}}{L_{\text{ef}} + 2\sqrt{\chi X_{\text{dep}}} + B_0}} + \frac{B_0}{W_{\text{ef}} + B_1} \right) \frac{1}{1 + K_{\text{extra}} V_{\text{subf}}} \]

\[ V_{\text{gsteff cv}} = n \nu_i \ln \left[ 1 + \exp \left( \frac{V_{gs} - V_{\text{th}}}{n \nu_i} \right) \right] \]

\[ V_{\text{ceff}} = V_{\text{dext,cv}} - 0.5 \{ V_4 + \sqrt{V_4^2 + 4\delta_4 V_{\text{dext,cv}}} \} \text{ where } V_4 = V_{\text{dext,cv}} - V_d - \delta_4; \quad \delta_4 = 0.02 \]

\[ Q_{\text{inv}} = -W_{\text{active}} L_{\text{active}} C_{\text{ox}} \left( V_{\text{gsteff cv}} - \frac{A_{\text{bulk}'} V_{\text{ceff}}}{2} \right) + \frac{A_{\text{bulk}'}^2 V_{\text{ceff}}^2}{12\left( V_{\text{gsteff cv}} - \frac{A_{\text{bulk}'} V_{\text{ceff}}}{2} \right)} \]

\[ \delta Q_{\text{sub}} = W_{\text{active}} L_{\text{active}} C_{\text{ox}} \left( \frac{1 - A_{\text{bulk}'} V_{\text{ceff}}}{2} - \frac{(1 - A_{\text{bulk}'} A_{\text{bulk}'}) A_{\text{bulk}'} V_{\text{ceff}}^2}{12\left( V_{\text{gsteff cv}} - \frac{A_{\text{bulk}'} V_{\text{ceff}}}{2} \right)} \right) \]

B.2.3.1 50/50 Charge partition
Capacitance Model Equations

\[ Q_s = Q_{av} = 0.5Q_{inv} = -\frac{W_{active} L_{active} C_{ox}}{2} \left( V_{gs}^{eff} - \frac{A_{bulk}'}{2} V_{c}^{eff} + \frac{A_{bulk}'}{12} \frac{V_{c}^{eff}}{2} \right) \]

B.2.3.2 40/60 Channel-charge Partition

\[ Q_s = -\frac{W_{active} L_{active} C_{ox}}{2} \left( V_{gs}^{eff} - \frac{4}{3} V_{gs}^{eff} \frac{2}{3} A_{bulk} \left( V_{c}^{eff} \right) + \frac{2}{3} V_{gs}^{eff} \frac{A_{bulk} \left( V_{c}^{eff} \right)^2}{15} \right) \]

B.2.3.3 0/100 Charge Partition

\[ Q_s = -W_{active} L_{active} C_{ox} \left( \frac{V_{gs}^{eff} + \frac{A_{bulk}'}{4} V_{c}^{eff}}{2} - \frac{\left( A_{bulk} \left( V_{c}^{eff} \right)^2 \right)}{24 \left( V_{gs}^{eff} - \frac{A_{bulk}'}{2} V_{c}^{eff} \right)} \right) \]

\[ Q_d = -W_{active} L_{active} C_{ox} \left( \frac{V_{gs}^{eff} - \frac{3A_{bulk}'}{4} V_{c}^{eff} + \frac{\left( A_{bulk} \left( V_{c}^{eff} \right)^2 \right)}{8 \left( V_{gs}^{eff} - \frac{A_{bulk}'}{2} V_{c}^{eff} \right)} \right) \]
NQS Model Equations:

**B.2.4 Intrinsic Capacitances (with Body bias and DIBL)**

\[
C_{(s,d,g,b)} = \frac{\partial Q_{s,d,g,b}}{\partial V_{s,d,g,b}} \frac{\partial V_{s,d,g,b}}{\partial V_{s,d,g,b}}
\]

\[
C_{(s,d,g,b)r} = -\frac{\partial Q_{s,d,g,b}}{\partial V_{dr}} + \frac{\partial Q_{s,d,g,b}}{\partial V_{s,d,g,b}} \frac{\partial V_{s,d,g,b}}{\partial V_{s,d,g,b}} \left( \frac{\partial V_{th}}{\partial V_{dr}} + \frac{\partial V_{th}}{\partial V_{bs}} \right)
\]

\[
C_{(s,d,g,b)d} = \frac{\partial Q_{s,d,g,b}}{\partial V_{ds}} - \frac{\partial Q_{s,d,g,b}}{\partial V_{s,d,g,b}} \frac{\partial V_{s,d,g,b}}{\partial V_{s,d,g,b}} \frac{\partial V_{th}}{\partial V_{ds}}
\]

\[
C_{(s,d,g,b)b} = \frac{\partial Q_{s,d,g,b}}{\partial V_{bs}} - \frac{\partial Q_{s,d,g,b}}{\partial V_{s,d,g,b}} \frac{\partial V_{s,d,g,b}}{\partial V_{s,d,g,b}} \frac{\partial V_{th}}{\partial V_{bs}}
\]

**B.3 NQS Model Equations:**

Quasi-static equilibrium channel charge:

\[
Q_{eq} = -(Q_g + Q_b)
\]

Actual channel charge and \( Q_{def} \) obtained from subcircuit (Figure 5-2):

\[
Q_{ch} = Q_{eq} - Q_{def}
\]

\[
g_{\tau} = \frac{1}{\tau} = \frac{1}{\tau_{drift}} + \frac{1}{\tau_{diff}}
\]
Flicker Noise

\[ \tau_{\text{drift}} = \frac{C_{\text{ox}} W_{\text{eff}} L_{\text{eff}}^3}{\mu_{\text{eff}} e |Q_{\text{eq}} - \alpha Q_{\text{def}}|} = \frac{\zeta}{|Q_{\text{eq}}|} \]

where,
\[ \varepsilon = \text{Elmore Constant (default = 5)} \quad 0.0 \leq \alpha \leq 1.0 \quad \text{(default = 0.5)} \]

and
\[ \zeta = \frac{C_{\text{ox}} W_{\text{eff}} L_{\text{eff}}^3}{\mu_{\text{eff}} e} \]

\[ \tau_{\text{diff}} = \frac{q L_{\text{eff}}^2}{16 \mu_{\text{eff}} K T} \]

B.4 Flicker Noise

There exists two models for flicker noise. Each of these can be toggled by the `noimod` flag.

1. For noimod=1 and 4

\[ Flicker \ Noise = \frac{K_{\text{da}}}{C_{\text{ox}} L_{\text{eff}}^2 f_{\text{ef}}} \quad \text{(8.1a)} \]

2. For noimod=2 and 3

1. \( V_{\text{gs}} > V_{\text{th}} + 0.1 \): 

\[ \text{(8.1b)} \]
Flicker Noise

\[
Flicker\text{Noise} = \frac{V_{in}q^2L_{DS}^{\mu_{Eff}}}{F_{req}L_{eff}^2C_{ox}\times 10^8}\left[Noia \times \log\left(\frac{N_0 + 2 \times 10^{14}}{N_i + 2 \times 10^{14}}\right) + Noib \times (N_0 - N_i) + 0.5 \times Noic \times \left(\frac{N_0^2 - N_i^2}{N_i + 2 \times 10^{14}}\right) + \frac{V_{in}L_{DS}^{\Delta L_{clm}}}{F_{req}L_{eff}W_{eff} \times 10^8} \times \frac{Noia + Noib \times N_i + Noic \times N_i^2}{(N_i + 2 \times 10^{14})^2}\right]
\]

where \(V_{th}\) is the thermal voltage, \(\mu_{eff}\) is the effective mobility at the given bias condition, \(L_{eff}\) and \(W_{eff}\) are the effective channel length and width, respectively. The parameter \(N_0\) is the charge density at the source given by:

\[
N_0 = \frac{C_{ox}(V_{GS} - V_{TH})}{q}
\]

The parameter \(N_i\) is the charge density at the drain given by:

\[
N_i = \frac{C_{ox}(V_{GS} - V_{TH} - V_{DS})}{q}
\]

\(V_{DS'} = \text{MIN}(V_{DS}, V_{DSAT})\)

\(\Delta L_{clm}\) refers to channel length reduction due to CLM and is given by:

\[
\Delta L_{clm} = \begin{cases} 
L_{itl} \times \log\left(\frac{V_{DS} - V_{DSAT}}{L_{itl}} + E_m\right) & \text{if } V_{DS} > V_{DSAT} \\
0 & \text{otherwise}
\end{cases}
\]

\(E_{SAT} = \frac{2 \times V_{sat}}{\mu_{eff}}\)

2. Otherwise,
Channel Thermal Noise

\[ FlickerNoise = \frac{S_{\text{limit}} \times S_{wi}}{S_{\text{limit}} + S_{wi}} \]  

(8.5)

Where, \( S_{\text{limit}} \) is the flicker noise calculated at \( V_{gs} = V_{th} + 0.1 \) and \( S_{wi} \) is given by:

\[ S_{wi} = \frac{Noiaw \times V_{tm} \times I_{DS}^2}{W_{eff} \times L_{eff} \times \text{Freq}^{AI} \times 4 \times 10^{36}} \]  

(8.6)

B.5 Channel Thermal Noise

There exists two models for channel thermal noise. Each of these can be toggled by the `noimod` flag.

1. For `noimod`=1 and 3

\[ \frac{8kT}{3} (gm + gds + gmb) \]

2. For `noimod`=2 and 4

\[ \frac{4KT \mu_{eff}}{L_{eff}^2} (-Q_{inv}) \]
Channel Thermal Noise

\[ Q_{ov} = -W_{eff} L_{eff} C_{ox} V_{gs_eff} (1 - \frac{A_{built}}{2(V_{gs_eff} + 2v_t)} V_{ds_eff}) \]

The derivation for this last thermal noise expression is based on the noise model found in [35].
APPENDIX C: References


APPENDIX D: Binning BSIM3v3
Parameters

Below is a list of all BSIM3v3 model parameters which can or cannot be binned. All model parameters which can be binned follow the following implementation:

\[ P = P_0 + \frac{P_L}{L_{eff}} + \frac{P_W}{W_{eff}} + \frac{P_p}{L_{eff} \times W_{eff}} \]

For example, for the parameter \( k_1 \): \( P_0 = k_1, P_L = l_k 1, P_W = w_k 1, P_p = p_k 1 \). Binunit is a bin unit selector. If binunit = 1, the units of \( L_{eff} \) and \( W_{eff} \) used in the binning equation above have the units of microns. Otherwise, they are in meters.

For example, for a device with \( L_{eff} = 0.5 \mu m \) and \( W_{eff} = 10 \mu m \). If binunit = 1, the parameter values for \( v_{sat} \) are \( 1e5, 1e4, 2e4, \) and \( 3e4 \) for \( v_{sat}, I_{vsat}, W_{vsat}, \) and \( P_{vsat} \), respectively. Therefore, the effective value of \( v_{sat} \) for this device is:

\[ v_{sat} = 1e5 + 1e4/0.5 + 2e4/10 + 3e4/(0.5 * 10) = 1.28e5 \]

To get the same effective value of \( v_{sat} \) for binunit = 0, the values of \( v_{sat}, I_{vsat}, W_{vsat}, \) and \( P_{vsat} \) would be \( 1e5, 1e-2, 2e-2, 3e-8, \) respectively. Thus,

\[ v_{sat} = 1e5 + 1e-2/0.5e6 + 2e-2/10e-6 + 3e-8/(0.5e-6 * 10e-6) = 1.28e5 \]

As a final note: although BSIM3v3 supports binning as an option for model extraction, it is not strongly recommended.
### D.1 BSIM3v3 Model Control Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>none</td>
<td>level</td>
<td>BSIMv3 model selector</td>
<td>NO</td>
</tr>
<tr>
<td>Mobmod</td>
<td>mobmod</td>
<td>Mobility model selector</td>
<td>NO</td>
</tr>
<tr>
<td>Capmod</td>
<td>capmod</td>
<td>Flag for the short channel capacitance model</td>
<td>NO</td>
</tr>
<tr>
<td>Nqsmod</td>
<td>nqsmod</td>
<td>Flag for NQS model</td>
<td>NO</td>
</tr>
<tr>
<td>Noimod</td>
<td>noimod</td>
<td>Flag for Noise model</td>
<td>NO</td>
</tr>
</tbody>
</table>

### D.2 DC Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>Vth0</td>
<td>vth0</td>
<td>Threshold voltage @ Vbs=0 for Large L.</td>
<td>YES</td>
</tr>
<tr>
<td>K1</td>
<td>k1</td>
<td>First order body effect coefficient</td>
<td>YES</td>
</tr>
<tr>
<td>K2</td>
<td>k2</td>
<td>Second order body effect coefficient</td>
<td>YES</td>
</tr>
<tr>
<td>K3</td>
<td>k3</td>
<td>Narrow width coefficient</td>
<td>YES</td>
</tr>
<tr>
<td>K3b</td>
<td>k3b</td>
<td>Body effect coefficient of k3</td>
<td>YES</td>
</tr>
<tr>
<td>W0</td>
<td>w0</td>
<td>Narrow width parameter</td>
<td>YES</td>
</tr>
<tr>
<td>Nlx</td>
<td>nlx</td>
<td>Lateral non-uniform doping parameter</td>
<td>YES</td>
</tr>
</tbody>
</table>
### DC Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>$D_{vt0}$</td>
<td>$d_{vt0}$</td>
<td>First coefficient of short-channel effect on $V_{th}$</td>
<td>YES</td>
</tr>
<tr>
<td>$D_{vt1}$</td>
<td>$d_{vt1}$</td>
<td>Second coefficient of short-channel effect on $V_{th}$</td>
<td>YES</td>
</tr>
<tr>
<td>$D_{vt2}$</td>
<td>$d_{vt2}$</td>
<td>Body-bias coefficient of short-channel effect on $V_{th}$</td>
<td>YES</td>
</tr>
<tr>
<td>$D_{vt0w}$</td>
<td>$d_{vt0w}$</td>
<td>First coefficient of narrow width effect on $V_{th}$ for small channel length</td>
<td>YES</td>
</tr>
<tr>
<td>$D_{vt1w}$</td>
<td>$d_{vt1w}$</td>
<td>Second coefficient of narrow width effect on $V_{th}$ for small channel length</td>
<td>YES</td>
</tr>
<tr>
<td>$D_{vt2w}$</td>
<td>$d_{vt2w}$</td>
<td>Body-bias coefficient of narrow width effect for small channel length</td>
<td>YES</td>
</tr>
<tr>
<td>$\mu_0$</td>
<td>$u_0$</td>
<td>Mobility at Temp = $T_{nom}$ NMOSFET PMOSFET</td>
<td>YES</td>
</tr>
<tr>
<td>$U_a$</td>
<td>$u_a$</td>
<td>First-order mobility degradation coefficient</td>
<td>YES</td>
</tr>
<tr>
<td>$U_b$</td>
<td>$u_b$</td>
<td>Second-order mobility degradation coefficient</td>
<td>YES</td>
</tr>
<tr>
<td>$U_c$</td>
<td>$u_c$</td>
<td>Body-effect of mobility degradation coefficient</td>
<td>YES</td>
</tr>
<tr>
<td>$v_{sat}$</td>
<td>$v_{sat}$</td>
<td>Saturation velocity at Temp = $T_{nom}$</td>
<td>YES</td>
</tr>
<tr>
<td>$A_0$</td>
<td>$a_0$</td>
<td>Bulk charge effect coefficient for channel length</td>
<td>YES</td>
</tr>
</tbody>
</table>
### DC Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>Ags</td>
<td>ags</td>
<td>gate bias coefficient of $A_{bulk}$</td>
<td>YES</td>
</tr>
<tr>
<td>B0</td>
<td>b0</td>
<td>Bulk charge effect coefficient for channel width</td>
<td>YES</td>
</tr>
<tr>
<td>B1</td>
<td>b1</td>
<td>Bulk charge effect width offset</td>
<td>YES</td>
</tr>
<tr>
<td>Keta</td>
<td>keta</td>
<td>Body-bias coefficient of bulk charge effect</td>
<td>YES</td>
</tr>
<tr>
<td>A1</td>
<td>a1</td>
<td>First non-saturation effect parameter</td>
<td>YES</td>
</tr>
<tr>
<td>A2</td>
<td>a2</td>
<td>Second non-saturation factor</td>
<td>YES</td>
</tr>
<tr>
<td>Rdsw</td>
<td>rdsw</td>
<td>Parasitic resistance per unit width</td>
<td>YES</td>
</tr>
<tr>
<td>Prwb</td>
<td>prwb</td>
<td>Body effect coefficient of Rdsw</td>
<td>YES</td>
</tr>
<tr>
<td>Prwg</td>
<td>prwg</td>
<td>Gate bias effect coefficient of Rdsw</td>
<td>YES</td>
</tr>
<tr>
<td>Wr</td>
<td>wr</td>
<td>Width Offset from $W_{eff}$ for $R_{ds}$ calculation</td>
<td>YES</td>
</tr>
<tr>
<td>Wint</td>
<td>wint</td>
<td>Width offset fitting parameter from I-V without bias</td>
<td>NO</td>
</tr>
<tr>
<td>Lint</td>
<td>lint</td>
<td>Length offset fitting parameter from I-V without bias</td>
<td>NO</td>
</tr>
<tr>
<td>dWg</td>
<td>dwg</td>
<td>Coefficient of $W_{eff}$’s gate dependence</td>
<td>YES</td>
</tr>
<tr>
<td>dWb</td>
<td>dwb</td>
<td>Coefficient of $W_{eff}$’s substrate body bias dependence</td>
<td>YES</td>
</tr>
<tr>
<td>Voff</td>
<td>voff</td>
<td>Offset voltage in the subthreshold region for large $W$ and $L$</td>
<td>YES</td>
</tr>
<tr>
<td>Nfactor</td>
<td>nfactor</td>
<td>Subthreshold swing factor</td>
<td>YES</td>
</tr>
</tbody>
</table>
## DC Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>EtaO</td>
<td>etaO</td>
<td>DIBL coefficient in subthreshold region</td>
<td>YES</td>
</tr>
<tr>
<td>Etab</td>
<td>etab</td>
<td>Body-bias coefficient for the subthreshold DIBL effect</td>
<td>YES</td>
</tr>
<tr>
<td>Dsub</td>
<td>dsub</td>
<td>DIBL coefficient exponent in subthreshold region</td>
<td>YES</td>
</tr>
<tr>
<td>Cit</td>
<td>cit</td>
<td>Interface trap capacitance</td>
<td>YES</td>
</tr>
<tr>
<td>Cdsc</td>
<td>cdsc</td>
<td>Drain/Source to channel coupling capacitance</td>
<td>YES</td>
</tr>
<tr>
<td>Cdscb</td>
<td>cdscb</td>
<td>Body-bias sensitivity of Cdsc</td>
<td>YES</td>
</tr>
<tr>
<td>Cdscd</td>
<td>cdscd</td>
<td>Drain-bias sensitivity of Cdsc</td>
<td>YES</td>
</tr>
<tr>
<td>Pclm</td>
<td>pclm</td>
<td>Channel length modulation parameter</td>
<td>YES</td>
</tr>
<tr>
<td>Pdiblc1</td>
<td>pdiblc1</td>
<td>First output resistance DIBL effect correction parameter</td>
<td>YES</td>
</tr>
<tr>
<td>Pdiblc2</td>
<td>pdiblc2</td>
<td>Second output resistance DIBL effect correction parameter</td>
<td>YES</td>
</tr>
<tr>
<td>Pdiblcb</td>
<td>pdiblcb</td>
<td>Body effect coefficient of DIBL correction parameters</td>
<td>YES</td>
</tr>
<tr>
<td>Drout</td>
<td>drout</td>
<td>L dependence coefficient of the DIBL correction parameter in Rout</td>
<td>YES</td>
</tr>
<tr>
<td>Pscbe1</td>
<td>pscbe1</td>
<td>First substrate current body-effect parameter</td>
<td>YES</td>
</tr>
<tr>
<td>Pscbe2</td>
<td>pscbe2</td>
<td>Second substrate current body-effect parameter</td>
<td>YES</td>
</tr>
</tbody>
</table>
### AC and Capacitance Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>Pורג</td>
<td>pורג</td>
<td>Gate dependence of Early voltage</td>
<td>YES</td>
</tr>
<tr>
<td>δ</td>
<td>δelta</td>
<td>Effective Vds parameter</td>
<td>YES</td>
</tr>
<tr>
<td>N переим</td>
<td>ngate</td>
<td>poly gate doping concentration</td>
<td>YES</td>
</tr>
<tr>
<td>α0</td>
<td>alpha0</td>
<td>The first parameter of impact ionization current</td>
<td>YES</td>
</tr>
<tr>
<td>β0</td>
<td>beta0</td>
<td>The second parameter of impact ionization current</td>
<td>YES</td>
</tr>
<tr>
<td>Rш</td>
<td>rш</td>
<td>Source drain sheet resistance in ohm per square</td>
<td>NO</td>
</tr>
<tr>
<td>Jсо</td>
<td>js</td>
<td>Source drain junction saturation current per unit area</td>
<td>NO</td>
</tr>
</tbody>
</table>

#### D.3 AC and Capacitance Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>Xpart</td>
<td>xpart</td>
<td>Charge partitioning rate flag</td>
<td>NO</td>
</tr>
<tr>
<td>CGS0</td>
<td>cgso</td>
<td>Non LDD region source-gate overlap capacitance per channel length</td>
<td>NO</td>
</tr>
</tbody>
</table>
### AC and Capacitance Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>CGD0</td>
<td>cgdo</td>
<td>Non LDD region drain-gate overlap capacitance per channel length</td>
<td>NO</td>
</tr>
<tr>
<td>CGB0</td>
<td>cgbo</td>
<td>Gate bulk overlap capacitance per unit channel length</td>
<td>NO</td>
</tr>
<tr>
<td>Cj</td>
<td>cj</td>
<td>Bottom junction per unit area</td>
<td>NO</td>
</tr>
<tr>
<td>Mj</td>
<td>mj</td>
<td>Bottom junction capacitance grating coefficient</td>
<td>NO</td>
</tr>
<tr>
<td>Mjsw</td>
<td>mjsw</td>
<td>Source/Drain side junction capacitance grading coefficient</td>
<td>NO</td>
</tr>
<tr>
<td>Cjsw</td>
<td>cjsw</td>
<td>Source/Drain side junction capacitance per unit area</td>
<td>NO</td>
</tr>
<tr>
<td>Pb</td>
<td>pb</td>
<td>Bottom built-in potential</td>
<td>NO</td>
</tr>
<tr>
<td>Pbsw</td>
<td>pbsw</td>
<td>Source/Drain side junction built-in potential</td>
<td>NO</td>
</tr>
<tr>
<td>CGS1</td>
<td>cgs1</td>
<td>Light doped source-gate region overlap capacitance</td>
<td>YES</td>
</tr>
<tr>
<td>CGD1</td>
<td>cgd1</td>
<td>Light doped drain-gate region overlap capacitance</td>
<td>YES</td>
</tr>
<tr>
<td>CKAPPA</td>
<td>ckappa</td>
<td>Coefficient for lightly doped region overlap capacitance Fringing field capacitance</td>
<td>YES</td>
</tr>
<tr>
<td>Cf</td>
<td>cf</td>
<td>Fringing field capacitance</td>
<td>YES</td>
</tr>
<tr>
<td>CLC</td>
<td>clc</td>
<td>Constant term for the short channel model</td>
<td>YES</td>
</tr>
<tr>
<td>CLE</td>
<td>cle</td>
<td>Exponential term for the short channel model</td>
<td>YES</td>
</tr>
</tbody>
</table>
### NQS Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>DLC</td>
<td>dlc</td>
<td>Length offset fitting parameter from C-V</td>
<td>YES</td>
</tr>
<tr>
<td>DWC</td>
<td>dwc</td>
<td>Width offset fitting parameter from C-V</td>
<td>YES</td>
</tr>
<tr>
<td>Vfb</td>
<td>vfb</td>
<td>Flat-band voltage parameter (for capmod=0 only)</td>
<td>YES</td>
</tr>
</tbody>
</table>

#### D.4 NQS Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>Elm</td>
<td>elm</td>
<td>Elmore constant of the channel</td>
<td>YES</td>
</tr>
</tbody>
</table>
### D.5 dW and dL Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>Wl</td>
<td>wl</td>
<td>Coefficient of length dependence for width offset</td>
<td>NO</td>
</tr>
<tr>
<td>Win</td>
<td>win</td>
<td>Power of length dependence of width offset</td>
<td>NO</td>
</tr>
<tr>
<td>Ww</td>
<td>ww</td>
<td>Coefficient of width dependence for width offset</td>
<td>NO</td>
</tr>
<tr>
<td>Wwn</td>
<td>wwn</td>
<td>Power of width dependence of width offset</td>
<td>NO</td>
</tr>
<tr>
<td>Wwl</td>
<td>wwl</td>
<td>Coefficient of length and width cross term for width offset</td>
<td>NO</td>
</tr>
<tr>
<td>Ll</td>
<td>ll</td>
<td>Coefficient of length dependence for length offset</td>
<td>NO</td>
</tr>
<tr>
<td>Lin</td>
<td>lin</td>
<td>Power of length dependence for length offset</td>
<td>NO</td>
</tr>
<tr>
<td>Lw</td>
<td>lw</td>
<td>Coefficient of width dependence for length offset</td>
<td>NO</td>
</tr>
<tr>
<td>Lwn</td>
<td>lwn</td>
<td>Power of width dependence for length offset</td>
<td>NO</td>
</tr>
<tr>
<td>Lwl</td>
<td>lwl</td>
<td>Coefficient of length and width cross term for length offset</td>
<td>NO</td>
</tr>
</tbody>
</table>
## D.6 Temperature Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>( T_{\text{nom}} )</td>
<td>( t_{\text{nom}} )</td>
<td>Temperature at which parameters are extracted</td>
<td>NO</td>
</tr>
<tr>
<td>( \mu_t )</td>
<td>( u_t )</td>
<td>Mobility temperature exponent</td>
<td>YES</td>
</tr>
<tr>
<td>( K_{t1} )</td>
<td>( k_{t1} )</td>
<td>Temperature coefficient for threshold voltage</td>
<td>YES</td>
</tr>
<tr>
<td>( K_{t11} )</td>
<td>( k_{t11} )</td>
<td>Channel length dependence of the temperature coefficient for threshold voltage</td>
<td>YES</td>
</tr>
<tr>
<td>( K_{t2} )</td>
<td>( k_{t2} )</td>
<td>Body-bias coefficient of ( V_{\text{th}} ) temperature effect</td>
<td>YES</td>
</tr>
<tr>
<td>( U_{a1} )</td>
<td>( u_{a1} )</td>
<td>Temperature coefficient for ( U_a )</td>
<td>YES</td>
</tr>
<tr>
<td>( U_{b1} )</td>
<td>( u_{b1} )</td>
<td>Temperature coefficient for ( U_b )</td>
<td>YES</td>
</tr>
<tr>
<td>( U_{c1} )</td>
<td>( u_{c1} )</td>
<td>Temperature coefficient for ( U_c )</td>
<td>YES</td>
</tr>
<tr>
<td>( A_t )</td>
<td>( a_t )</td>
<td>Temperature coefficient for saturation velocity</td>
<td>YES</td>
</tr>
<tr>
<td>( P_{rt} )</td>
<td>( p_{rt} )</td>
<td>Temperature coefficient for ( R_{\text{dsw}} )</td>
<td>YES</td>
</tr>
<tr>
<td>( n_j )</td>
<td>( n_j )</td>
<td>Emission coefficient</td>
<td>YES</td>
</tr>
<tr>
<td>( X_{TI} )</td>
<td>( x_{TI} )</td>
<td>Junction current temperature exponent coefficient</td>
<td>YES</td>
</tr>
</tbody>
</table>
D.7 Flicker Noise Model Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>Noia</td>
<td>noia</td>
<td>Noise parameter A</td>
<td>NO</td>
</tr>
<tr>
<td>Noib</td>
<td>noib</td>
<td>Noise parameter B</td>
<td>NO</td>
</tr>
<tr>
<td>Noic</td>
<td>noic</td>
<td>Noise parameter C</td>
<td>NO</td>
</tr>
<tr>
<td>Em</td>
<td>em</td>
<td>Saturation field</td>
<td>NO</td>
</tr>
<tr>
<td>Af</td>
<td>af</td>
<td>Frequency exponent</td>
<td>NO</td>
</tr>
<tr>
<td>Ef</td>
<td>ef</td>
<td>Frequency exponent</td>
<td>NO</td>
</tr>
<tr>
<td>Kf</td>
<td>kf</td>
<td>Flicker noise parameter</td>
<td>NO</td>
</tr>
</tbody>
</table>

D.8 Process Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>Tox</td>
<td>tox</td>
<td>Gate oxide thickness</td>
<td>NO</td>
</tr>
<tr>
<td>Xj</td>
<td>xj</td>
<td>Junction Depth</td>
<td>YES</td>
</tr>
<tr>
<td>γl</td>
<td>gamma1</td>
<td>Body-effect coefficient near the surface</td>
<td>YES</td>
</tr>
</tbody>
</table>
### D.9 Bin Description Parameters

<table>
<thead>
<tr>
<th>Symbols used in equation</th>
<th>Symbols used in SPICE</th>
<th>Description</th>
<th>Can Be Binned?</th>
</tr>
</thead>
<tbody>
<tr>
<td>$\gamma_2$</td>
<td>gamma2</td>
<td>Body-effect coefficient in the bulk</td>
<td>YES</td>
</tr>
<tr>
<td>Nch</td>
<td>nch</td>
<td>Channel doping concentration</td>
<td>YES</td>
</tr>
<tr>
<td>Nsub</td>
<td>nsub</td>
<td>Substrate doping concentration</td>
<td>YES</td>
</tr>
<tr>
<td>Vbx</td>
<td>vbx</td>
<td>$V_{bs}$ at which the depletion region width equals $x_t$</td>
<td>YES</td>
</tr>
<tr>
<td>Vbm</td>
<td>vbm</td>
<td>Maximum applied body bias in $V_{th}$ calculation</td>
<td>YES</td>
</tr>
<tr>
<td>Xt</td>
<td>xt</td>
<td>Doping depth</td>
<td>YES</td>
</tr>
<tr>
<td>Lmin</td>
<td>lmin</td>
<td>Minimum channel length</td>
<td>NO</td>
</tr>
<tr>
<td>Lmax</td>
<td>lmax</td>
<td>Maximum channel length</td>
<td>NO</td>
</tr>
<tr>
<td>Wmin</td>
<td>wmin</td>
<td>Minimum channel width</td>
<td>NO</td>
</tr>
<tr>
<td>Wmax</td>
<td>wmax</td>
<td>Maximum channel width</td>
<td>NO</td>
</tr>
<tr>
<td>binunit</td>
<td>binunit</td>
<td>Bin unit selector</td>
<td>NO</td>
</tr>
</tbody>
</table>